

# Applications of nanostructured porous silicon in biomedicine

**Raúl J. Martín Palma**

# Outline

- Introduction: What is Nanotechnology? Examples and applications.
- What is porous silicon? Why is it interesting?
- How is porous silicon fabricated?, how does it look like?
- Key properties.
- Applications: From photonics to biomedicine.
- Summary

# What is Nanotechnology?

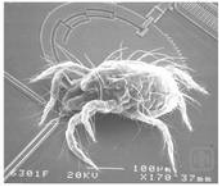
“Nanotechnology is the understanding and control of matter at dimensions between approximately 1 and 100 nanometers, where unique phenomena enable novel applications. Encompassing nanoscale science, engineering, and technology, nanotechnology involves imaging, measuring, modeling, and manipulating matter at this length scale.”

(<http://www.nano.gov/html/facts/whatIsNano.html>, Accessed 03 June 2009)

# The Scale of Things – Nanometers and More



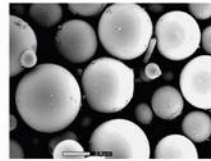
## Things Natural



Dust mite  
200  $\mu\text{m}$



Ant  
~ 5 mm

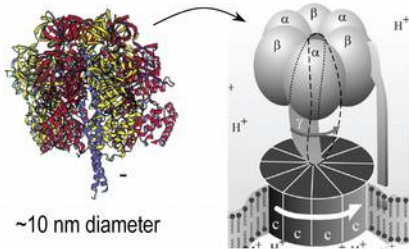
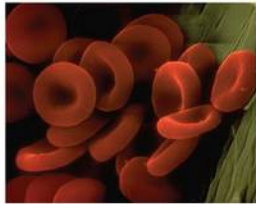


Fly ash  
~ 10-20  $\mu\text{m}$



Human hair  
~ 60-120  $\mu\text{m}$  wide

Red blood cells  
(~7-8  $\mu\text{m}$ )

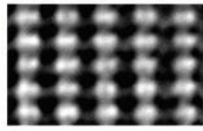


~10 nm diameter

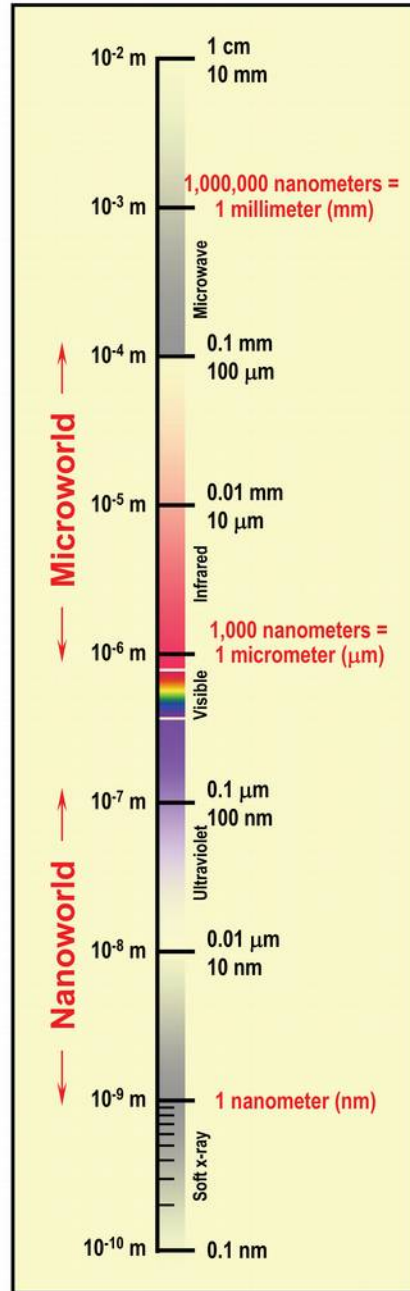
ATP synthase



DNA  
~2-1/2 nm diameter



Atoms of silicon  
spacing 0.078 nm



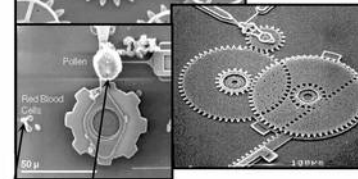
## Things Manmade



Head of a pin  
1-2 mm

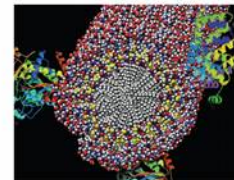


MicroElectroMechanical (MEMS) devices  
10 -100  $\mu\text{m}$  wide

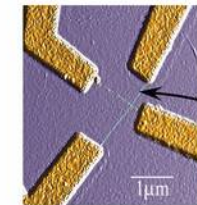


Pollen grain  
Red blood cells

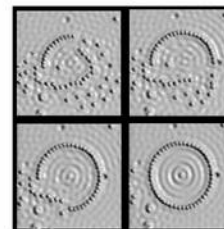
Zone plate x-ray "lens"  
Outer ring spacing ~35 nm



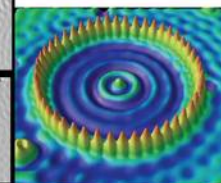
Self-assembled,  
Nature-inspired structure  
Many 10s of nm



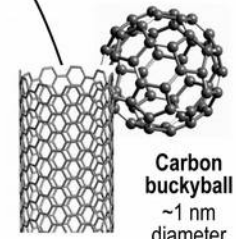
Nanotube electrode



Quantum corral of 48 iron atoms on copper surface  
positioned one at a time with an STM tip  
Corral diameter 14 nm

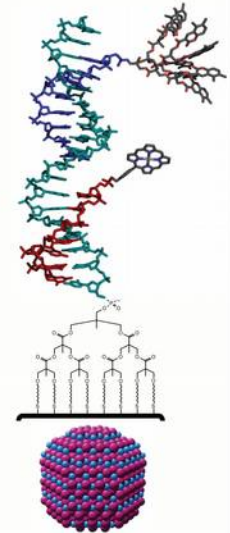


Carbon nanotube  
~1.3 nm diameter



Carbon buckyball  
~1 nm diameter

### The Challenge



*Fabricate and combine nanoscale building blocks to make useful devices, e.g., a photosynthetic reaction center with integral semiconductor storage.*

# Examples

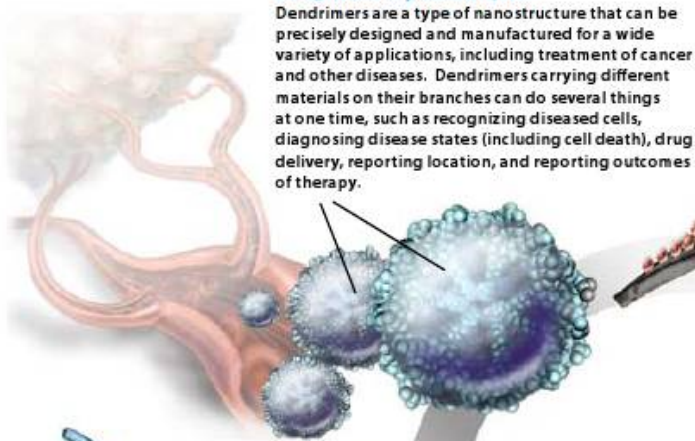


Martín-Palma & Lakhtakia  
SPIE Press 2010

# Nanotechnology Applications and Products

## Drug-Delivery Techniques

Dendrimers are a type of nanostructure that can be precisely designed and manufactured for a wide variety of applications, including treatment of cancer and other diseases. Dendrimers carrying different materials on their branches can do several things at one time, such as recognizing diseased cells, diagnosing disease states (including cell death), drug delivery, reporting location, and reporting outcomes of therapy.



## Nanofilms

Different nanoscale materials can be used in thin films to make them water-repellent, anti-reflective, self-cleaning, ultraviolet or infrared-resistant, anti-fog, anti-microbial, scratch-resistant, or electrically conductive. Nanofilms are used now on eyeglasses, computer displays, and cameras to protect or treat the surfaces.



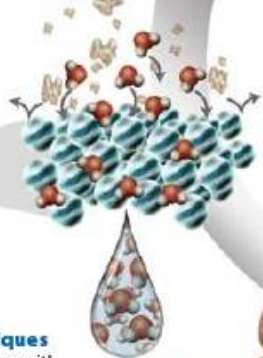
## Nanotubes

Carbon nanotubes (CNTs) are used in baseball bats, tennis racquets, and some car parts because of their greater mechanical strength at less weight per unit volume than that of conventional materials. Electronic properties of CNTs have made them a candidate for flat panel displays in TVs, batteries, and other electronics. Nanotubes for various uses can be made of materials other than carbon.



## Water-Filtration Techniques

Researchers are experimenting with carbon nanotube-based membranes for water desalination and nanoscale sensors to identify contaminants in water systems. Other nanoscale materials that have great potential to filter and purify water include nanoscale titanium dioxide, which is used in sunscreens and which has been shown to neutralize bacteria, including *E. coli*, in water.



## Solar Plastics

Thin, flexible, lightweight rolls of plastics containing nanoscale materials are being developed that some people believe could replace traditional solar energy technologies. The nanoscale materials absorb sunlight and, in some cases, indoor light, which is converted into electrical energy. Thin-film solar cells paired with a new kind of rechargeable battery also are the subject of research today. This technology will be more widely used when researchers learn how to capture solar energy more efficiently.



## Nanoscale transistors

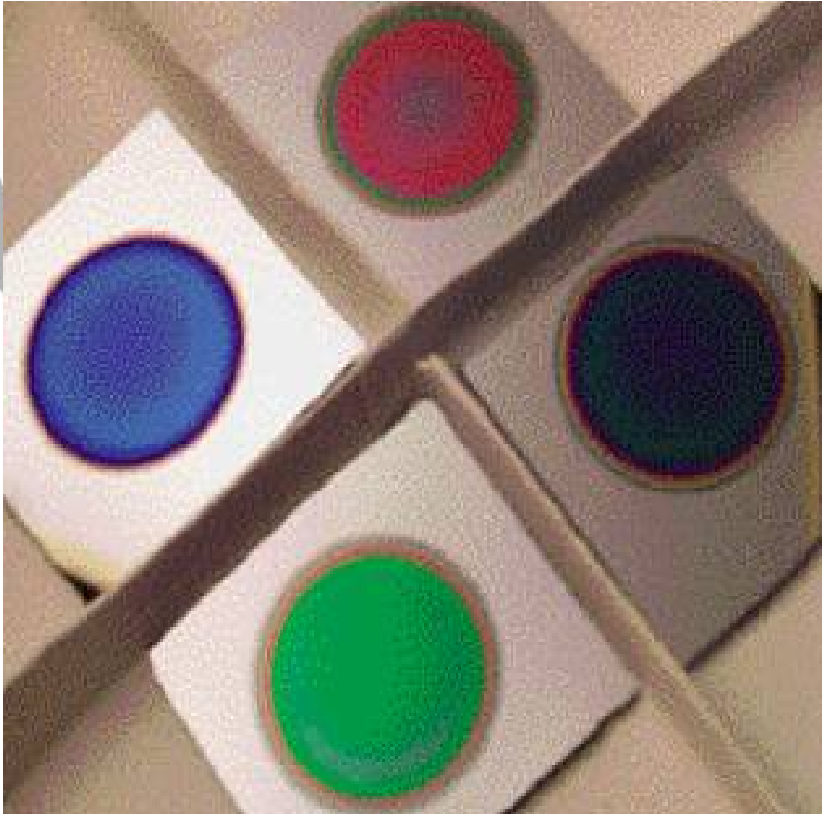
Transistors are electronic switching devices where a small amount of electricity is used like a gate to control the flow of larger amounts of electricity. In computers, the more transistors, the greater the power. Transistor sizes have been decreasing, so computers have become more powerful. Until recently, the industry's best commercial technology produced computer chips with transistors having 65-nanometer features. Recent announcements indicate that 45-nanometer feature technology soon will be here.

# Silicon in the field of photonics

- Advantages:
  - Is abundant.
  - Tremendous base technology that has developed around it.
  - Superior mechanical and thermal properties.
  - Possibility to form an excellent passivating oxide.
  - Technology is much less hazardous to the environment than other technologies.
- Drawbacks:
  - Si is lacking the properties necessary to emit light efficiently: Cannot be used for optically active or optoelectronic applications.

It is of great importance to develop a technology that allows optical and electronic devices to be easily and inexpensively integrated on Si wafers.

# Light emission from nanostructured porous silicon

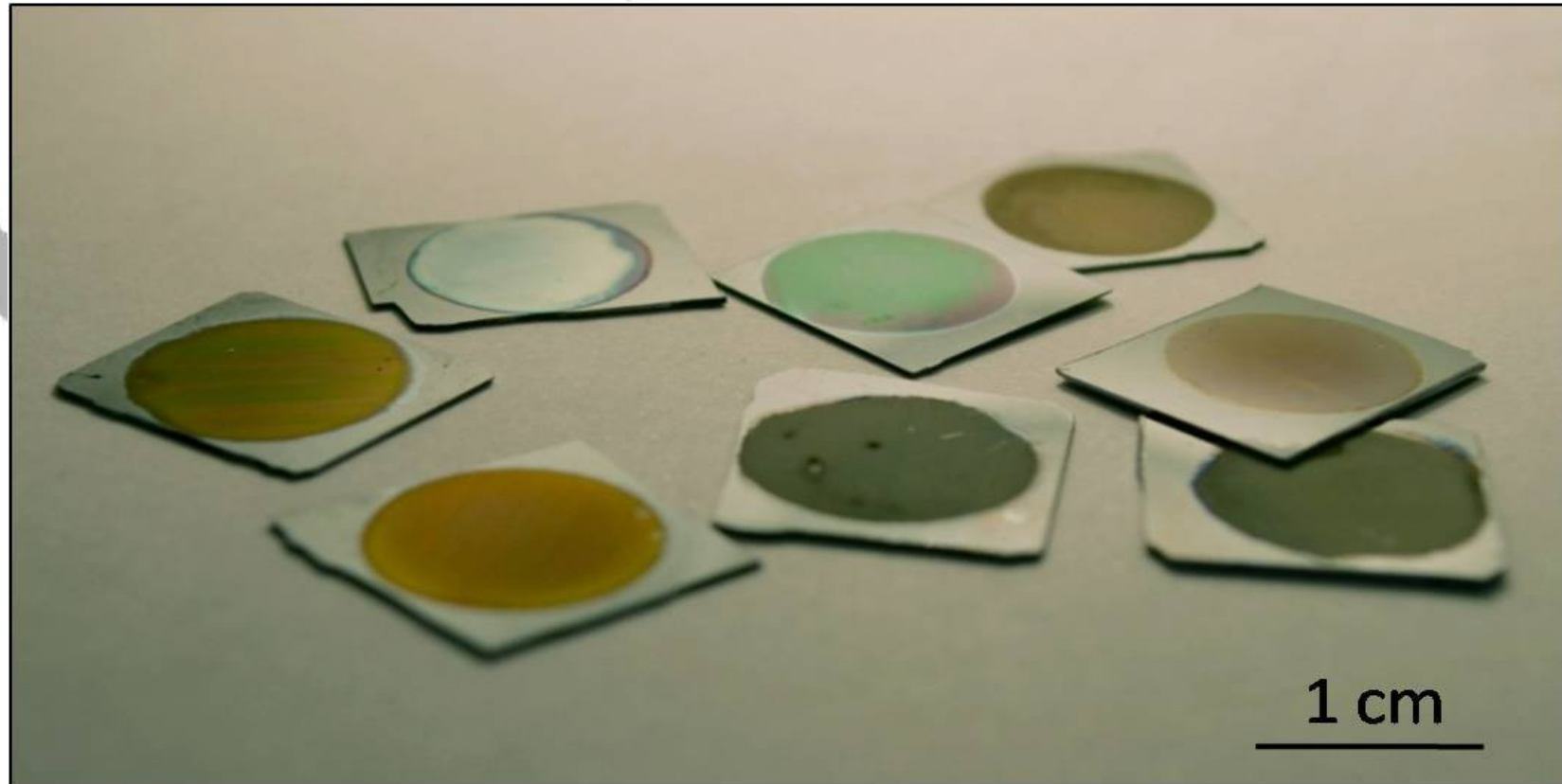


G. Marsh, Materials Today, January 2002.

- Emission energy well above the bandgap of bulk Si.
- The energy (color) can be tuned throughout the visible (NIR) spectrum.
- Quantum efficiency comparable to that of direct-bandgap (compound) semiconductors.



# Nanostructured porous silicon

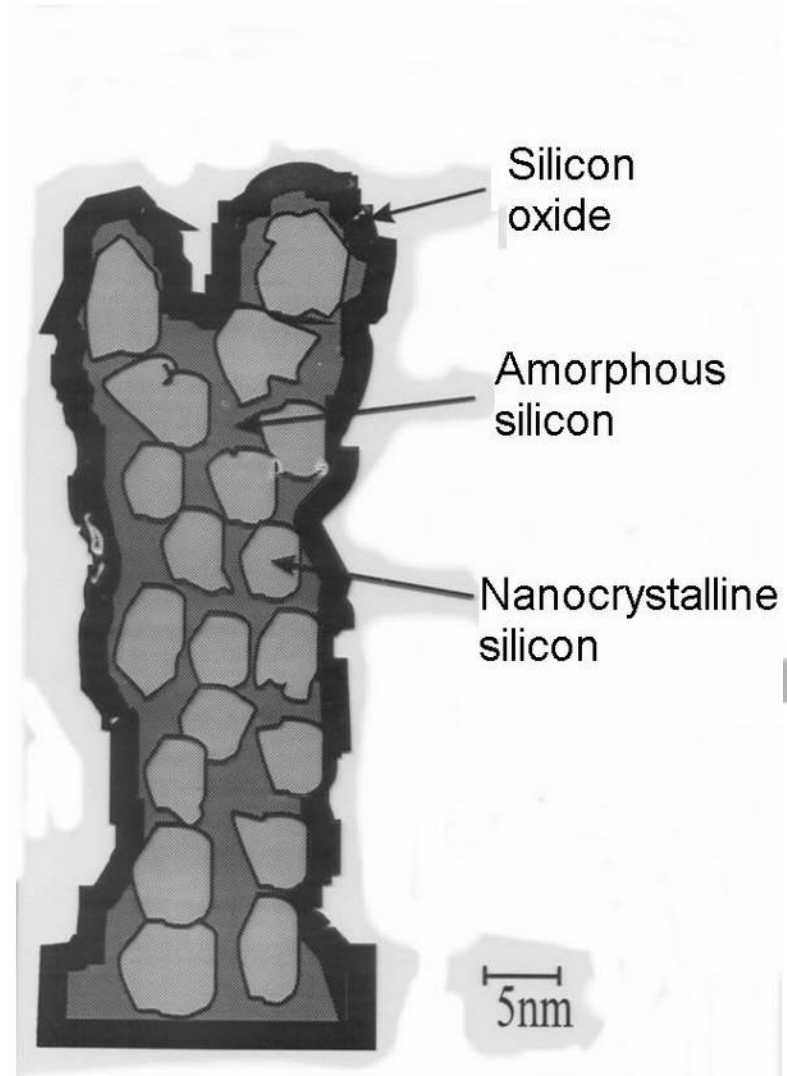


J. Hernández-Montelongo, Á. Muñoz-Noval, J.P. García-Ruíz, V. Torres-Costa, R.J. Martín-Palma, and M. Manso-Silván, *Frontiers in Bioengineering and Biotechnology* 3, 60 (2015).

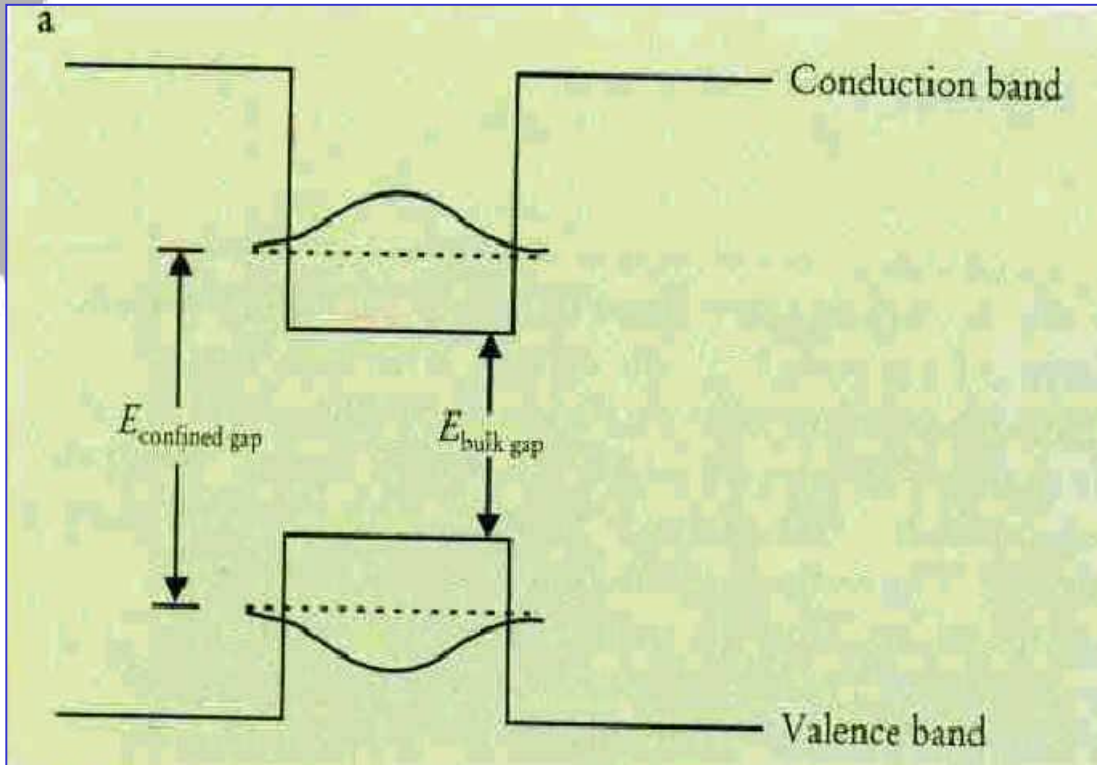
# What is porous silicon?

Network of nanometer-sized Si regions surrounded by void space

Shows quantum size effects



# Emission in the visible: Quantum confinement



Simple effective-mass approximation:

$$E_{\text{confined-gap}} = E_{\text{bulk-gap}} + \frac{h^2}{8} \times \left[ \frac{1}{w_x^2} + \frac{1}{w_y^2} + \frac{1}{w_z^2} \right] \times \left[ \frac{1}{m_c^*} + \frac{1}{m_v^*} \right]$$

Semiconductor quantum well:

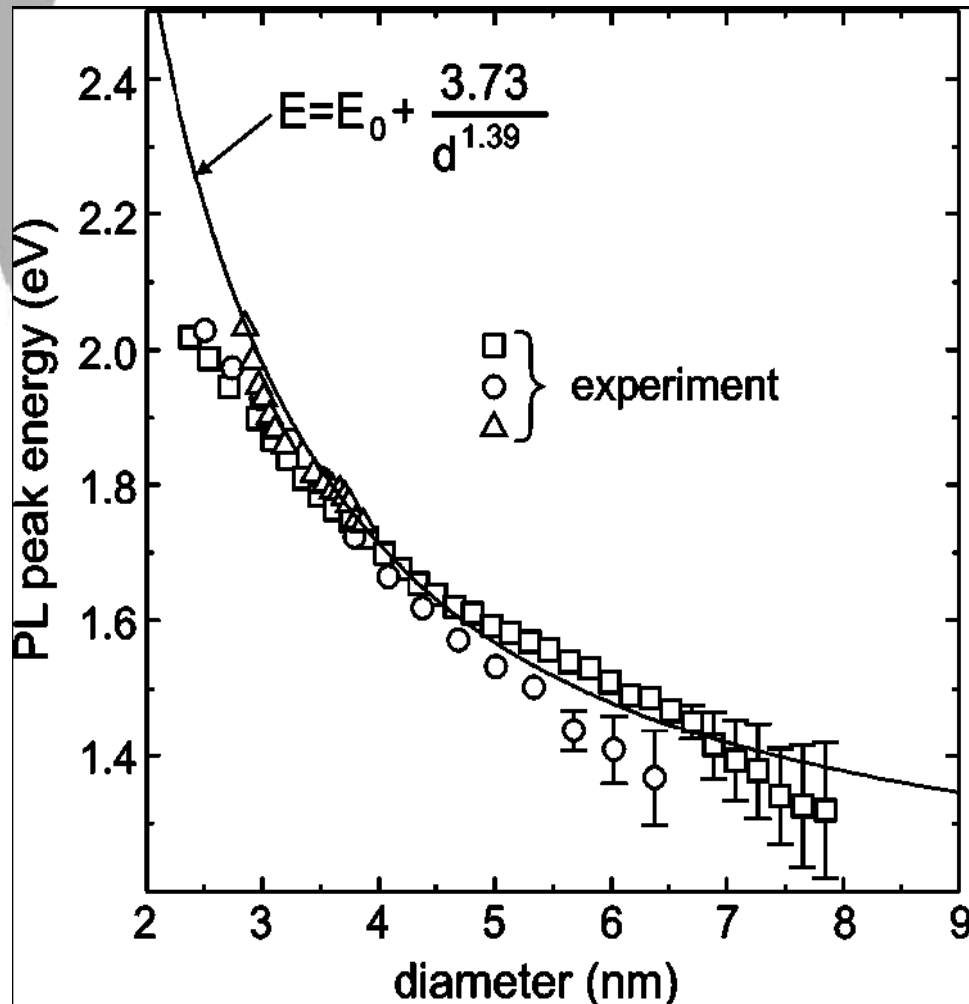
Electrons and holes are confined spatially by potential barriers (surface of nanocrystals, Si/SiO<sub>2</sub> interface, ...).

The lowest energy optical transition from the VB to the CB increases in energy, effectively increasing the bandgap.

More sophisticated calculations:

- Nonparabolicity of the CB.
- Detailed shape of the VB.
- Influence of the neighboring bands.
- Excitonic contributions.

# Tunability of color: Quantum confinement



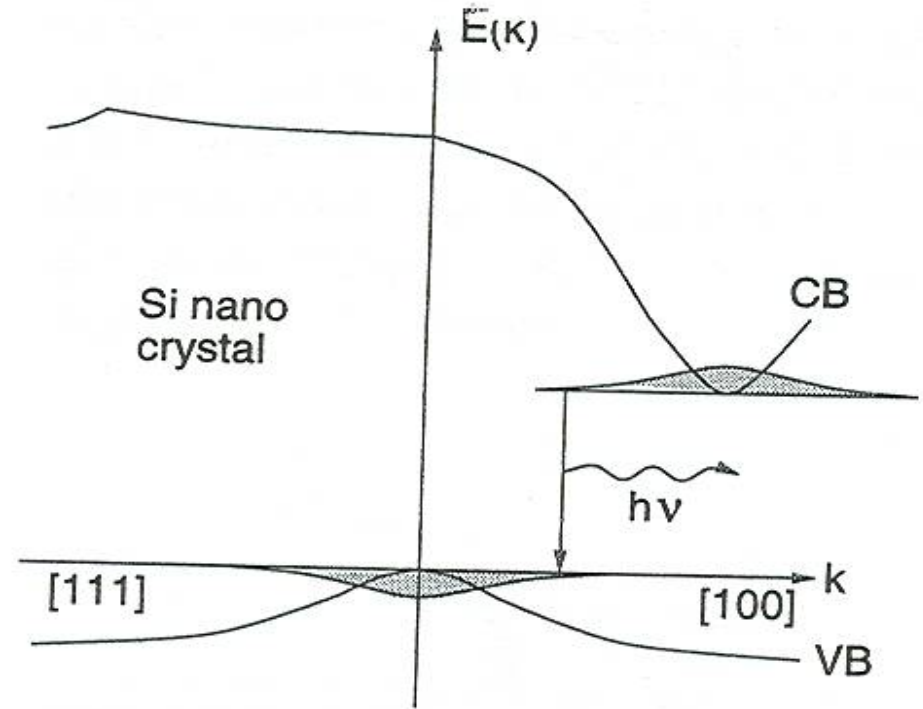
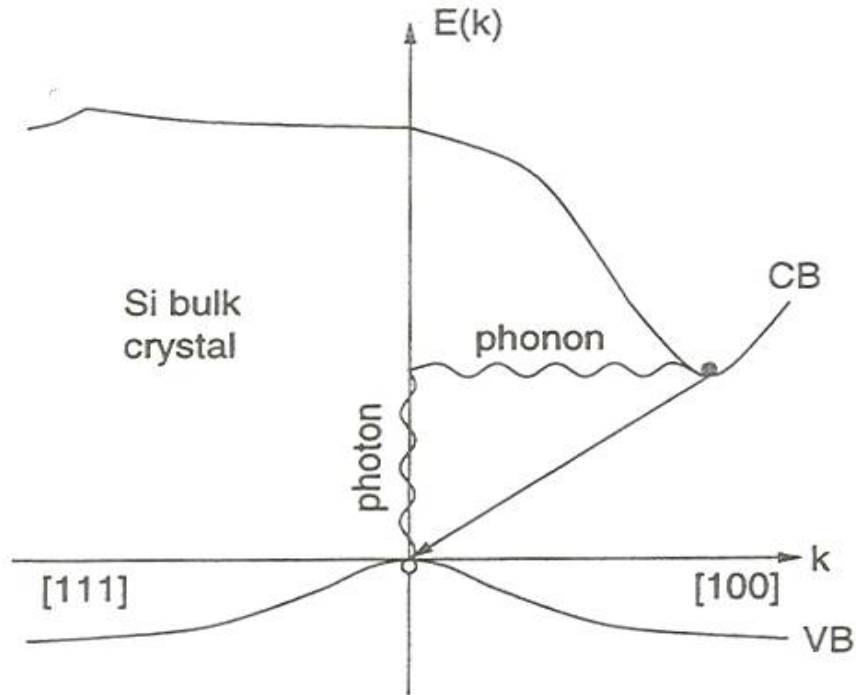
The size of the confined bandgap grows as the characteristic dimensions of the crystallite decreases.



The emission spectrum shifts to higher energy as the particle size decreases.

Visible PL and tunability are a consequence of quantum size effects.

# Increased quantum efficiency



Poor optoelectronic behavior caused by the indirect bandgap:

The extreme of the bands are located at different  $k$  values  $\rightarrow$  A transition process requires a change of the wave vector  $\rightarrow$  Interaction with phonons  $\rightarrow$  Less efficient process

Heisenberg uncertainty principle:  $\Delta x \Delta p \geq \hbar/2$

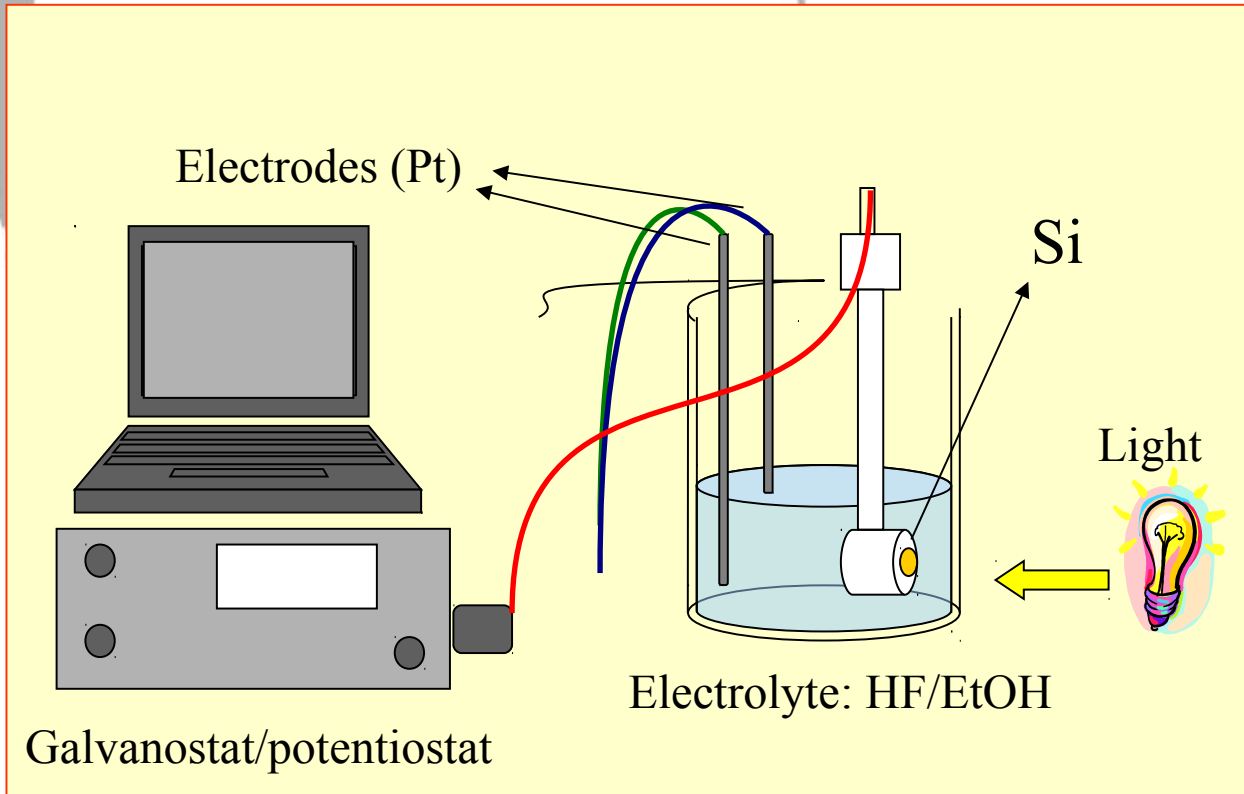
↓  
Increased probability distribution

↓  
Increased radiative recombination rate

# History

- Discovered by Uhlir in 1956 at Bell Labs. Bulk Si was transformed into a porous material when subjected to an electrochemically forced dissolution process in HF: A. Uhlir, Bell System Tech. J. 35, 333 (1956).
- First practical application: dielectric in Si-on-insulator (SOI) technology (80's).
- Canham reported an intense orange/red photoluminescence and at room temperature: L.T. Canham, Appl. Phys. Lett. 57, 1046 (1990).
- Electroluminescence demonstrated in 1992: N. Koshida and H. Koyama, Appl. Phys. Lett. 60, 347 (1992).

# Fabrication

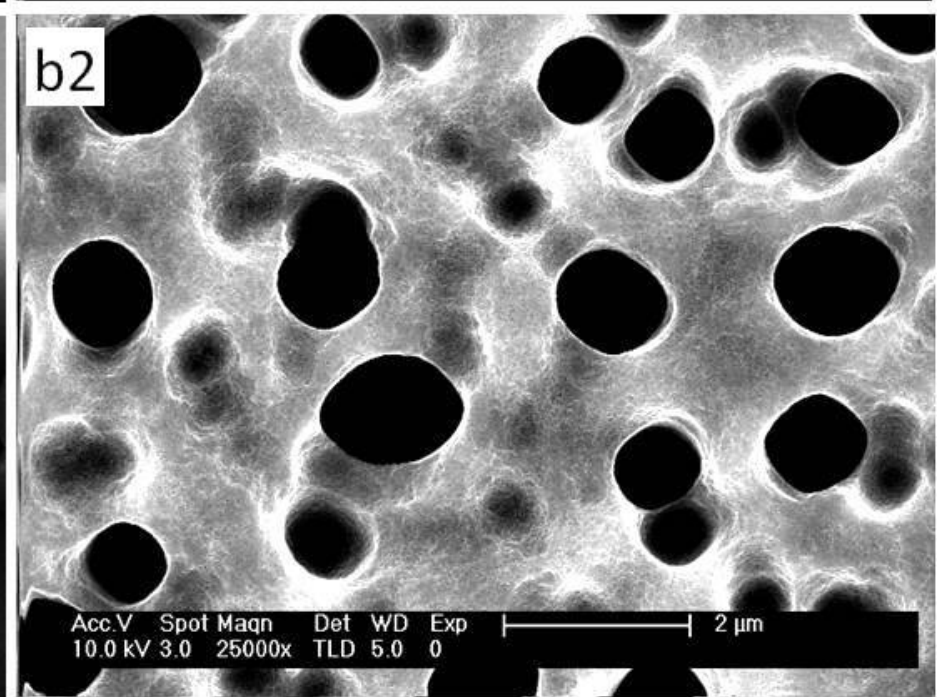
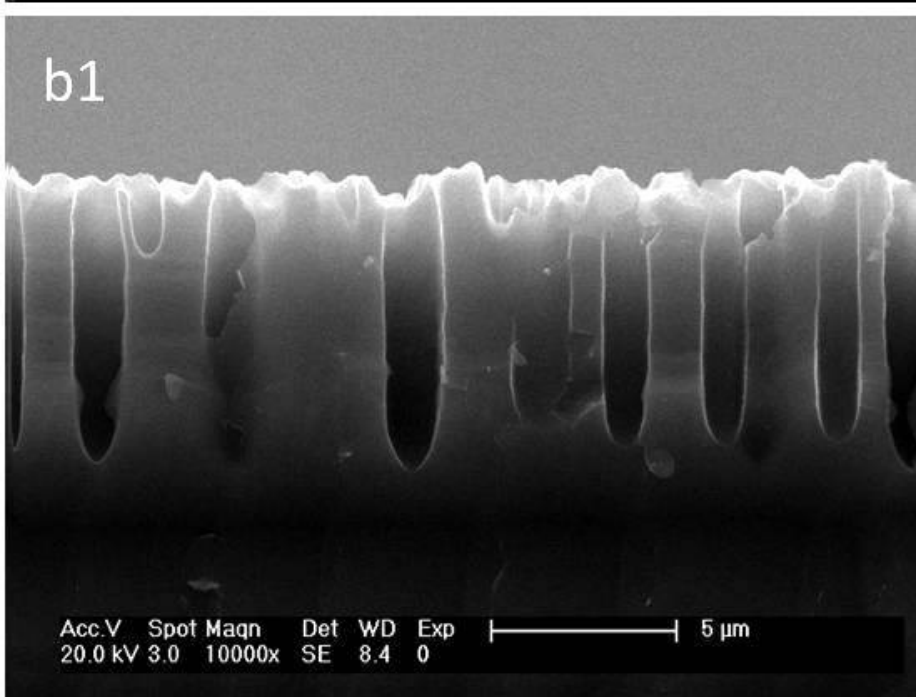
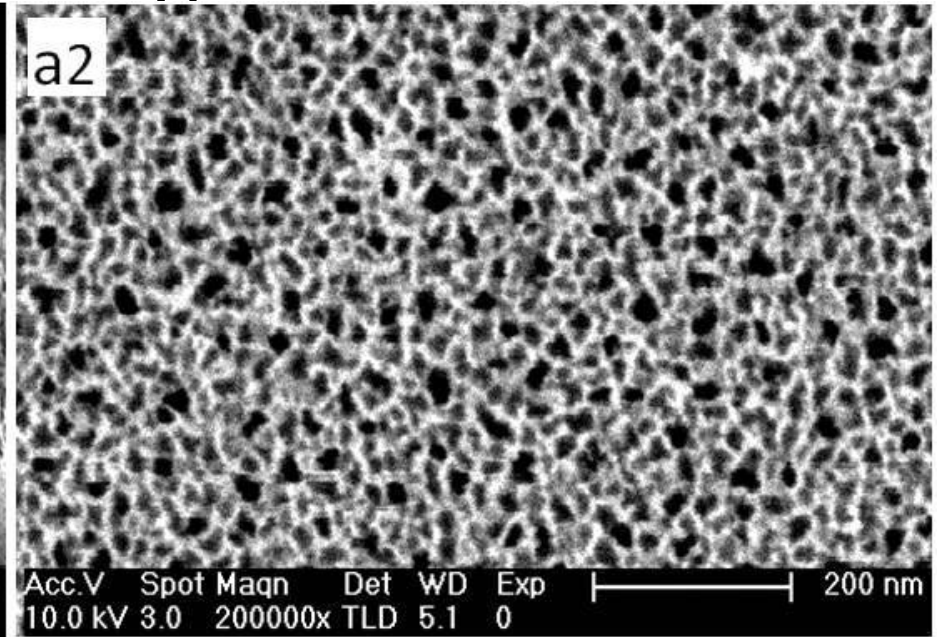
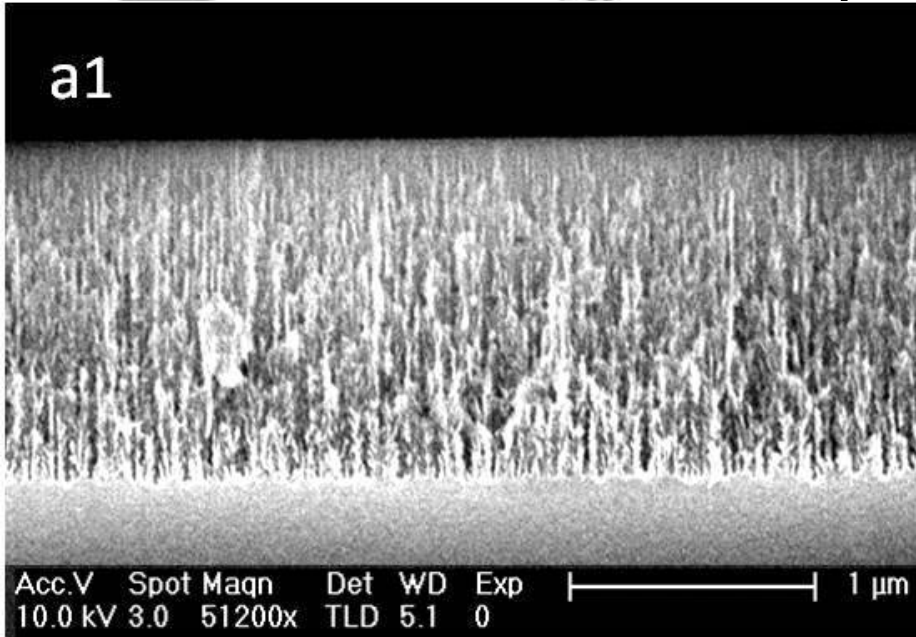


PS is formed by the electrochemical etch of Si in HF-based solutions. Chemical etching is also possible ...

The particular structure depends on:

- Formation method (chemical/electrochemical).
- Concentration of the components of the solution.
- Etching time.
- Current density (electrochemical).
- Post-formation process.
- Presence of light.
- Temperature.

# Morphology



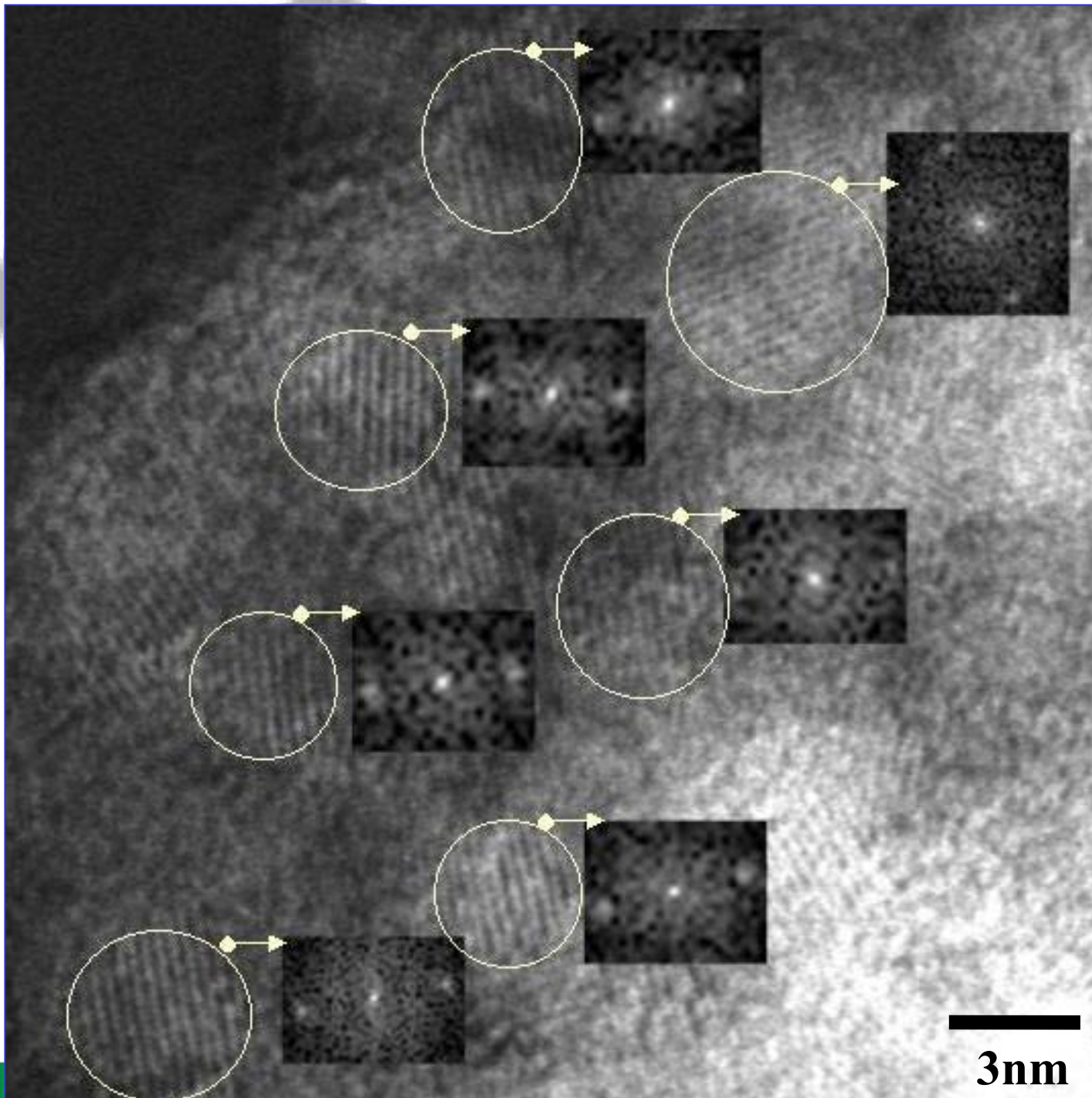


# Morphology (cont'd)

NanoPS consists in an amorphous matrix with Si crystallites embedded in it that retain the substrate crystallinity:

- Round shape
- Characteristic dimensions: 20 - 80 Å
- No preferential orientation:  
Polycrystalline diffraction pattern

R.J. Martín-Palma, L. Pascual, P. Herrero and J.M. Martínez-Duart, Applied Physics Letters 81, 25 (2002).



R.J. Martín-Palma, L. Pascual, P. Herrero and J.M. Martínez-Duart, *Applied Physics Letters* **81**, 25 (2002).

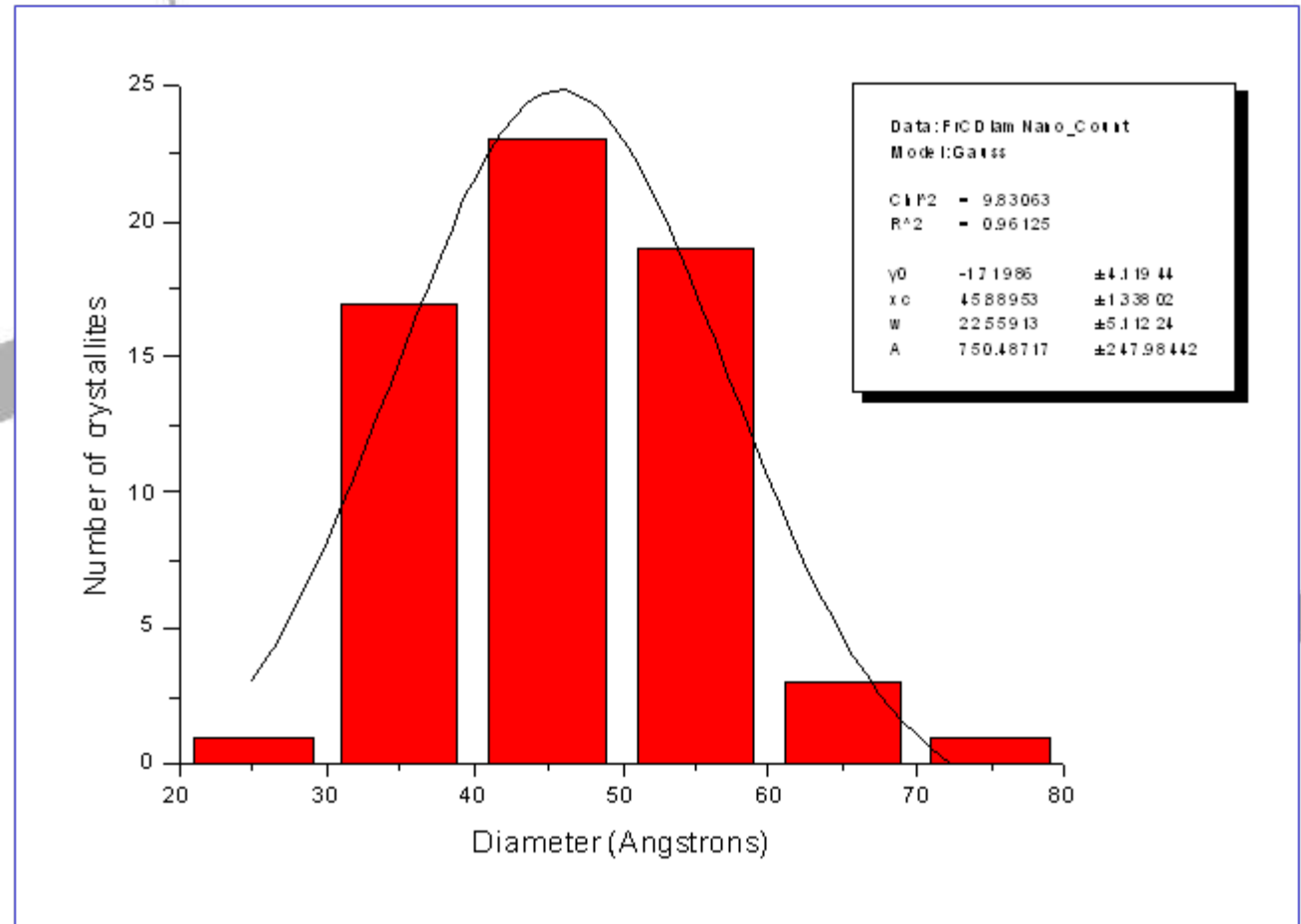
# Size of the individual Si crystallites

The size of the individual Si crystallites was directly determined.



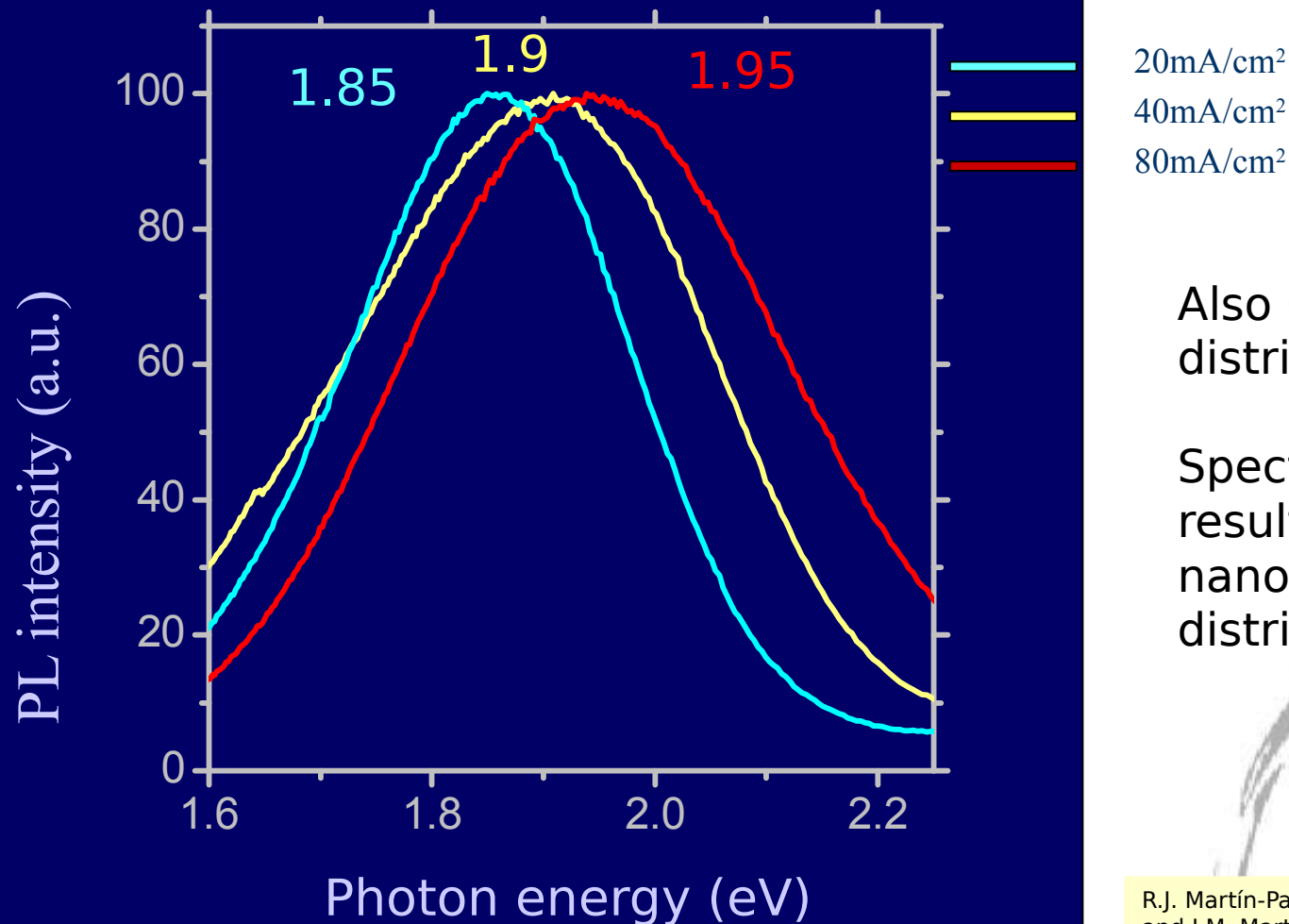
All the data were fitted to Gaussian distributions.

Individual Si crystallites:  
20 Å - 80 Å  
Center: 45.89 Å



The size distribution affects the properties of PS

# Photoluminescence

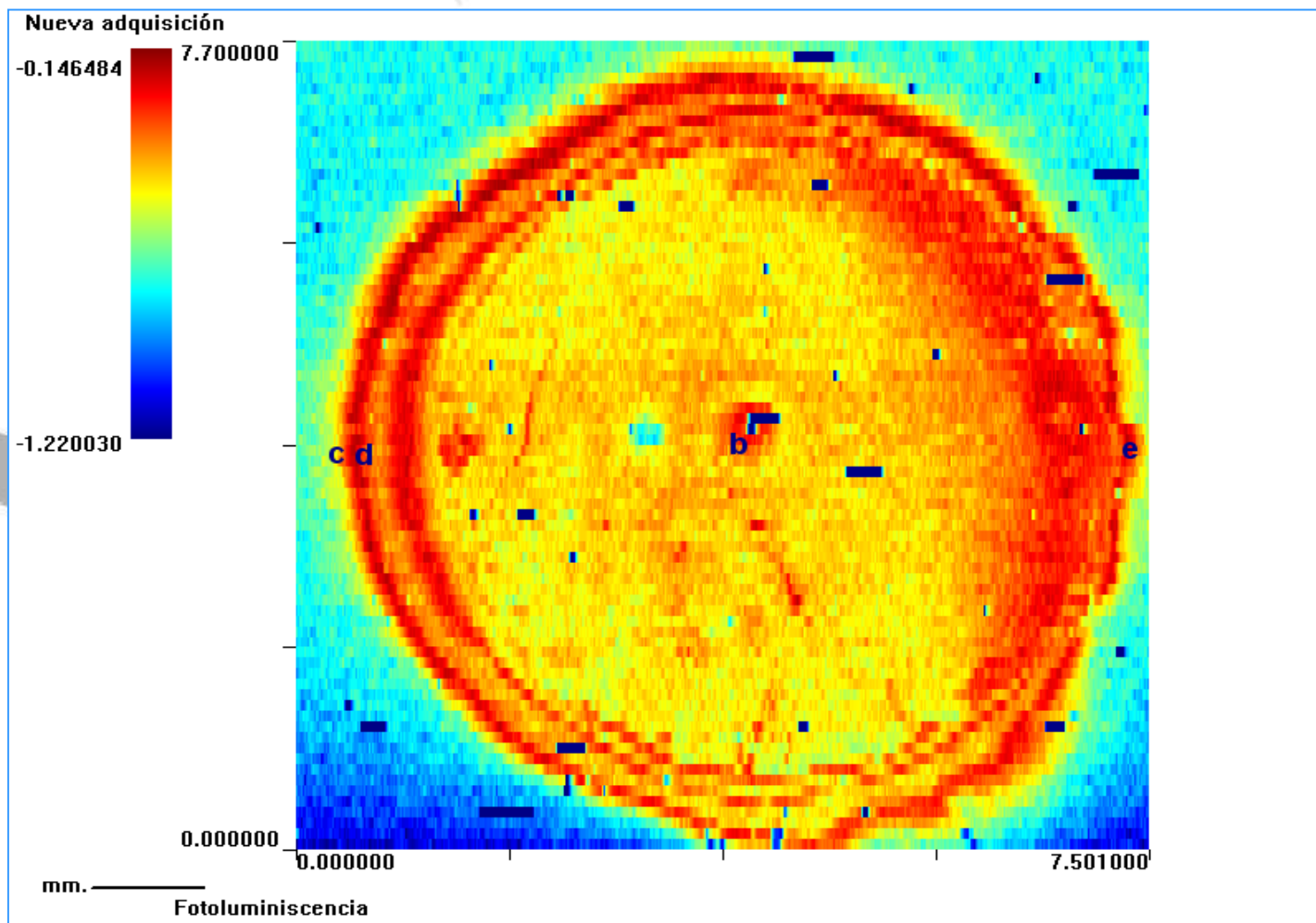


Also Gaussian distribution!!!

Spectral width result of the nanocrystal size distribution

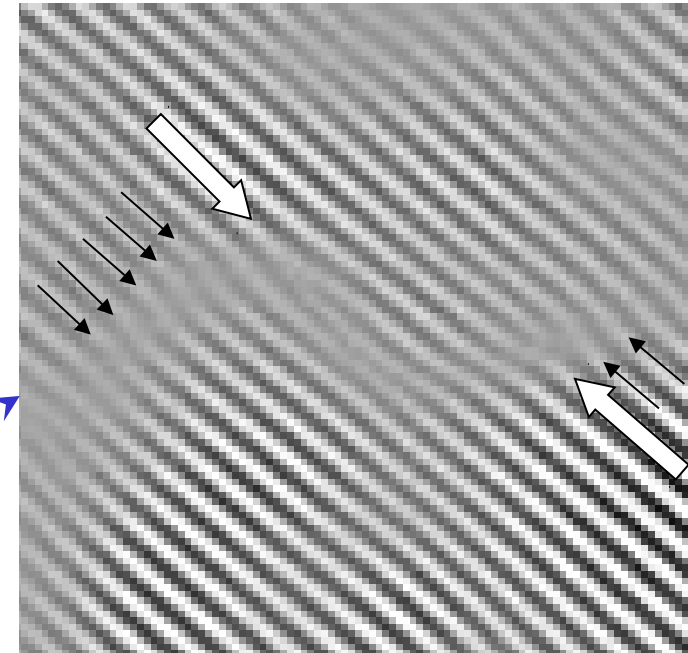
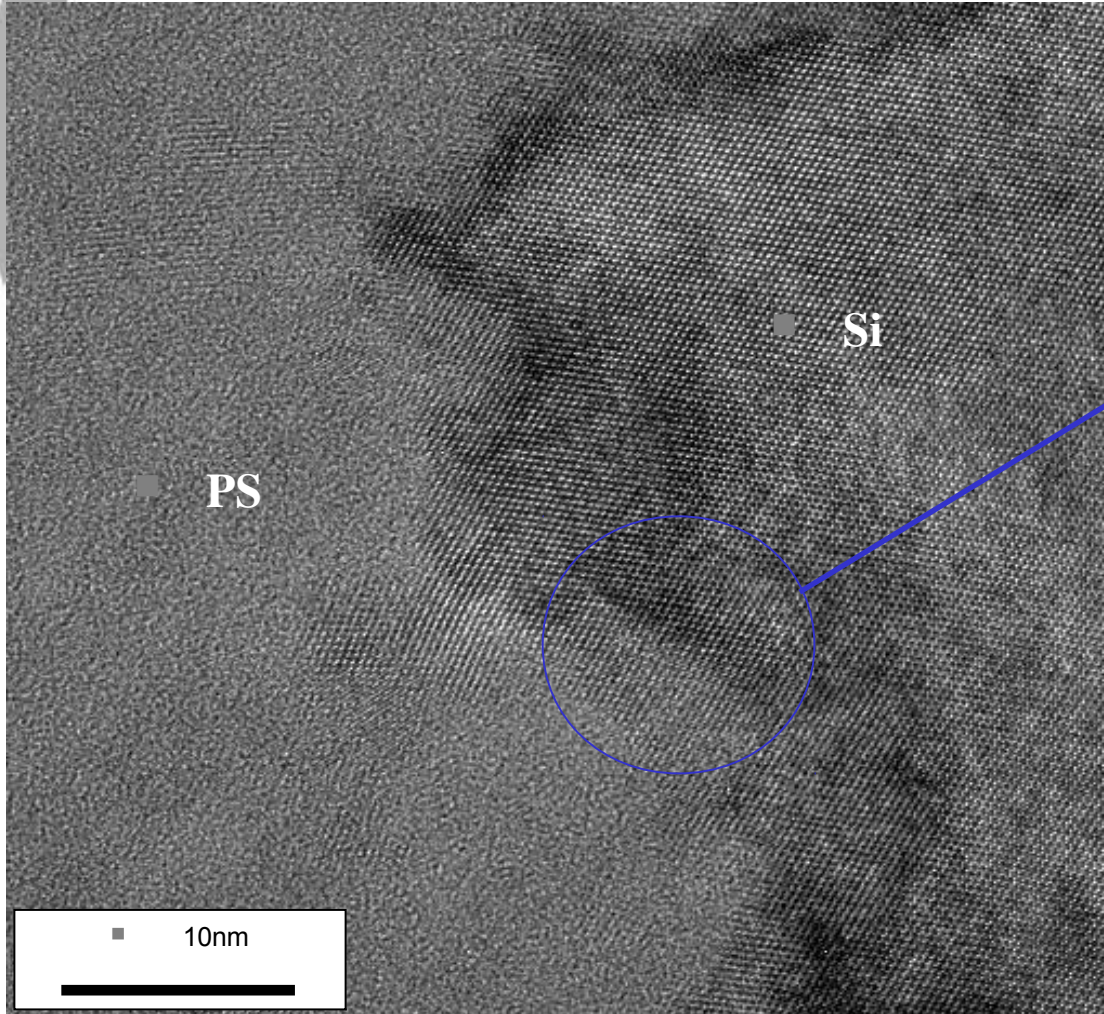
R.J. Martín-Palma, L. Pascual, P. Herrero and J.M. Martínez-Duart, *Applied Physics Letters* **87**, 211906 (2005).

# Porous SiGe



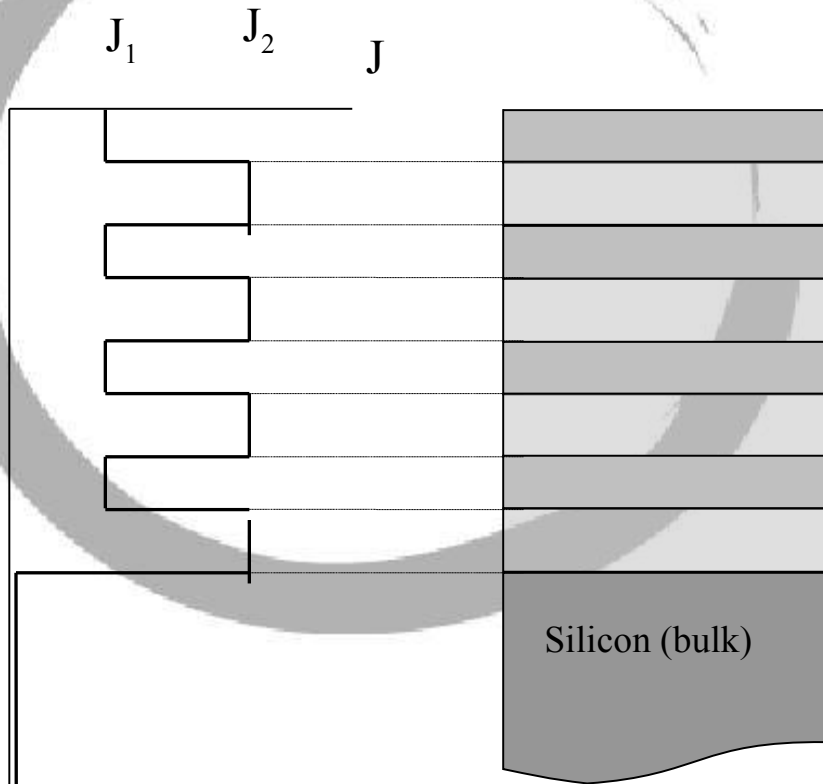
T. Del Caño, L. F. Sanz, P. Martín, M. Avella, J. Jiménez, A. Rodríguez, J. Sangrador, T. Rodríguez, V. Torres-Costa, R. J. Martín-Palma, and J. M. Martínez-Duart, *Journal of The Electrochemical Society* **151**, C326 (2004).

# PS/Si interface



- High density of dislocations.
- Significant effect on the overall behavior (anomalous absorption, leak currents, etc.).

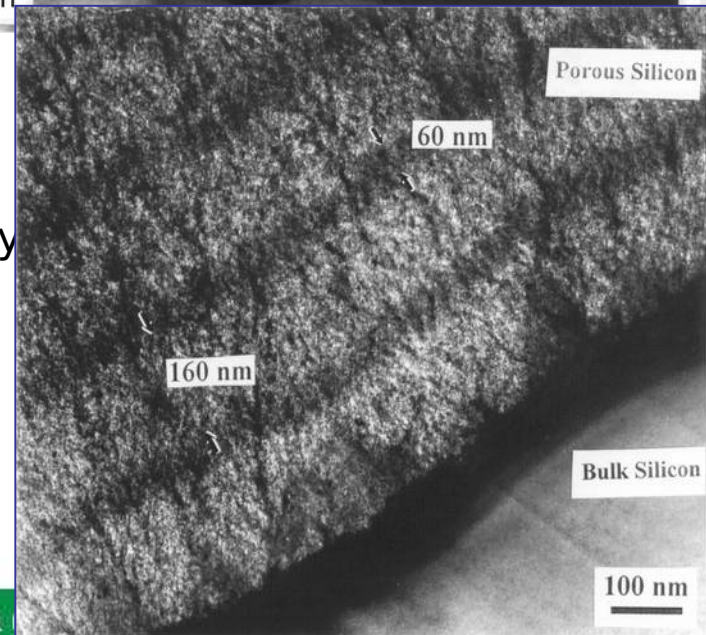
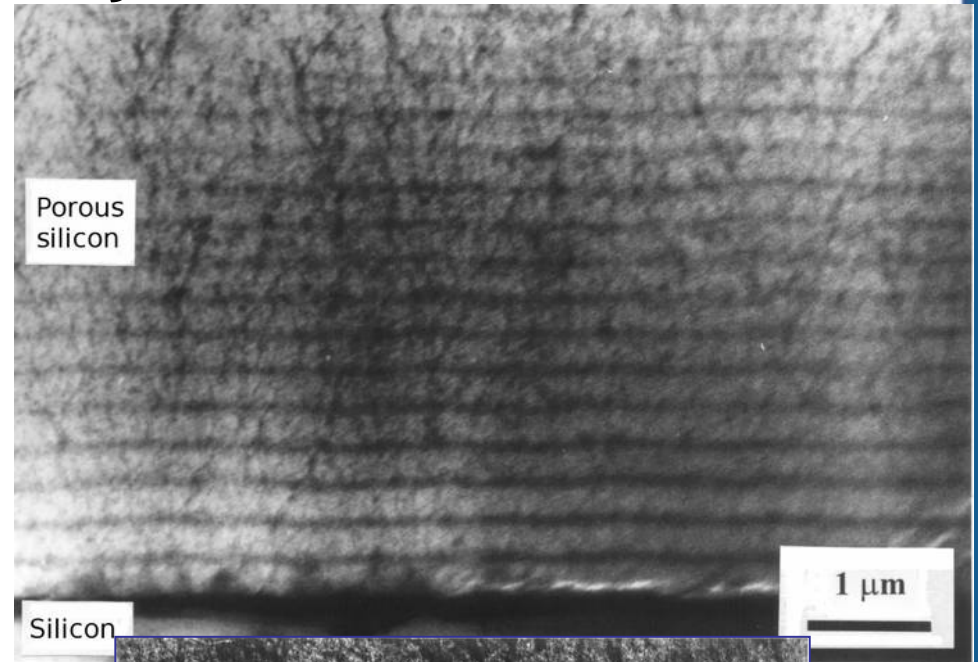
# Multilayers



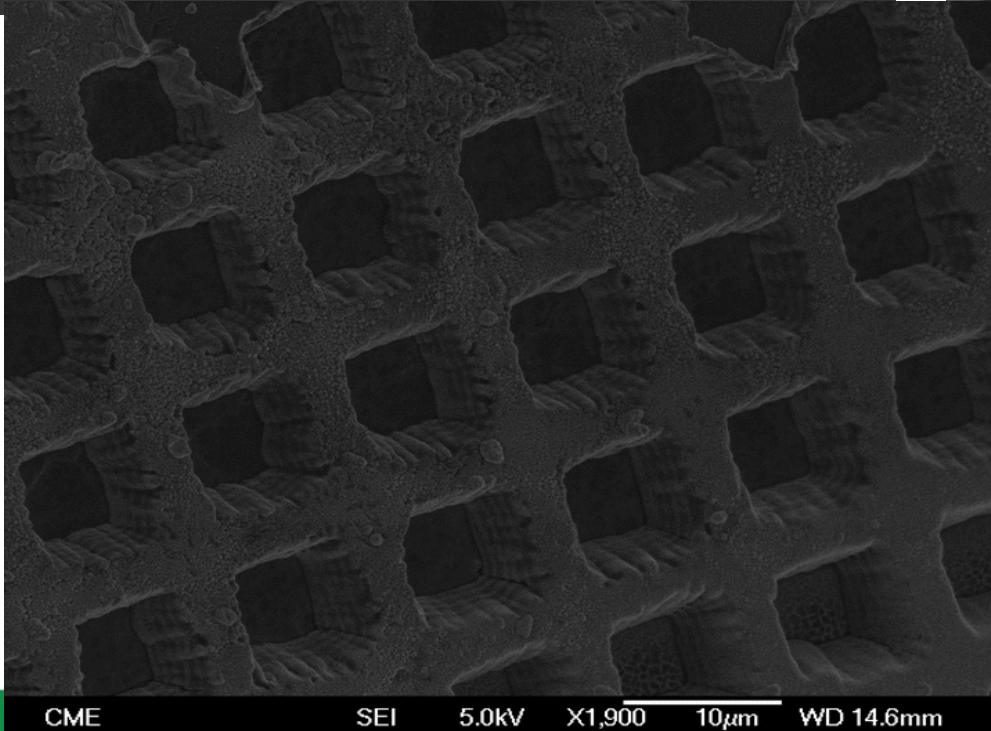
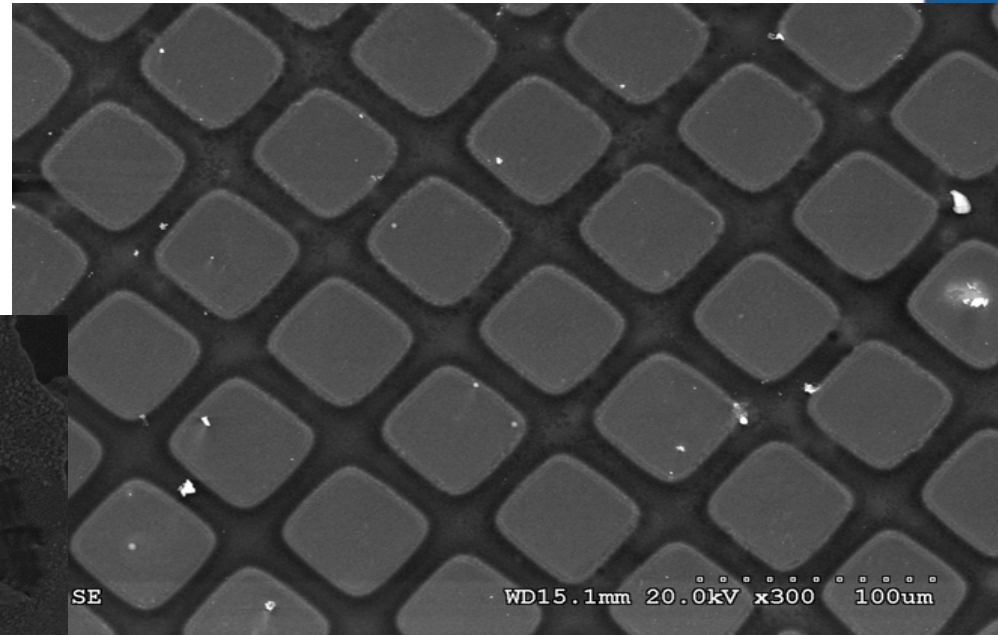
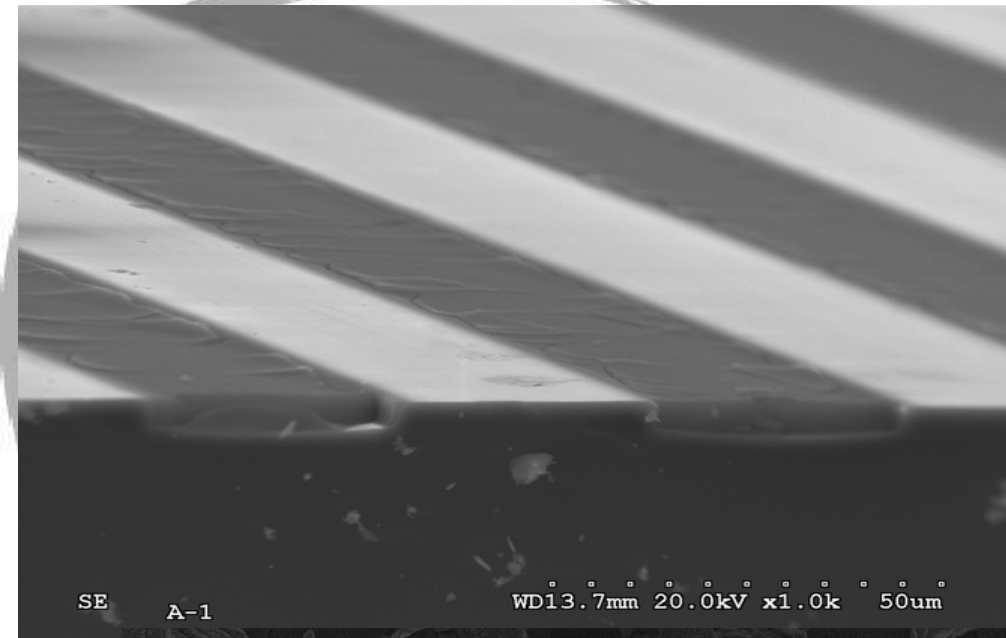
Produced by variations of the current density  
 Periodic variations of porosity.

air / (HL)<sup>p</sup> / Si

- H = high  $n$ , low porosity
- L = low  $n$ , high porosity
- $p$  = number of periods



# 1D, 2D, & 3D patterns





# Key properties

- Formed by (electro-)chemical dissolution of Si: cheap to fabricate.
- Light emission from Si (quantum size effects).
- Can be fabricated as a thin film or as powder.
- Large surface area (200-1000 m<sup>2</sup>/cm<sup>3</sup>).
- Can be passivated by SiO<sub>2</sub>, Si<sub>3</sub>N<sub>4</sub>, ...
- The ability to electrochemically tune the pore diameters and nanocrystals size, and to chemically modify the surface provides control over the size and type of molecules adsorbed.
- Its behavior can be altered from bio-inert to bioactive to resorbable.
- Other porous semiconductors: SiC, GaP, SiGe, Ge, GaAs, InP.

## Strong Explosive Interaction of Hydrogenated Porous Silicon with Oxygen at Cryogenic Temperatures

D. Kovalev, V. Yu. Timoshenko, N. Künzner, E. Gross, and F. Koch

*Technische Universität München, Physik-Department E16, D-85747 Garching, Germany*

(Received 12 March 2001; published 19 July 2001)

We report new types of heterogeneous hydrogen-oxygen and silicon-oxygen branched chain reactions which have been found to proceed explosively after the filling of pores of hydrogen-terminated porous silicon (Si) by condensed or liquid oxygen in the temperature range of 4.2–90 K. Infrared vibrational absorption spectroscopy shows that, while initially Si nanocrystals assembling the layers have hydrogen-terminated surfaces, the final products of the reaction are SiO<sub>2</sub> and H<sub>2</sub>O. Time-resolved optical experiments show that the explosive reaction develops in a time scale of 10<sup>-6</sup> s. We emphasize the remarkable structural properties of porous Si layers which are crucial for the strong explosive interaction.

DOI: 10.1103/PhysRevLett.87.068301

PACS numbers: 81.65.-b, 68.03.Fg, 82.33.Vx

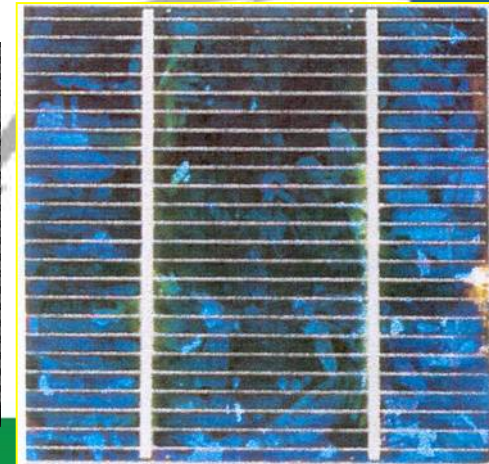
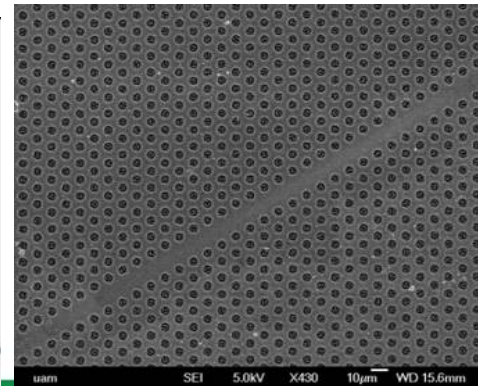
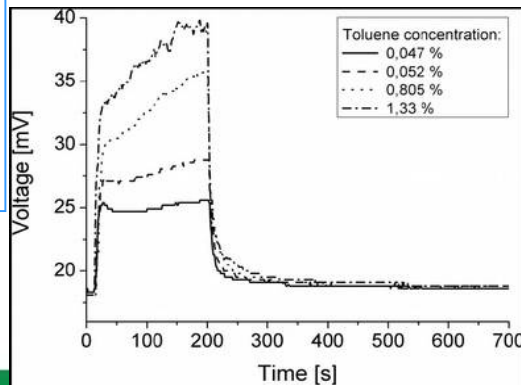
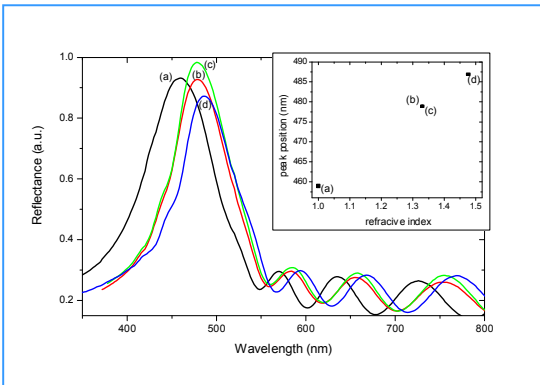
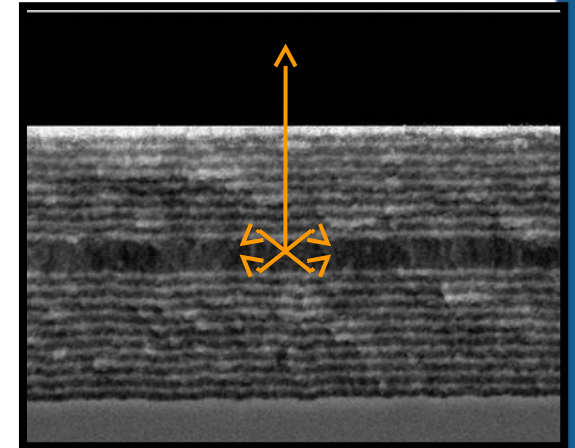
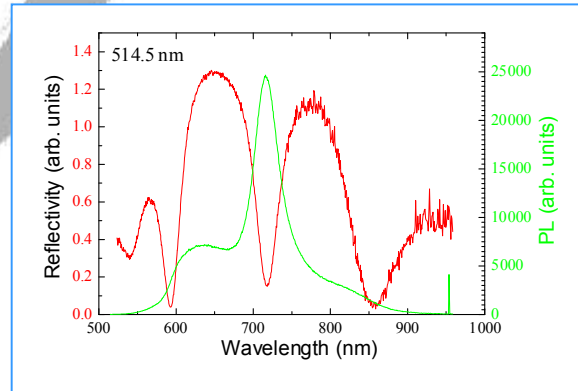
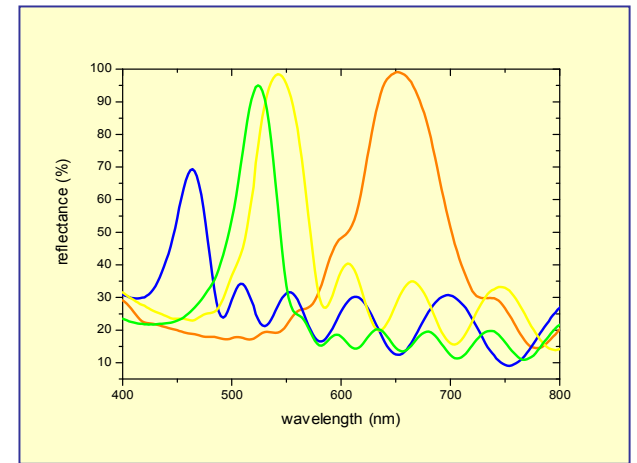
- “Hydrogenated porous silicon reacts explosively with oxygen at cryogenic temperatures, releasing several times as much energy as an equivalent amount of TNT, at a much greater speed”.
- Although hydrogenated porous silicon would probably not be effective as a weapon, due to its functioning only at low temperatures, other uses can be explored.

# Outline

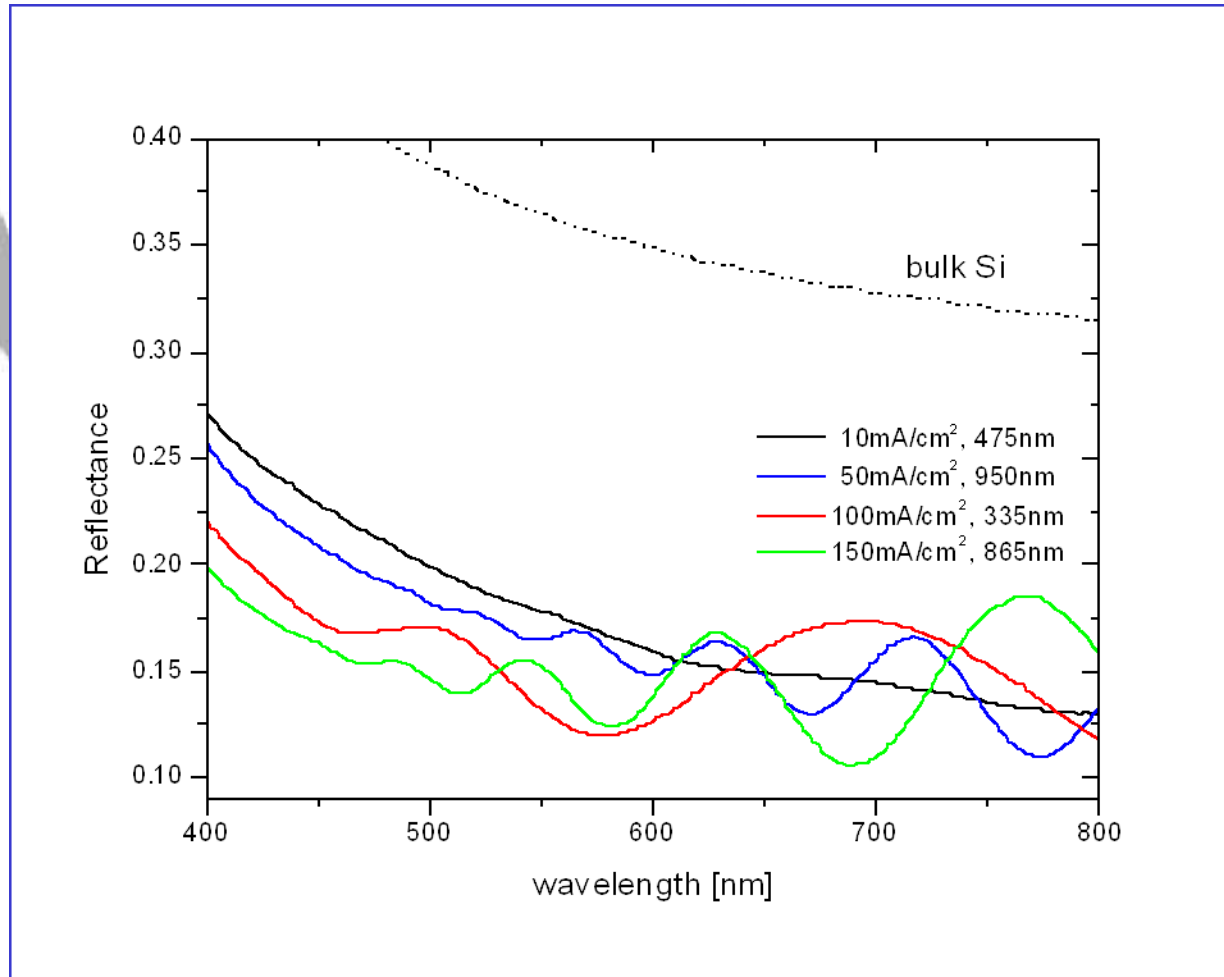
- Introduction: What is Nanotechnology? Examples and applications.
- What is porous silicon? Why is it interesting?
- How is porous silicon fabricated?, how does it look like?
- Key properties.
- **Applications: From photonics to biomedicine**
- Summary

# Applications

- AR coating, Bragg reflectors, waveguides, microcavities,...
- Photonic crystals
- Light emitting diodes
- Photodiodes, solar cells
- Chemical sensors
- Biological sensors

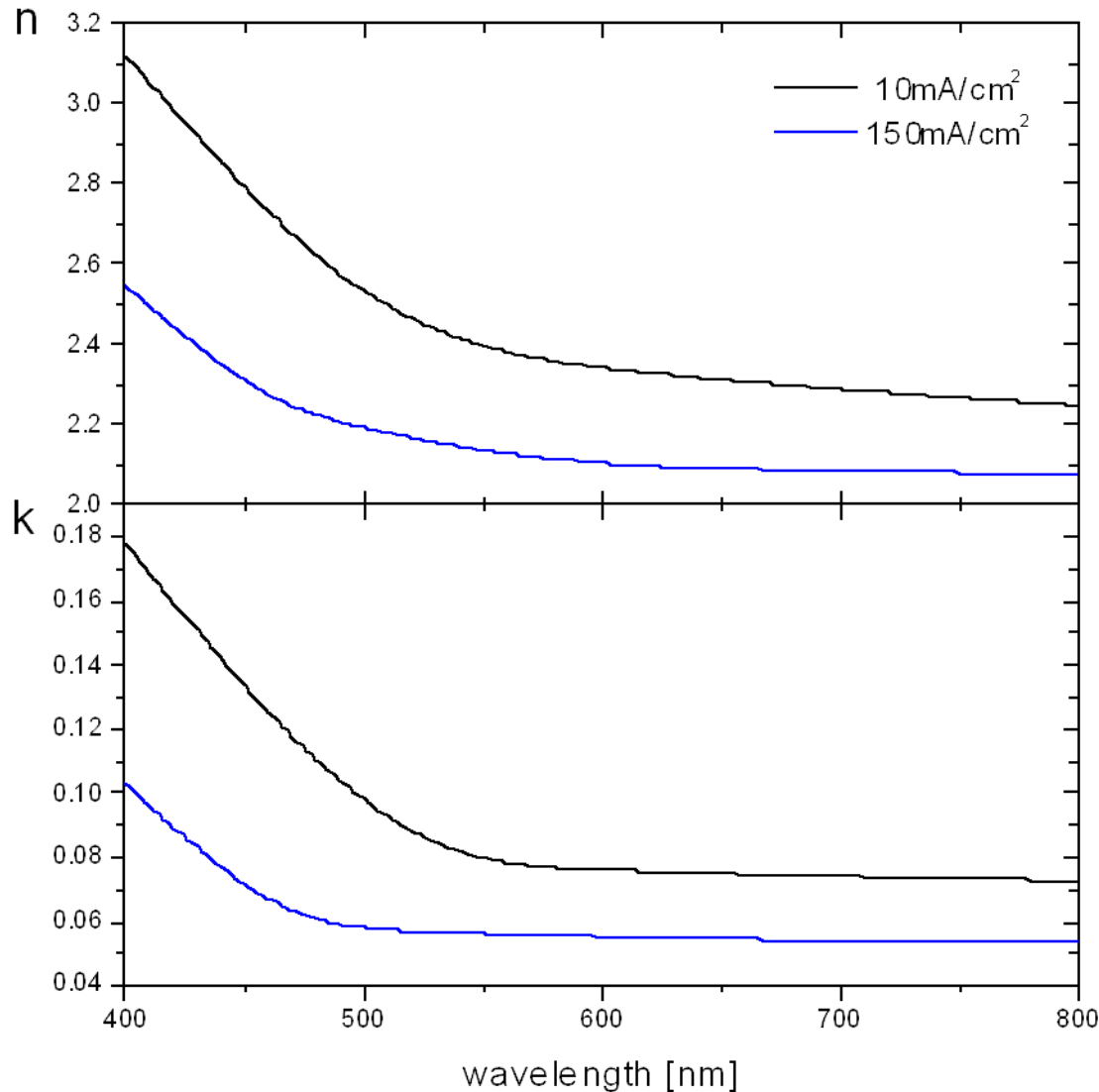


# AR coatings



- Notable reduction of  $R$ .
- $R$  depends on the formation parameters  
→ Structure of PS.

# Optical constants ( $n$ and $k$ )

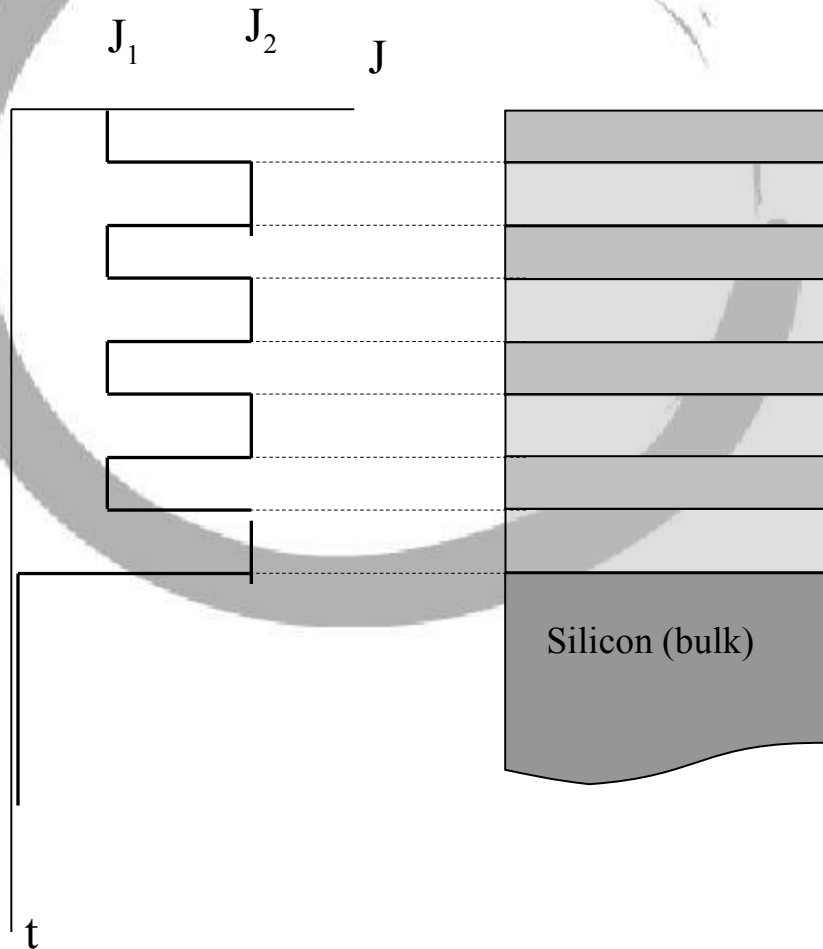


The optical constants ( $n$  and  $k$ ) and layer thickness are determined from the reflectance spectrum by means of a self-adaptive genetic algorithm.

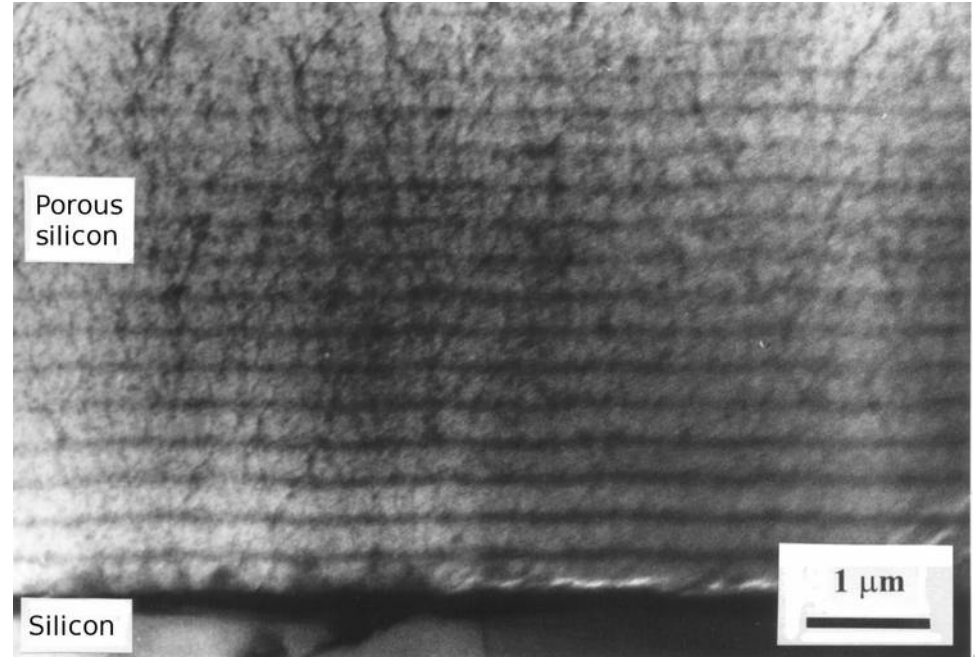
Thickness inhomogeneity and absorption processes lead to high values of  $k$ , since the value of this “effective”  $k$  stands for the overall coherency loss.

V. Torres-Costa, R.J. Martín-Palma and J.M. Martínez-Duart, *Journal of Applied Physics* **96**, 4197 (2004).

# PS multilayer stacks

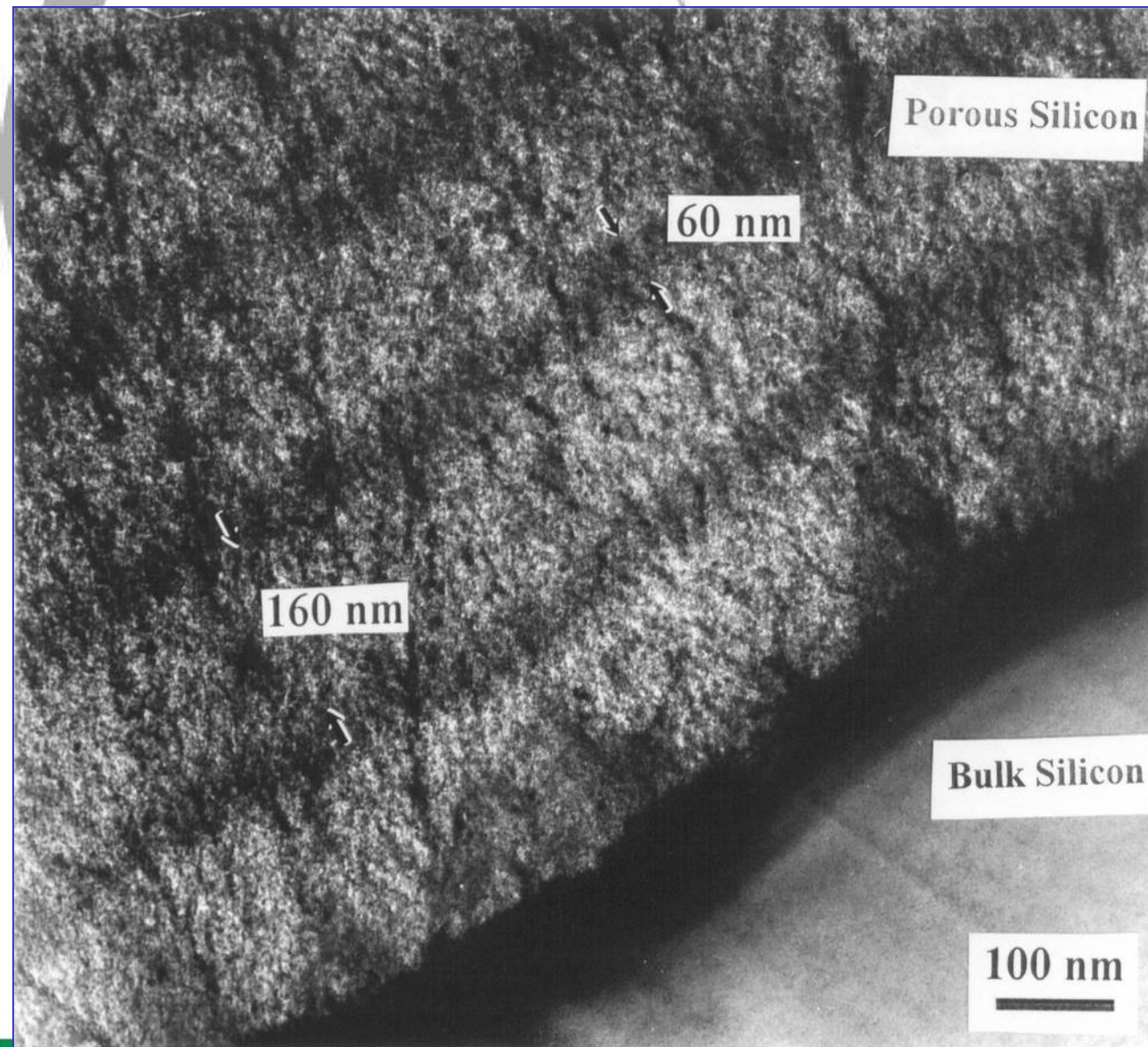


Produced by variations of the current density: Periodic variations of porosity.



air / (HL)<sup>p</sup> / Si {  
 H = high  $n$ , low porosity  
 L = low  $n$ , high porosity  
 p = number of periods.

# PS multilayer stacks (cont'd)



A change of  $\rho$  does not affect the already etched parts of the sample



Only the newly produced PS grows with a different porosity according to the new  $\rho$ .

Good quality of layers and interfaces



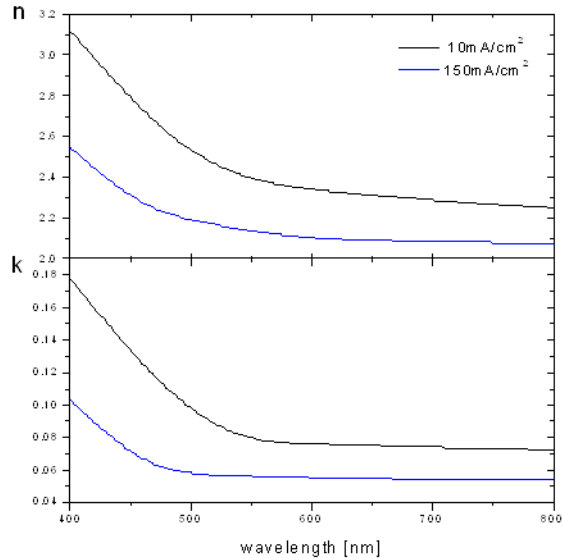
Results in good optical properties.

R.J. Martín-Palma et al., *J. Mat. Sci. Lett.* **17**, 845 (1998).

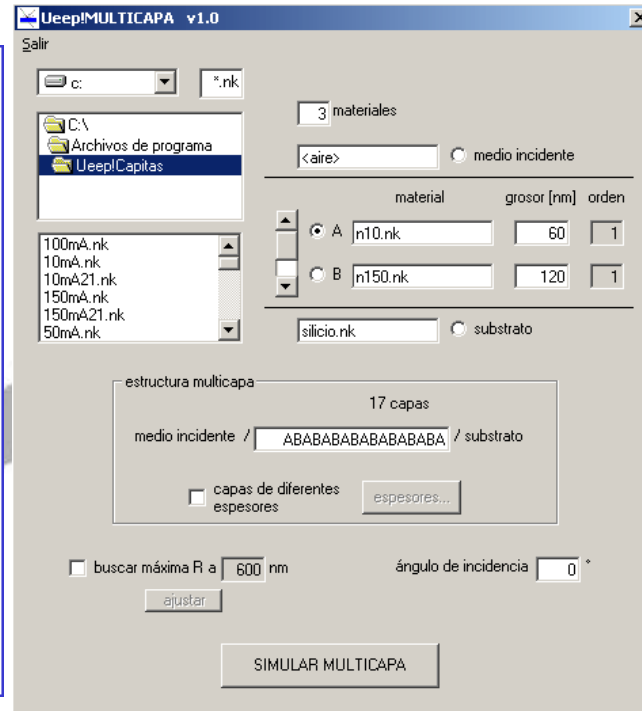


# Multilayer design

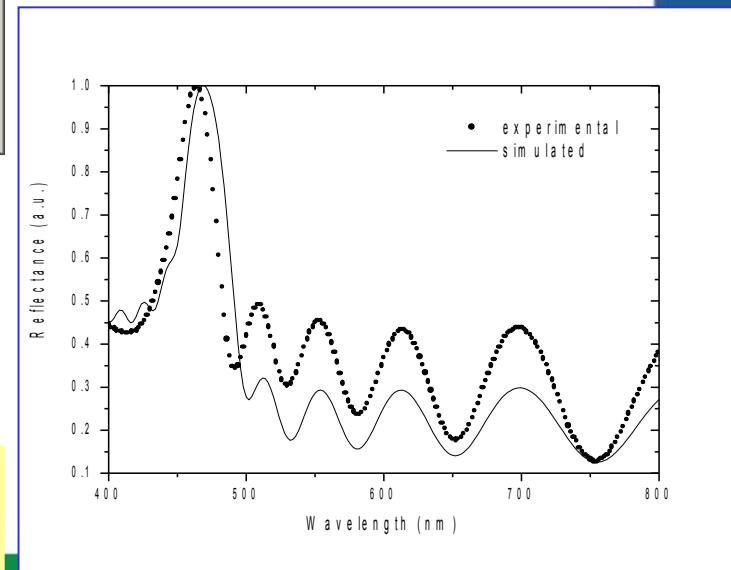
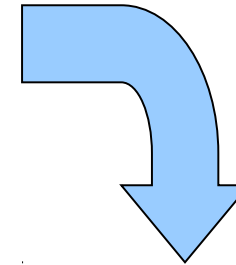
## Optical constants



## Structure desing



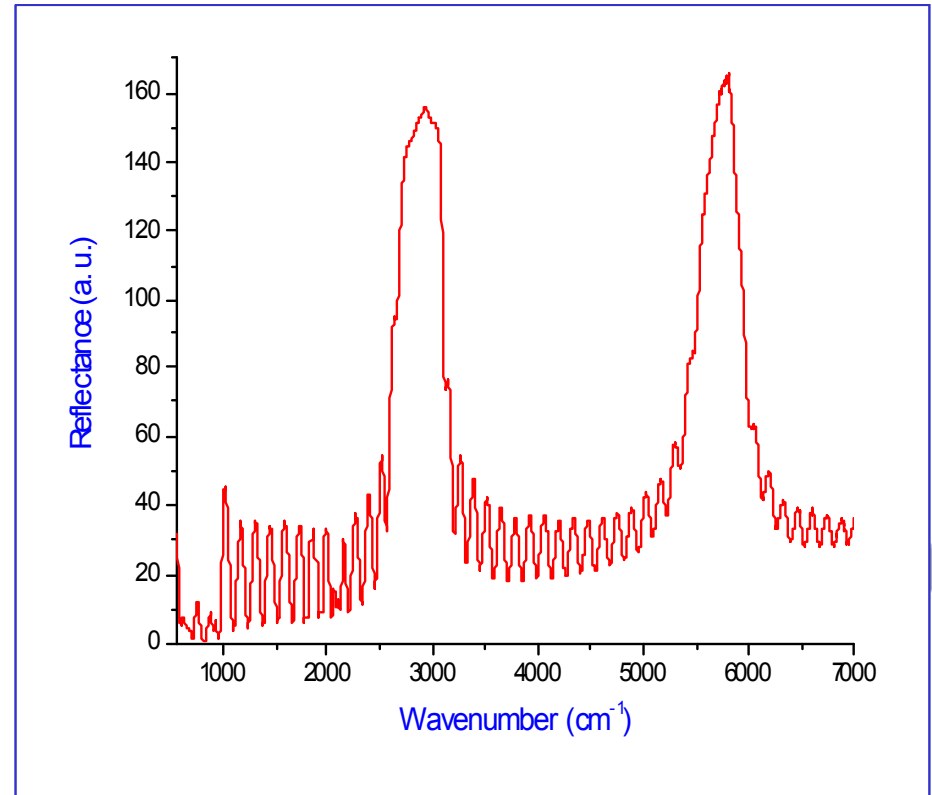
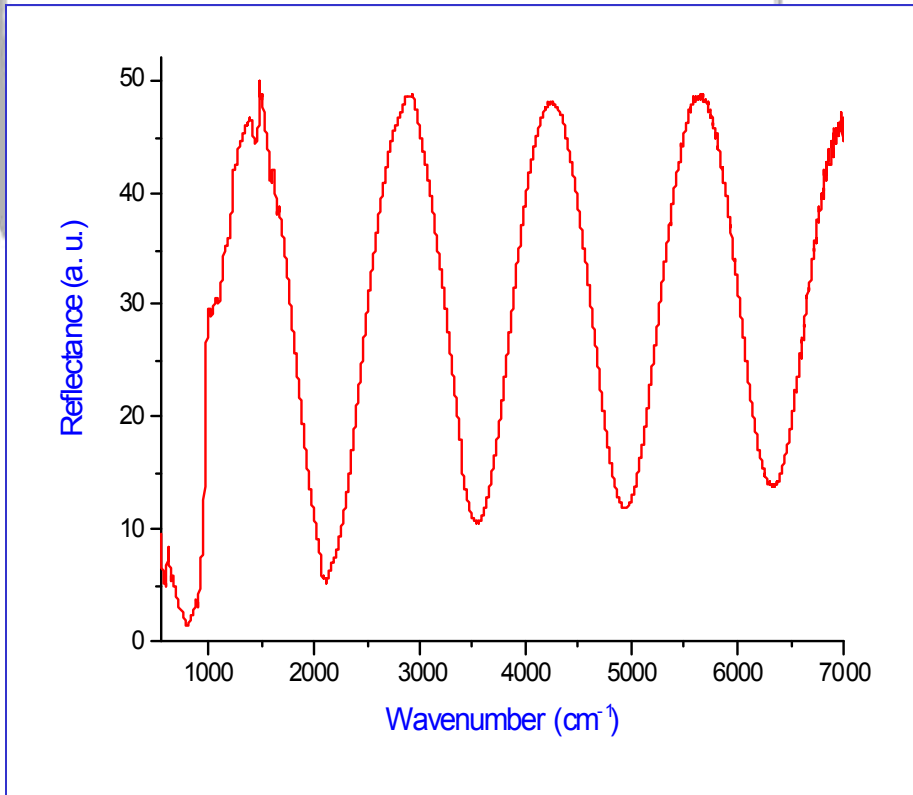
## Simulation and fabrication



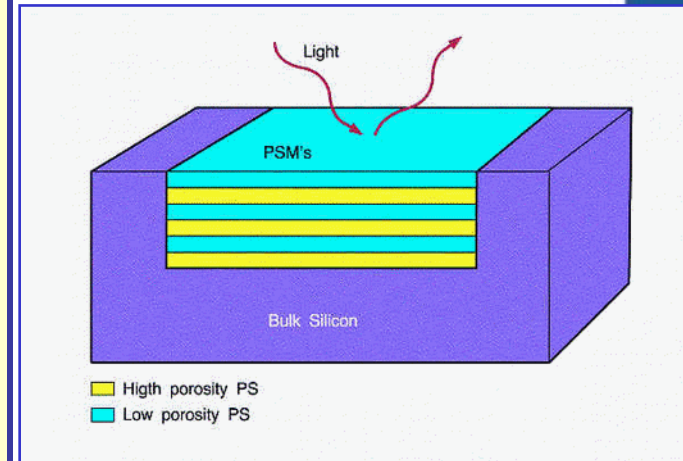
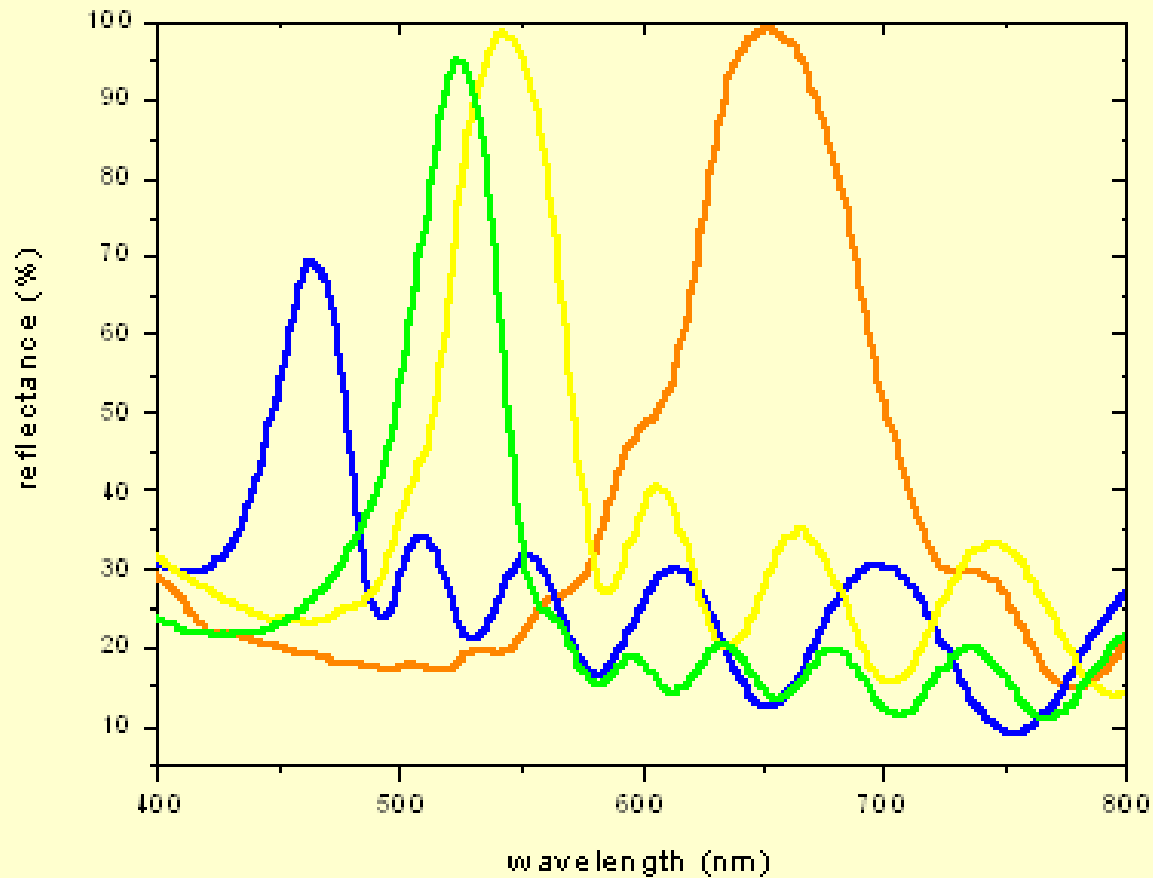
Control porosity → Control  $n$  (and thickness)

Coatings with the “desired” optical properties can be fabricated

# Interference filters in the IR



# Bragg reflectors



Reflectance maximum (stop-band) centered at the wavelength where the  $\lambda/2$  condition is reached.

Structure infiltration by a substance of refractive index  $n_{liq}$



increase of effective refractive index:

$$\Delta n \cong p(n_{liq}-1)$$



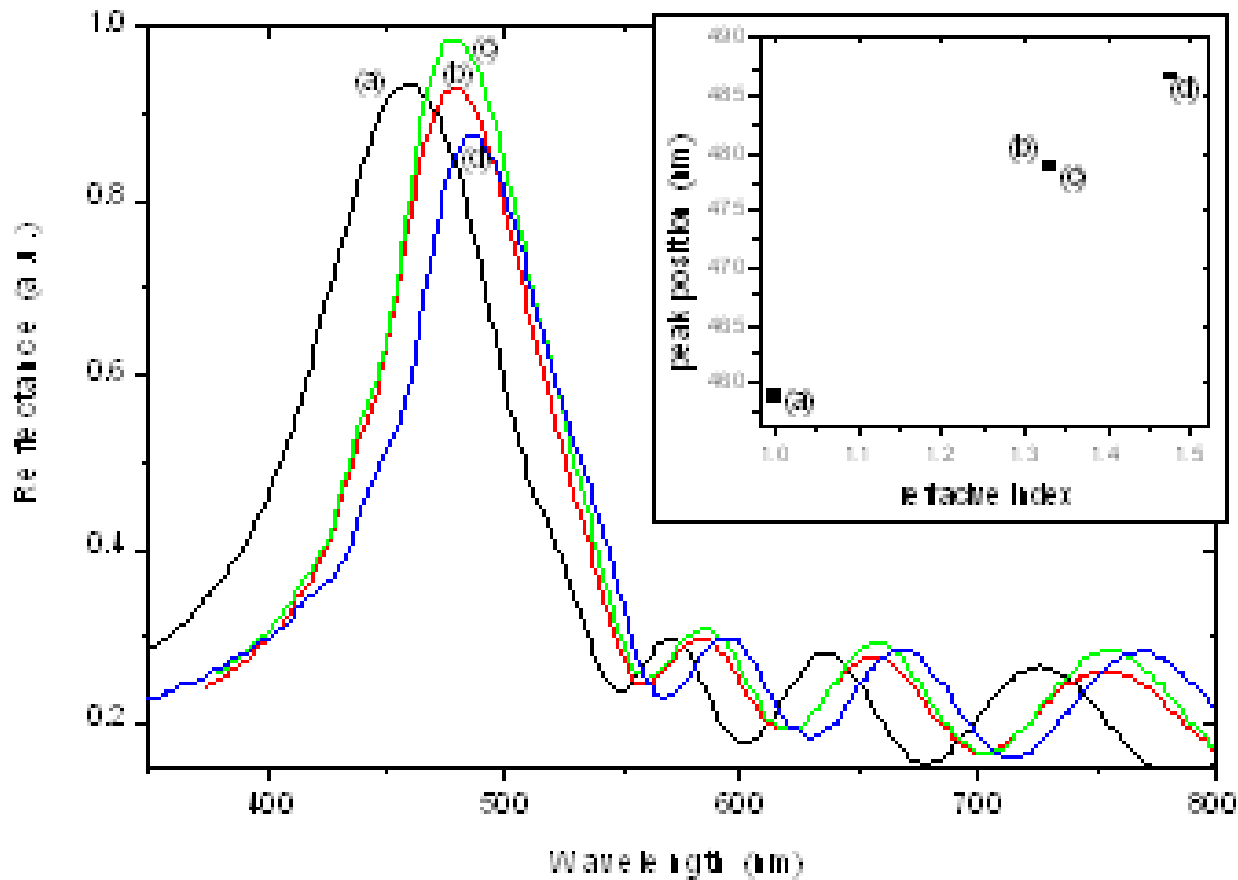
spectral shift:

$$\Delta\lambda/\lambda_0 = \Delta n = p(n_{liq}-1)$$



Optical chemical sensors

# Chemical sensors

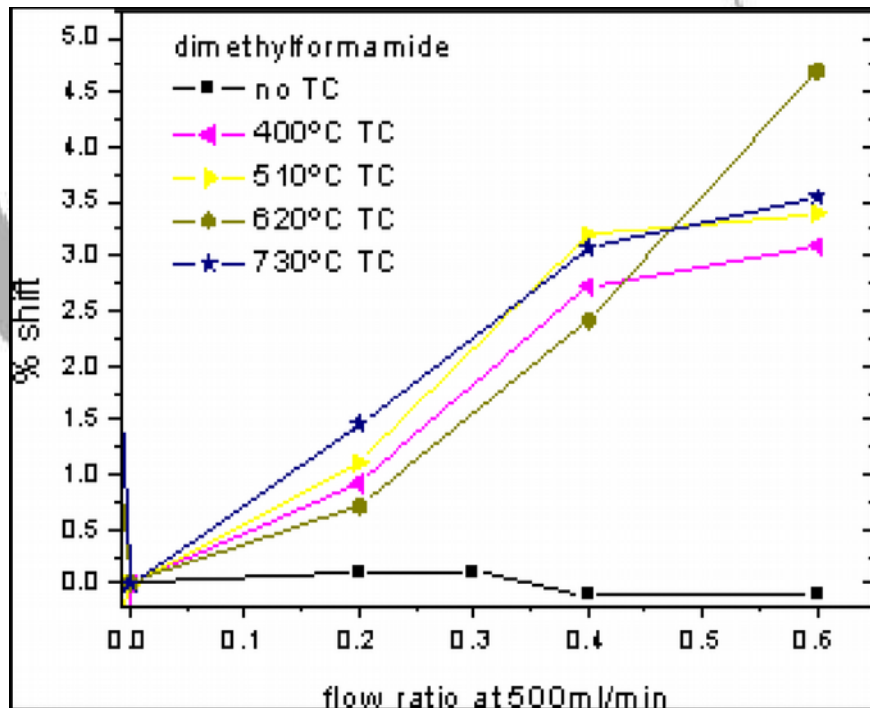


- (a) As-prepared PS multilayer.
- Infiltration with:
  - (a) Water.
  - (b) Ethanol.
  - (c) Trichloroethylene.

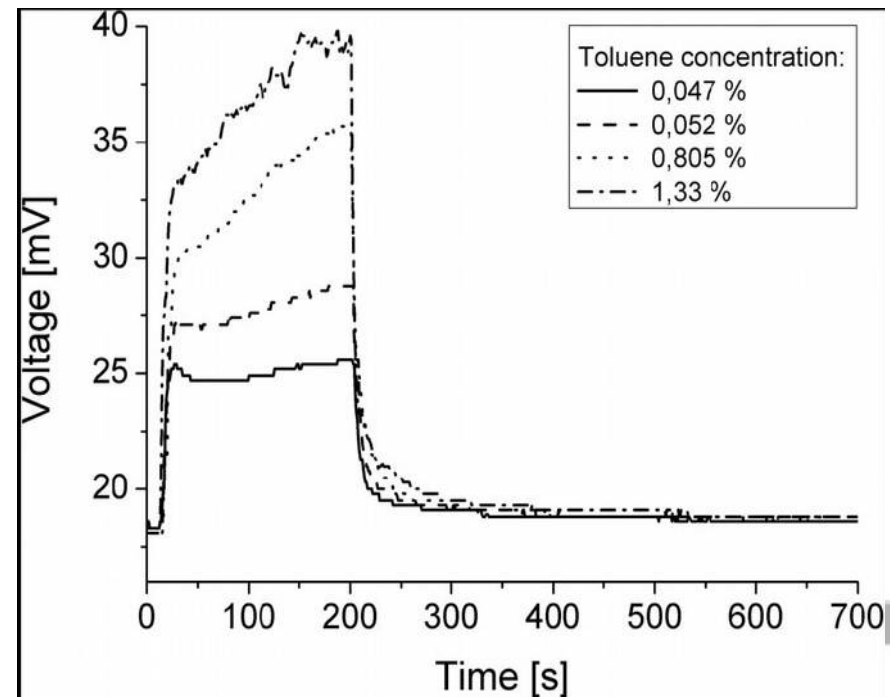
Reflectance peak position as a function of  $n$  of the filling liquid: (water  $n=1.333$ , ethanol  $n=1.329$  and trichloroethylene  $n=1.476$ ).

Reversible behavior!!!

# Gas sensors



Optical response of PS as a function of dimethylformamide concentration at a constant nitrogen flow.



- Response of TC PS sensors to different toluene concentrations ( $R$  @ fixed  $\lambda$ ).
- Toluene was introduced in the chamber with a nitrogen flow at  $t = 20$  s and flushed away at  $t = 200$  s.



High specific surface of PS

+

Control of the physico-chemical behavior of its surface

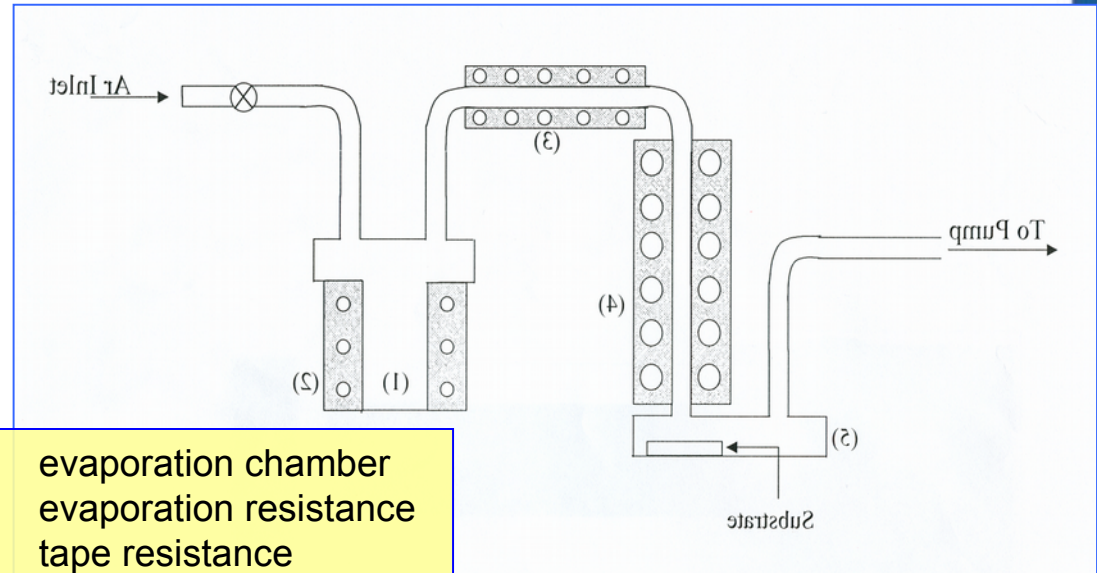


Development of **biosensors**

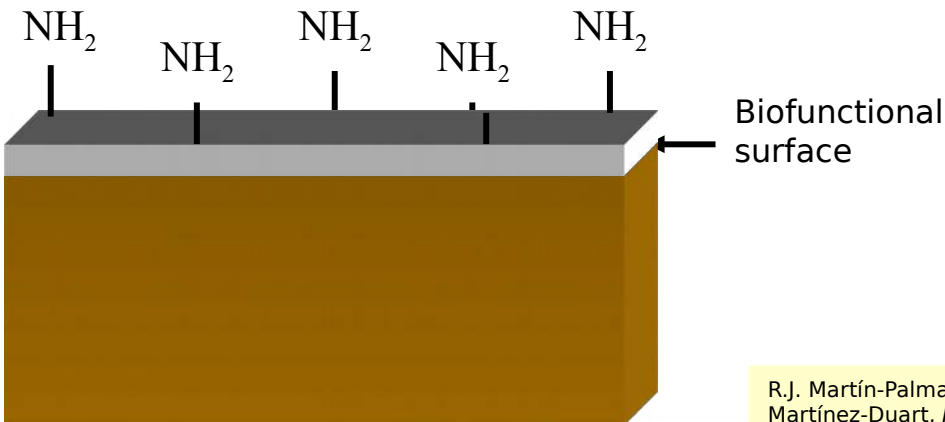


# Surface functionalization

- **Biofunctional surface:** **Functional groups** on the surface. These groups react with biomolecules (proteins, DNA, ...).
- **Thermally activated chemical vapor deposition (TA-CVD):** Activation of precursor 3-aminopropyltriethoxysilane (APTS) at high temperature.
- By TA-CVD amine groups are deposited (-NH<sub>2</sub>). These groups react with biomolecules through a peptide bond.



- (1) evaporation chamber
- (2) evaporation resistance
- (3) tape resistance
- (4) activation furnace
- (5) treatment chamber.



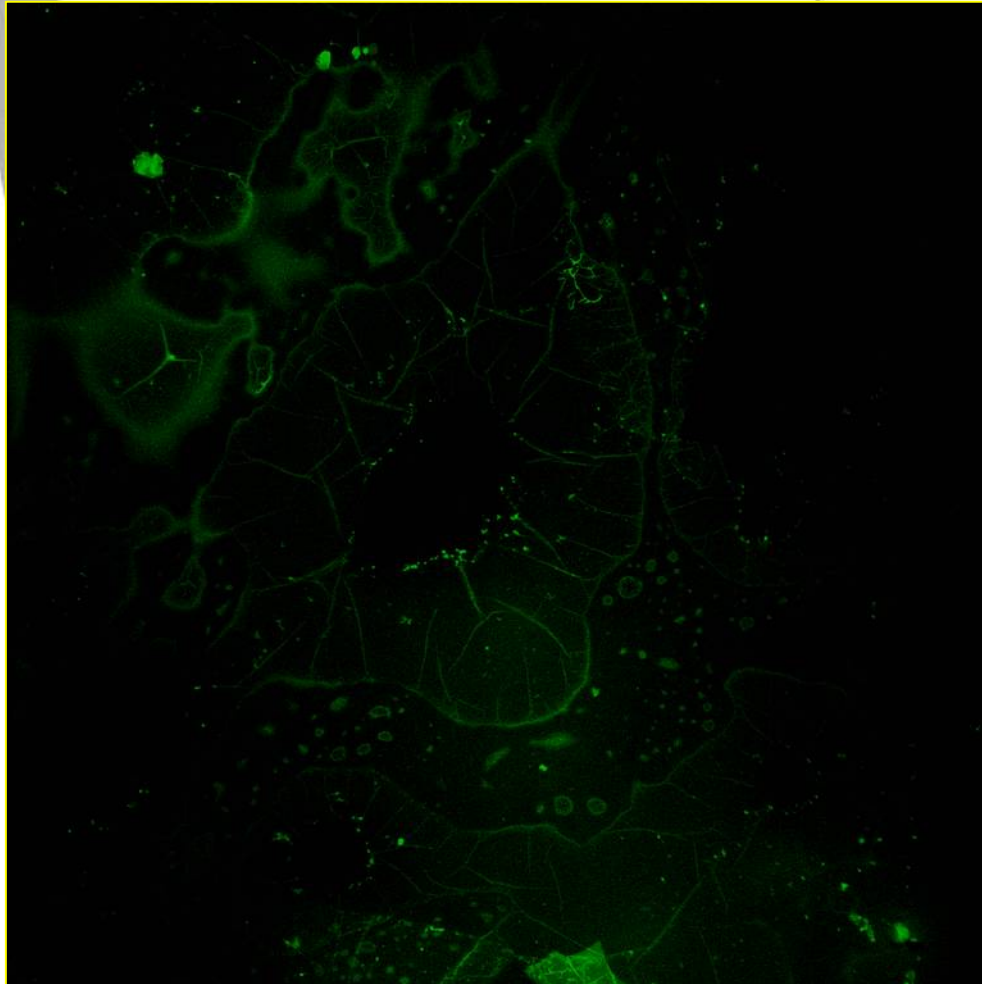
- Metalorganic precursor:  
3-aminopropyltriethoxysilane (APTS).
- Evaporation temperature: 100°C to 200°C.
- Activation temperature: 700°C to 850°C.
- Pressure: 0.6mb to 3mb.

R.J. Martín-Palma, M. Manso, J. Pérez-Rigueiro, J.P. García-Ruiz and J.M. Martínez-Duart, *Journal of Materials Research* **19**, 2415 (2004).

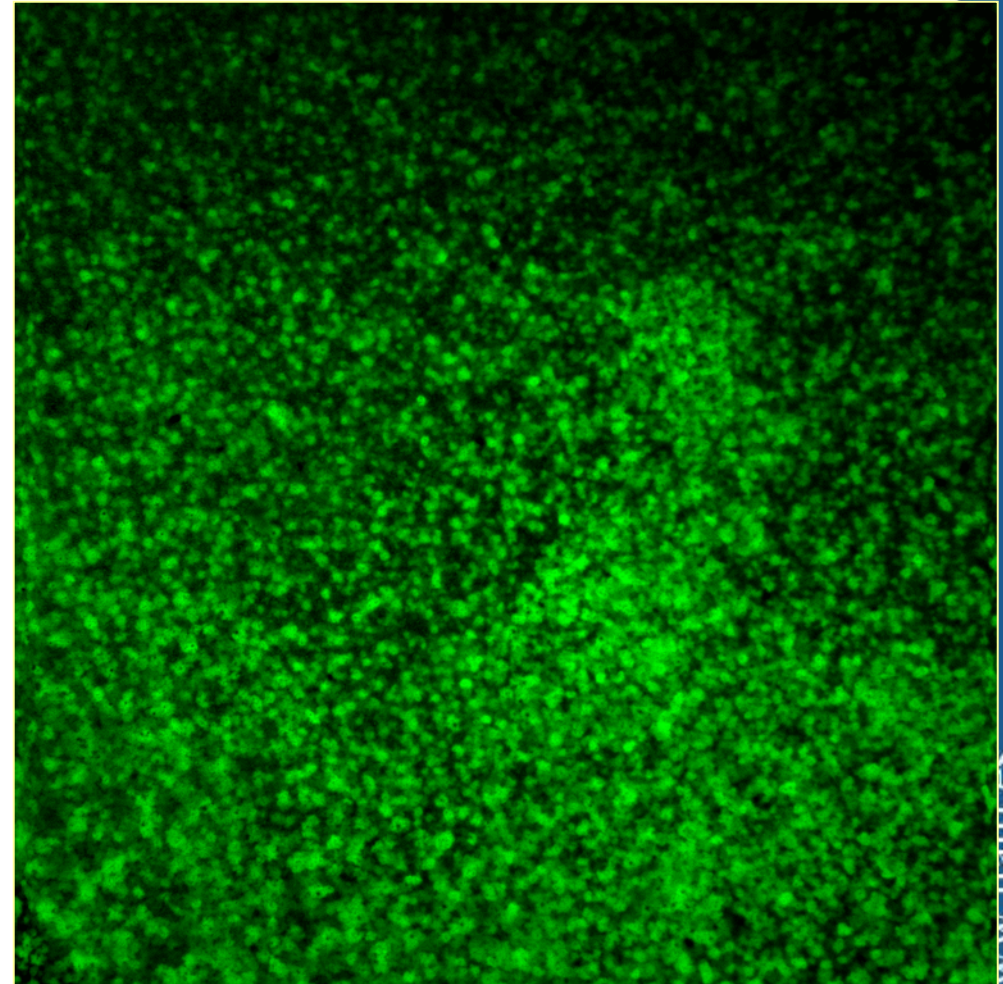


# Biocompatibility of PS: Activation of the surface

- To test functionality we use a label fluorophore (**fluoresceine isotiocianate**, FITC).
- Fluorescence is measured by confocal microscopy: pinholes keep light from just one plane.



**Silicon substrate**



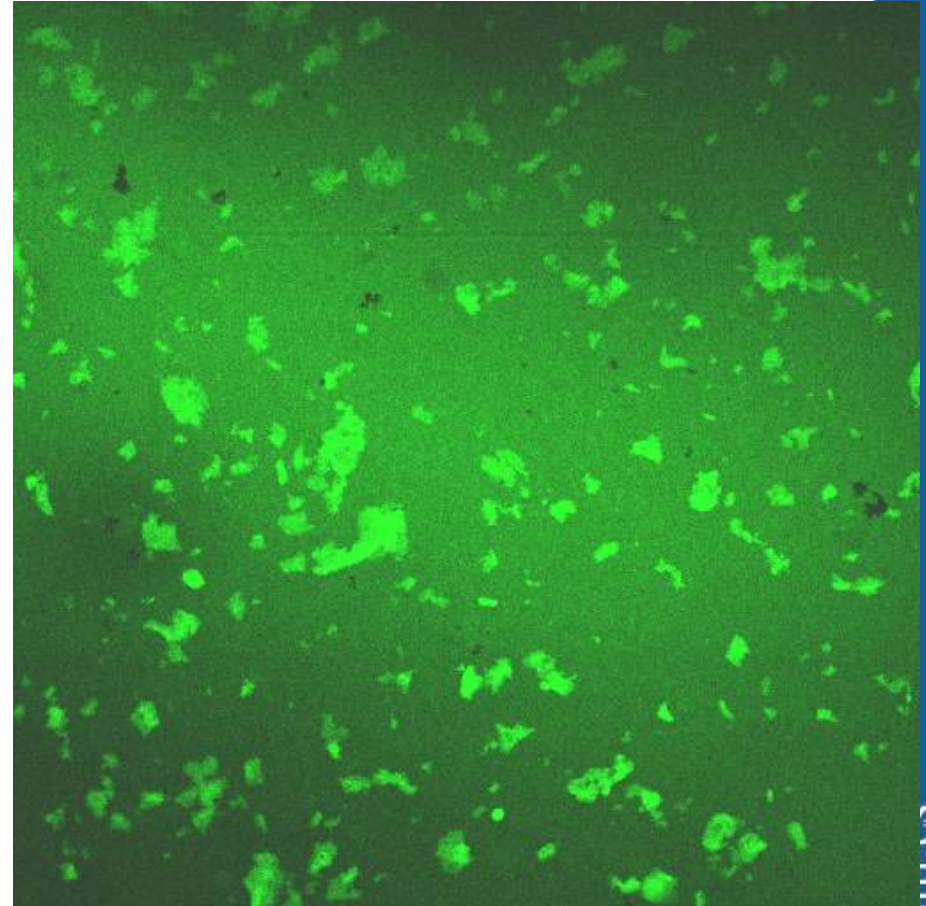
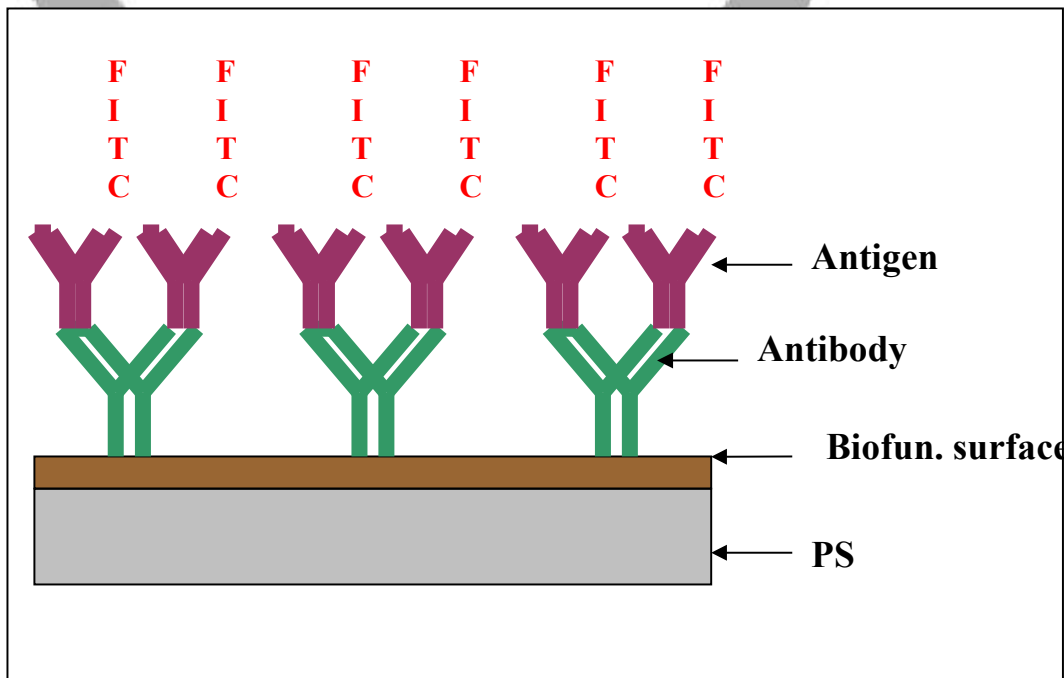
**Porous silicon substrate**

Surface  $305 \times 305 \mu\text{m}^2$

# Functionalized surfaces with antibodies immobilized

To test the functionality of immobilized biomolecules, specific **antibody-antigen reaction** was chosen. It can be used for biosensing of antigens.

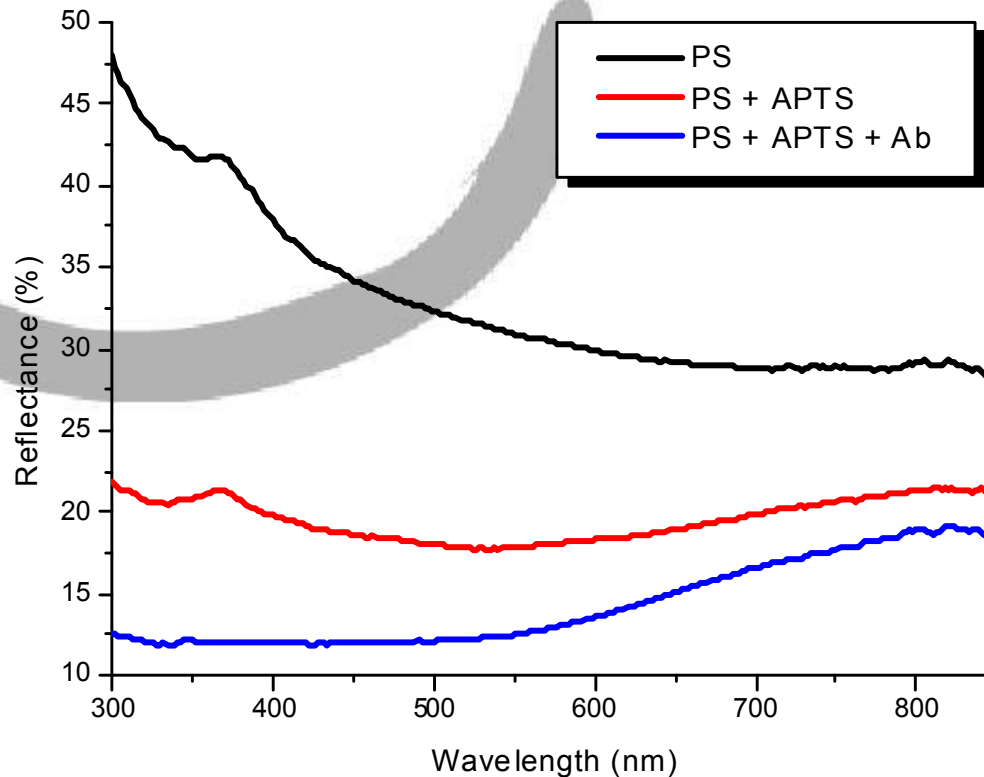
Antigens are marked with FITC that make possible its detection by confocal microscopy.



Surface 305 x 305  $\mu\text{m}^2$

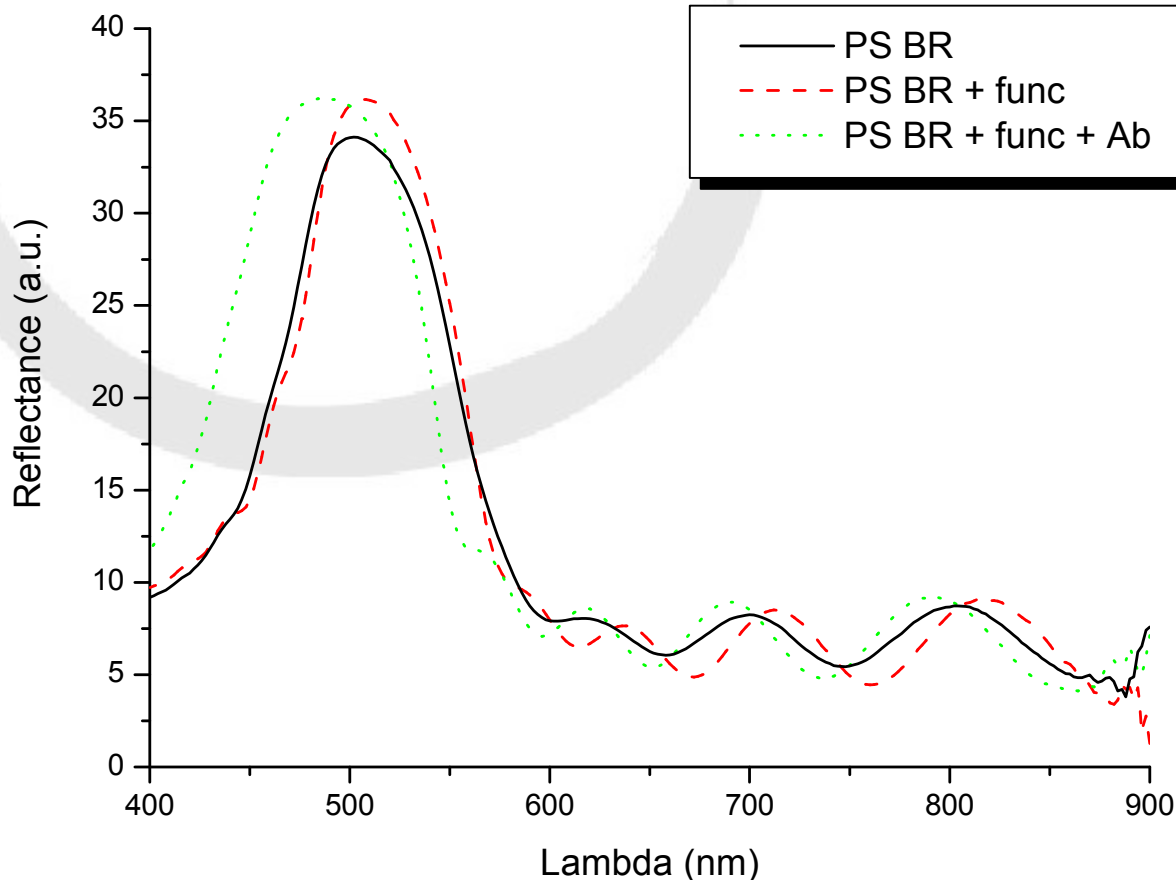
Policlonal mouse immunoglobulines were used.

# Optical biosensing: reflectance spectrum



- Notable reduction of R after the bioactivation process.
- Larger reduction after immobilization of antibodies.
- R at a given wavelength can be used for detection.

# Optical biosensing: Bragg reflectors



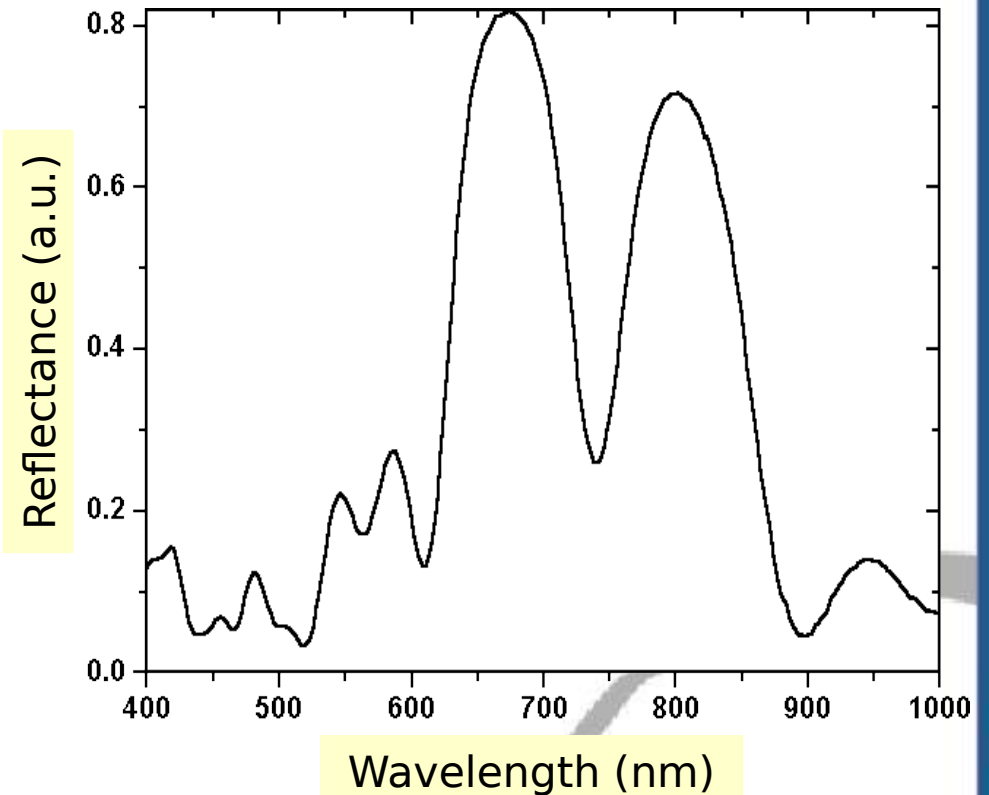
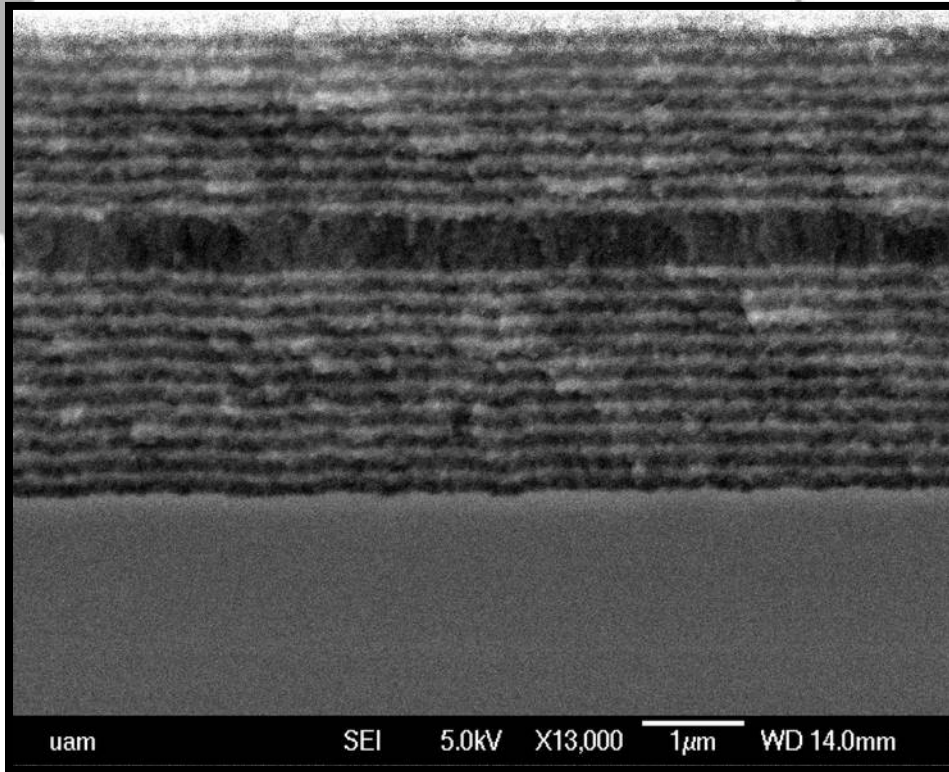
PS-based Bragg reflector:

- As formed.
- After the biofunctionalization process.
- After immobilization of polyclonal mouse antibodies.

Polyclonal mouse antibodies are detected.

It is possible to detect “any” molecule (DNA, proteins, ...) just by choosing the appropriate complementary pair.

# Optical microcavities



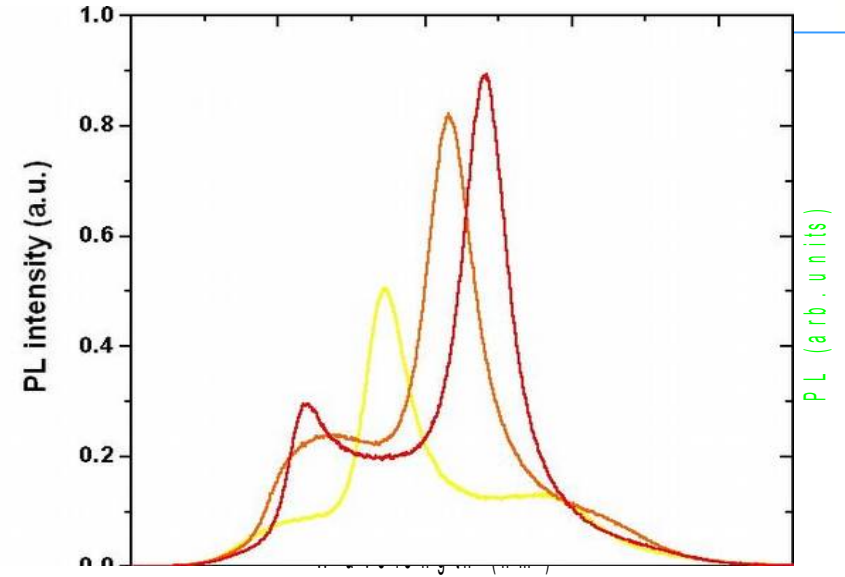
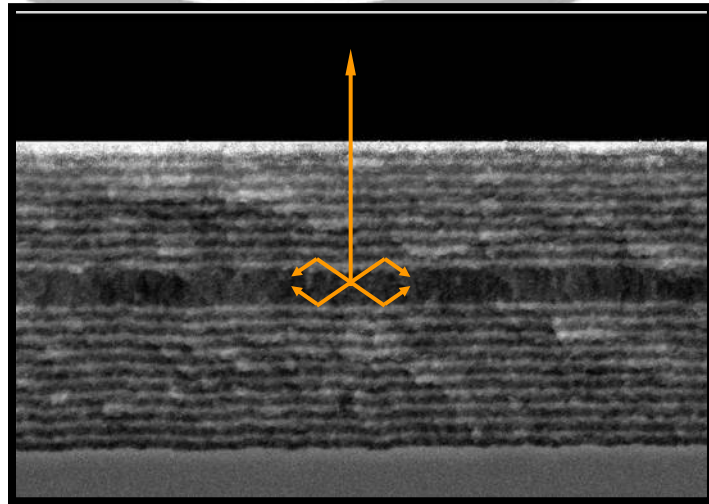
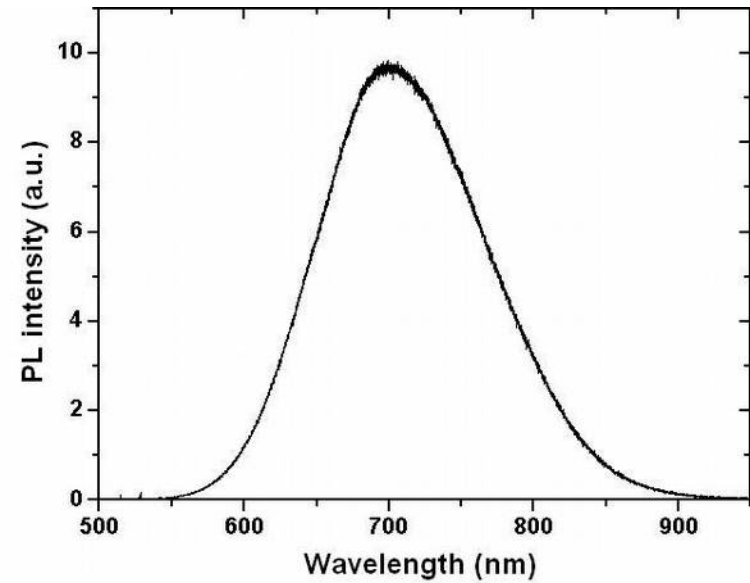
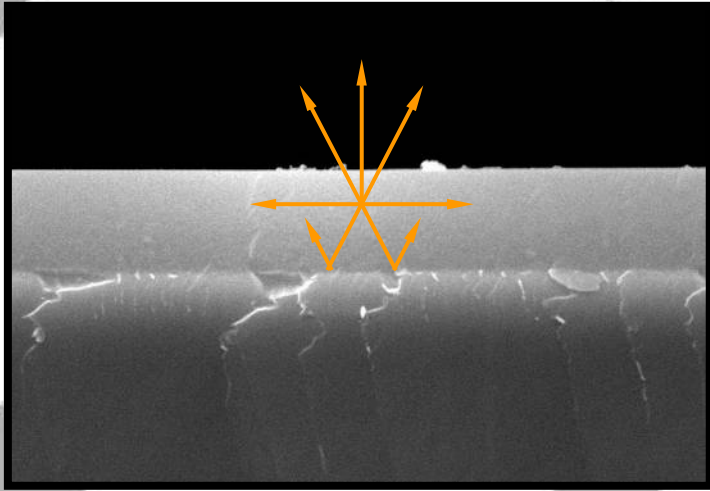
Resonant layer between Bragg reflectors

air / (AB)<sup>p</sup> B (AB)<sup>p</sup> /Si

Resonant peak at  $\lambda_0$ :

$$2n_s d_s \cos\theta_s = m\lambda_0 \quad (m = 1, 2, \dots)$$

# Filtered light emitters



V. Torres-Costa, F. Agulló-Rueda, R.J. Martín-Palma and J.M. Martínez-Duart, *Optical Materials* 27, 1084 (2005).

PS optical microcavities can be used to filter PS luminescent emission, leading to monochromatic light emitters.

# PS-based solar cells

## Advantages of using PS:

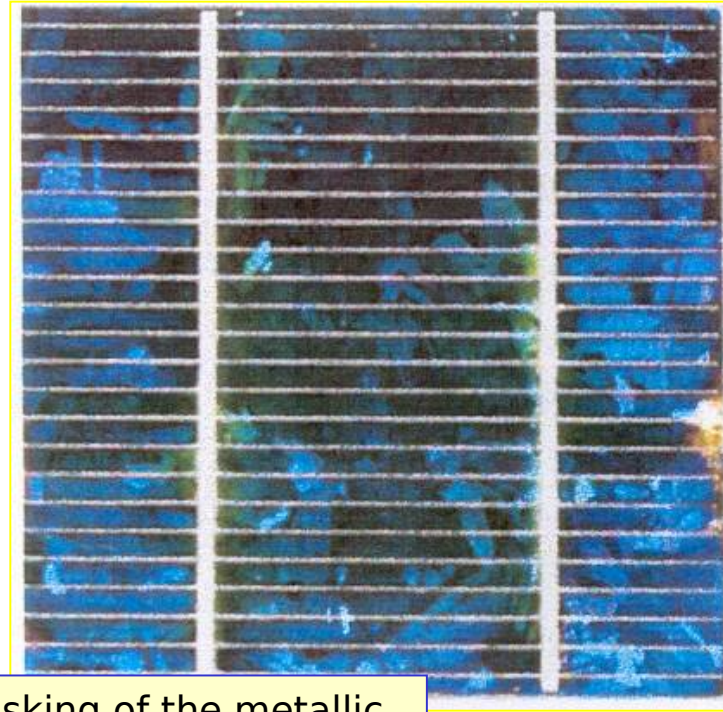
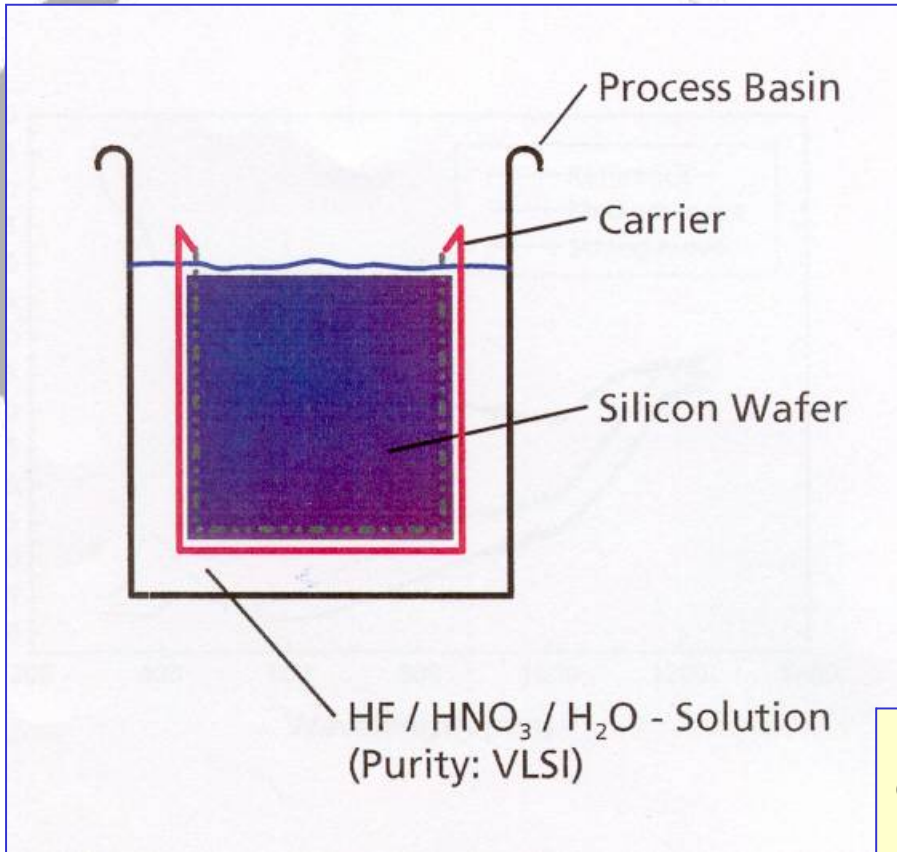
- The highly textured morphology of PS can be used to enhance light trapping → Reduction of  $R$  in the visible/NIR range
- Cheap process

## Drawbacks:

- Electrical contacts to PS (highly resistive material)
- Long-term stability

# Fabrication

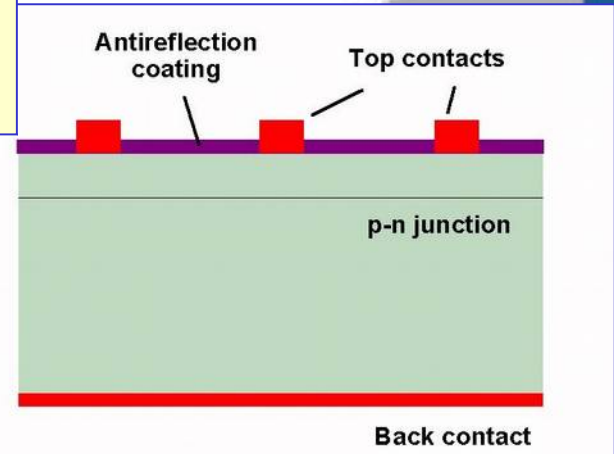
Surface: 50×50 mm<sup>2</sup>.



Masking of the metallic contacts is not necessary during the formation of PS.

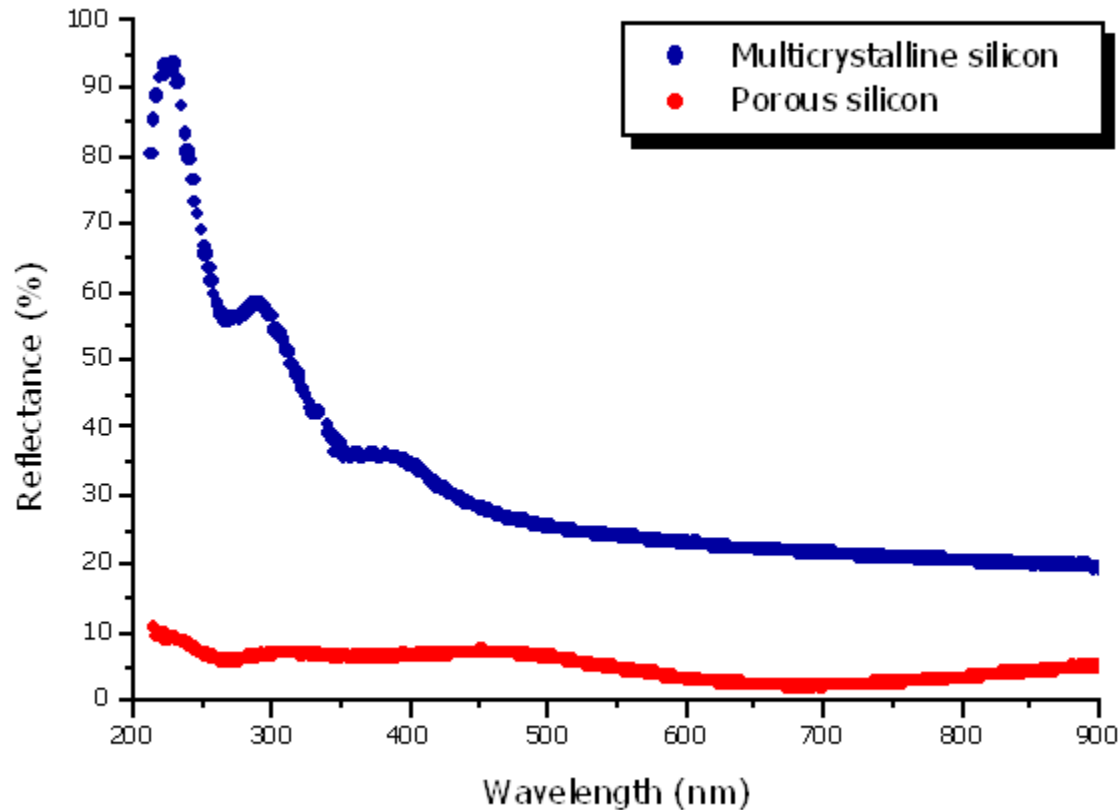
- PS formed by chemically etching ready-made industrial solar cells (emitter of the n<sup>+</sup>/p junctions), after the deposition of the front and back contacts.
- HF/HNO<sub>3</sub>-based solution.
- No protection of contacts.

Simple and inexpensive PS formation process.



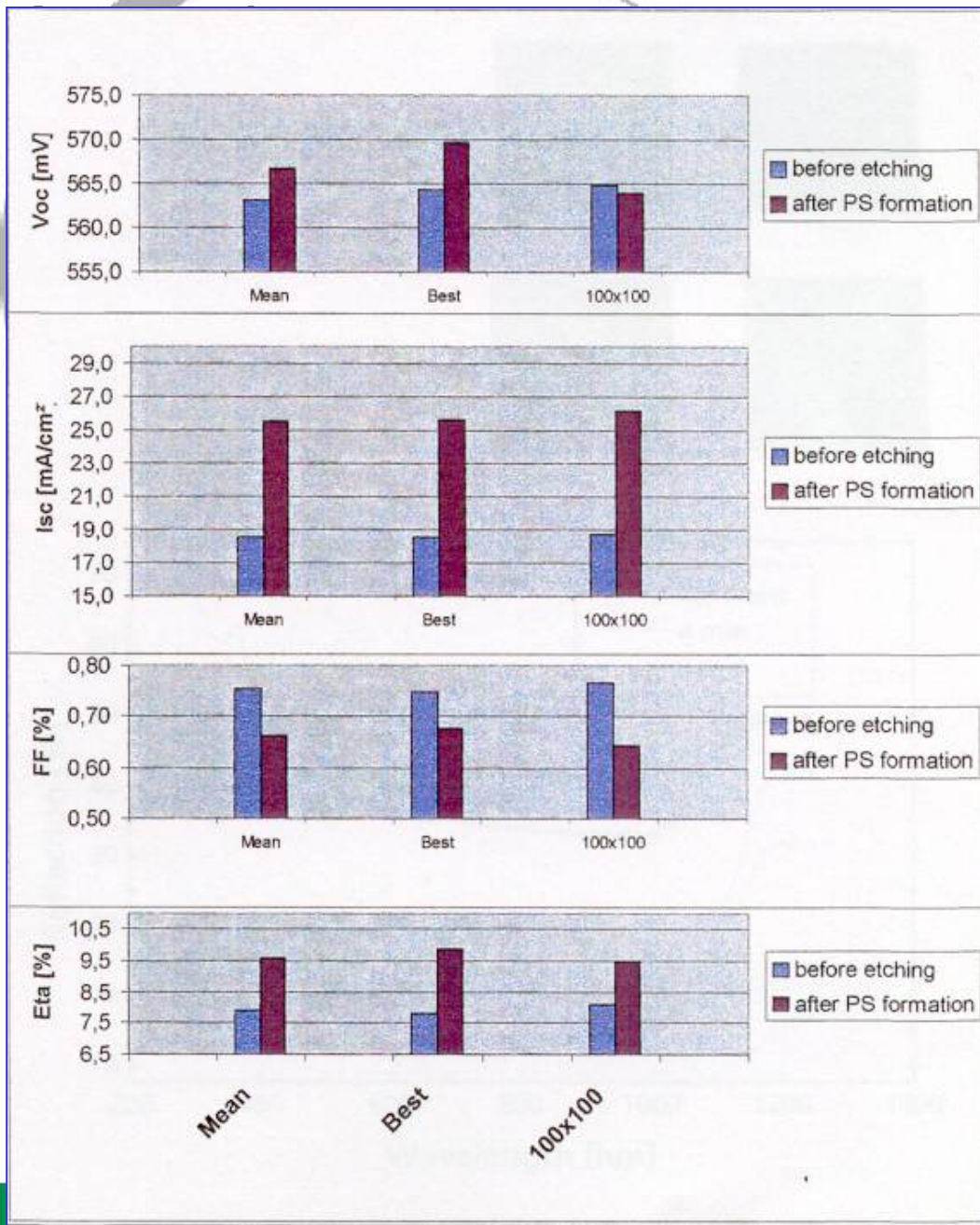


# Optical properties

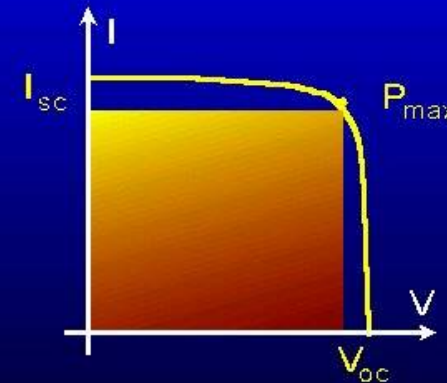


Average reflectance:  
26.8 % (Multicrystalline  
silicon) → 5.0 % (PS,  
stain etched)

# Characteristic solar cell parameters before/after PS



The I-V characteristic of a solar cell with the maximum power point

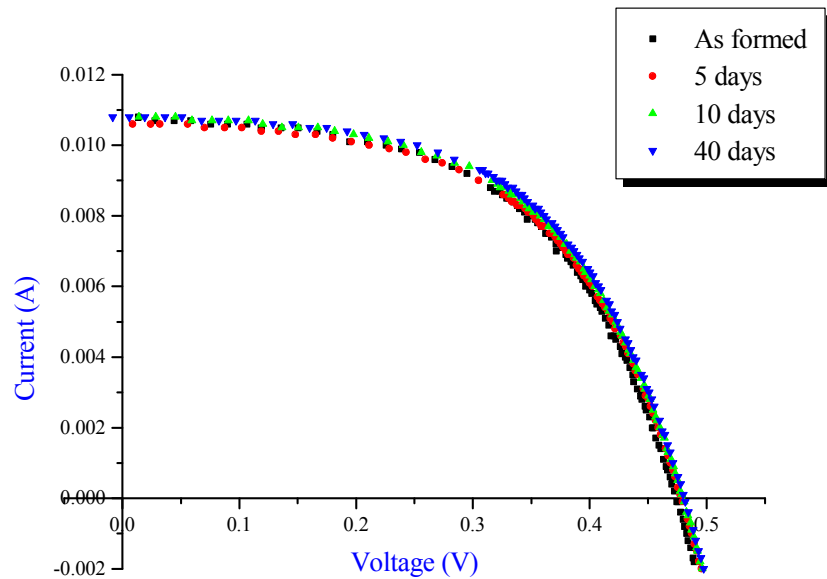


$$FF = \frac{V_{oc} - \ln(V_{oc} + 0.72)}{V_{oc} + 1} \quad \eta = \frac{P_{out}^{max}}{P_{in}}$$

The overall effect of PS formation on the solar cells is a notable rise of the efficiency from about 7.5 % to around 9.6 %.

R.J. Martín-Palma, L. Vázquez, J.M. Martínez-Duart, M. Schnell and S. Schaefer, *Semiconductor Science and Technology* **16**, 657 (2001).

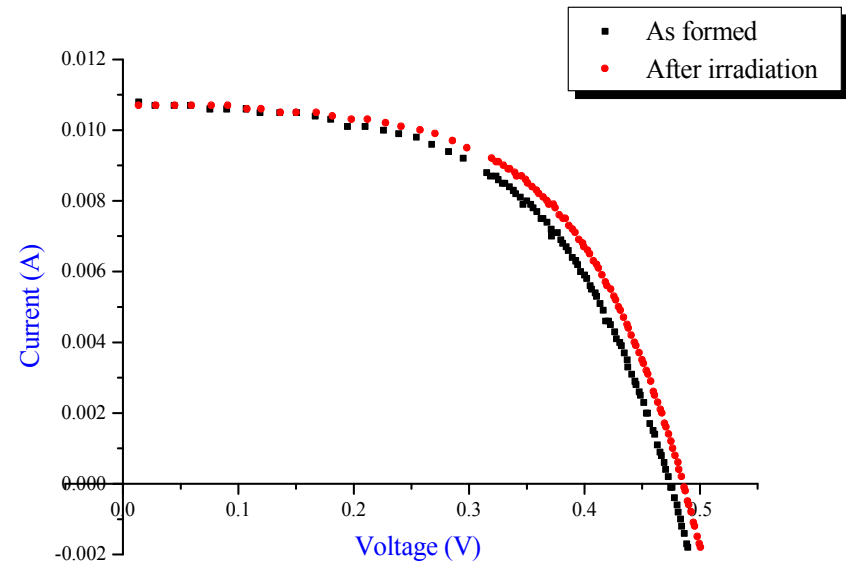
# Effect of extended exposure to the atmosphere and long periods of irradiation on the I-V characteristics



In both cases:

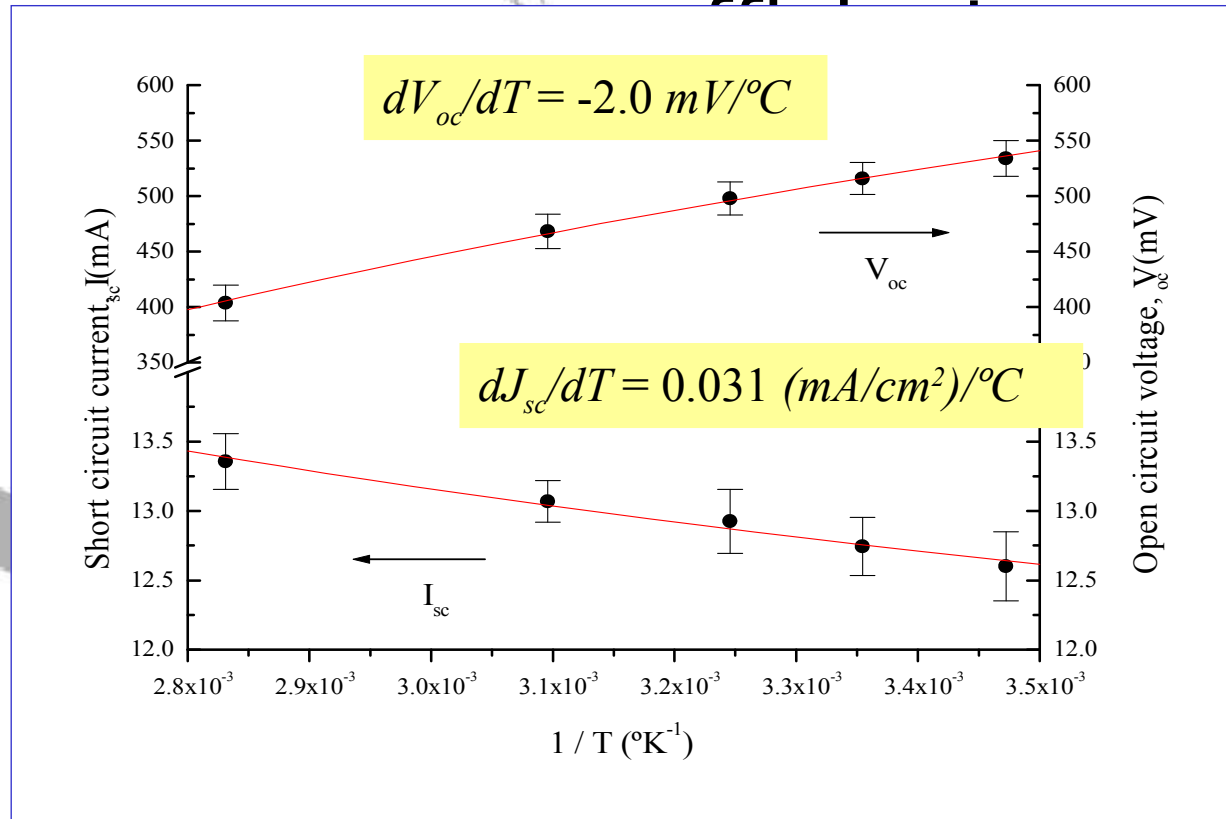
→  $I_{sc}$  remains almost constant.

→ Slight increase of  $V_{oc}$ .



R.J. Martín-Palma, R. Guerrero-Lemus, J.D. Moreno, J.M. Martínez-Duart, A. Gras and D. Levy, *Materials Science & Engineering B* **69**, 87 (2000).

# Electrical characterization: temperature



R.J. Martín-Palma, R. Guerrero-Lemus, J.D. Moreno, J.M. Martínez-Duart, A.Gras and D. Levy, *Materials Science & Engineering B* **69**, 87 (2000).

- The variation of  $I_{sc}$  and  $V_{oc}$  vs.  $T$  (10 °C to 80 °C) was determined.
- $I_{sc}$  rises with  $T$  (0.011 mA/K) → Increment of  $L_{dif}$  for minority carriers.
- $V_{oc}$  decreases with  $T$  (-2 mV/K) →  $I_o \propto T$ .
- Temperature coefficients close to that of standard Si solar cells → PS is not degrading the electrical behavior at different  $T$  of the solar cells.

# NANOSAT program

## Una nueva filosofía en proyectos espaciales

Promover líneas de Investigación y Desarrollo en el área de las Nanotecnologías en el INTA y en las otras Instituciones participantes.

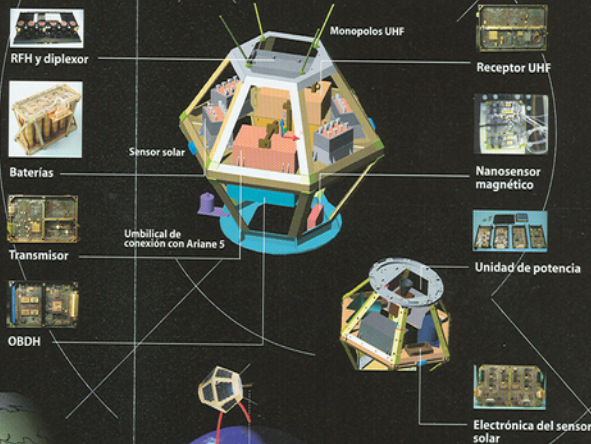
Desarrollar un sistema de comunicaciones en diferido para enlazar estaciones científicas remotas, como la Base Antártica Española y otras ubicaciones, para la centralización de los datos y la tele-operación de los equipos.

Calificar una pequeña plataforma para la demostración en órbita de nuevos sensores, componentes comerciales y nuevas tecnologías como las comunicaciones ópticas intra-satélite.



Estaciones INTA

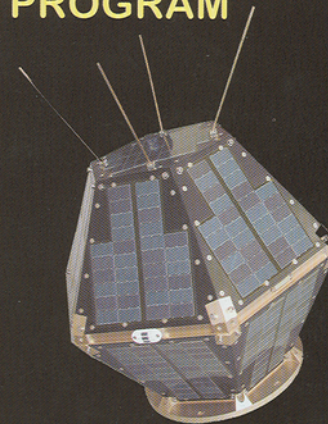
### CONFIGURACION NANOSAT STM



### Orbita:

Tipo: Polar heliosincrona  
 Altura: 645 km  
 Inclinación: 97,97°  
 Periodo: 97,6 min.  
 Orbitas/días: 14,75  
 Separación entre órbitas: 24,4°  
 Periodo de repetición: 4 días

## NANOSAT PROGRAM



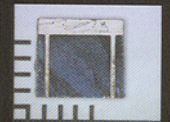
## PROGRAMA NANOSAT

### TECHNOLOGIES

### TECNOLOGÍAS

#### NANO SUNSENSOR

Based on porous silicon cell.



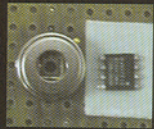
**NANOSENSOR SOLAR**  
 Basado en una célula de silicio poroso.

#### NANO MAGNETIC SENSOR

Based on Faraday Effect or polarization plane rotation when light crosses a material with magnetic nanoparticles.

#### NANOSENSOR MAGNÉTICO

Basado en el efecto Faraday o rotación del plano de polarización de la luz al atravesar un material con nanopartículas magnéticas.

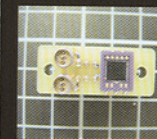


#### OPTICAL WIRELESS COMMUNICATIONS

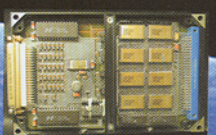
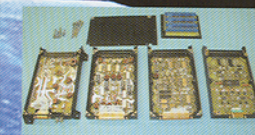
Aimed at remove data cables and connectors inside the satellite.

#### COMUNICACIONES ÓPTICAS

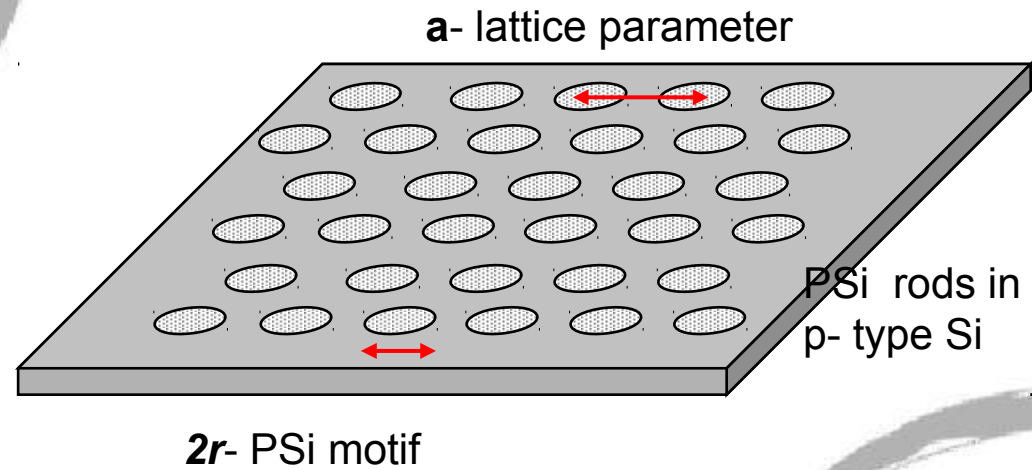
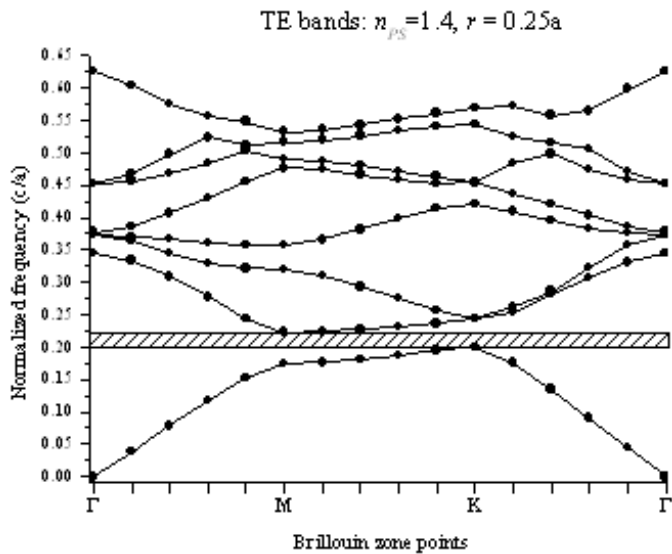
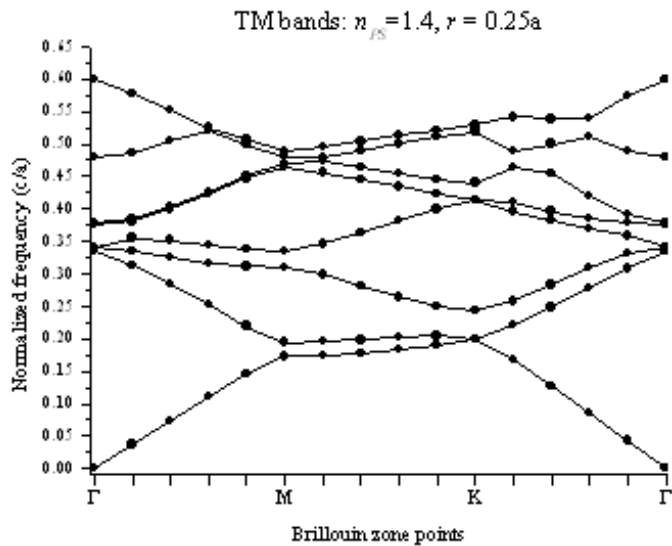
Para sustituir los mazos de cables de transmisión de datos en el interior del satélite.



#### MODULAR DESIGN OF ELECTRONIC UNITS DISEÑO MODULAR DE LAS UNIDADES ELECTRÓNICAS

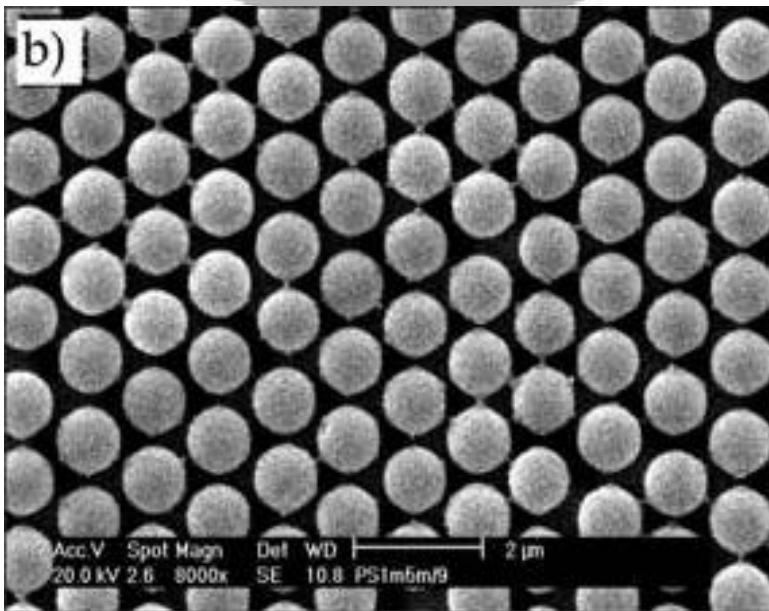
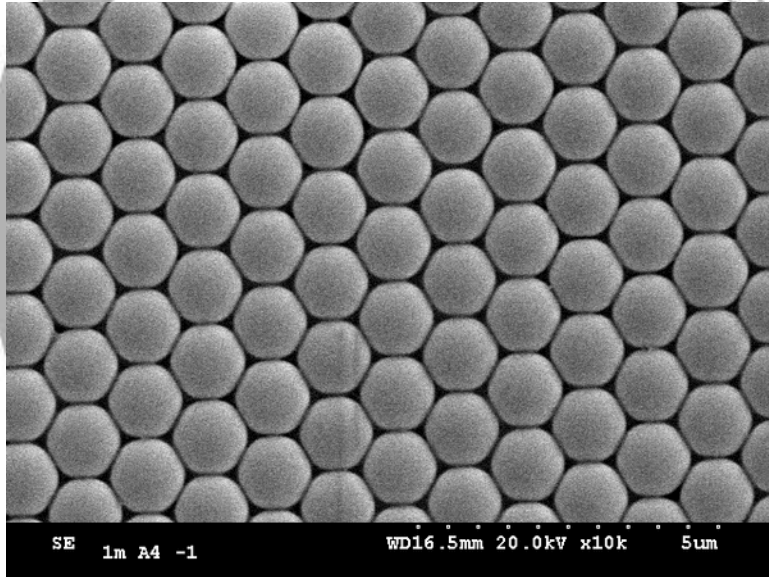


# Photonic crystals



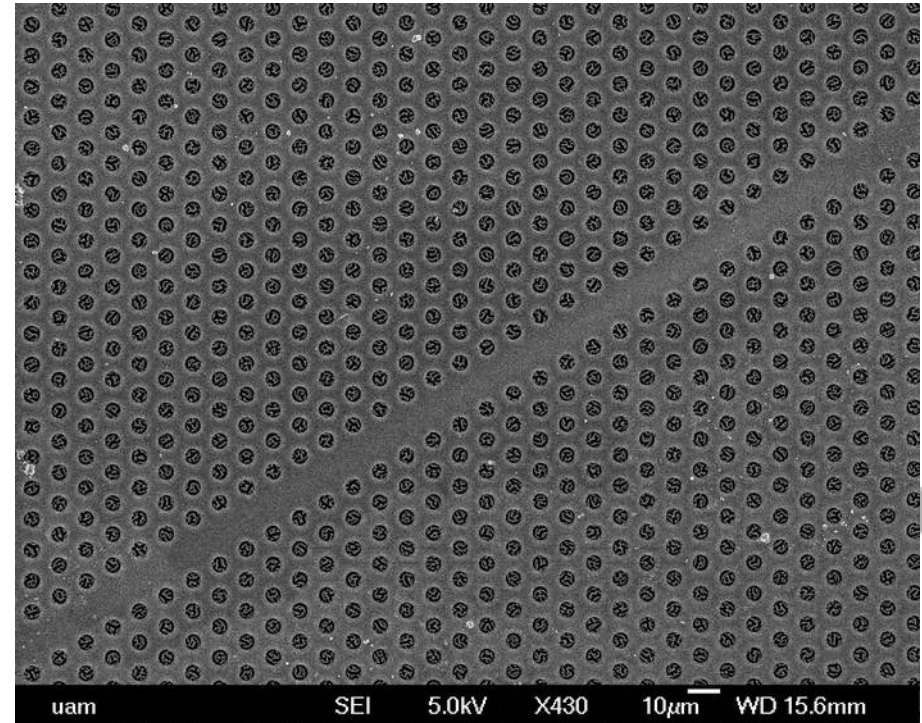
R.J. Martín-Palma, M. Manso, M. Arroyo-Hernández, V. Torres-Costa and J.M. Martínez-Duart, *Applied Physics Letters* **89**, 053126 (2006).

## Colloidal lithography



# Photonic crystals

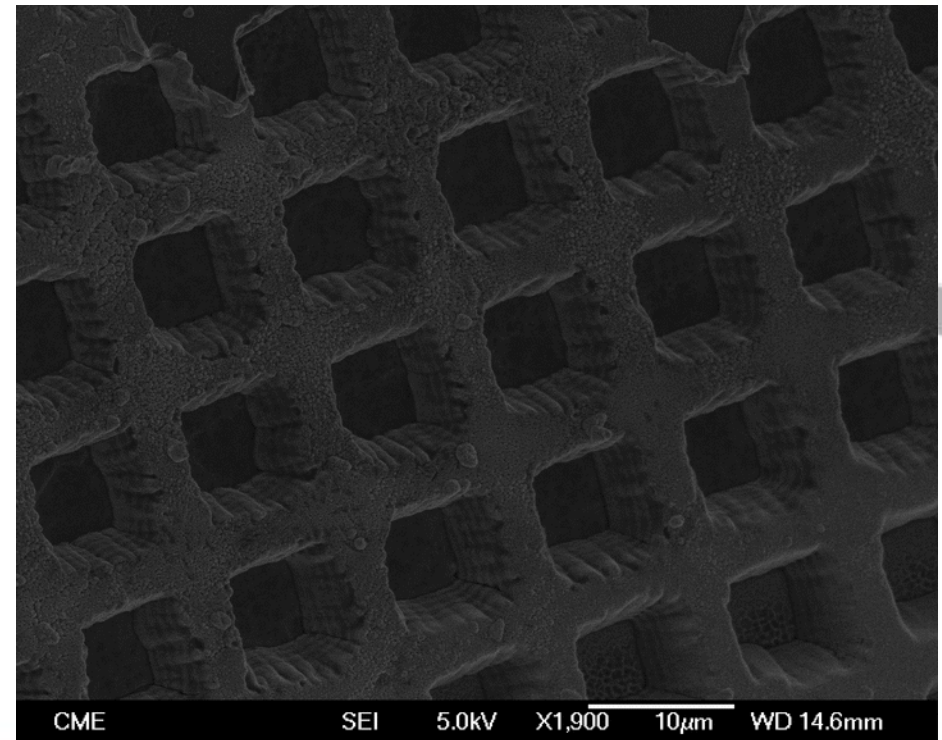
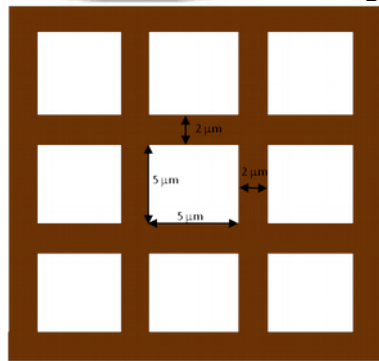
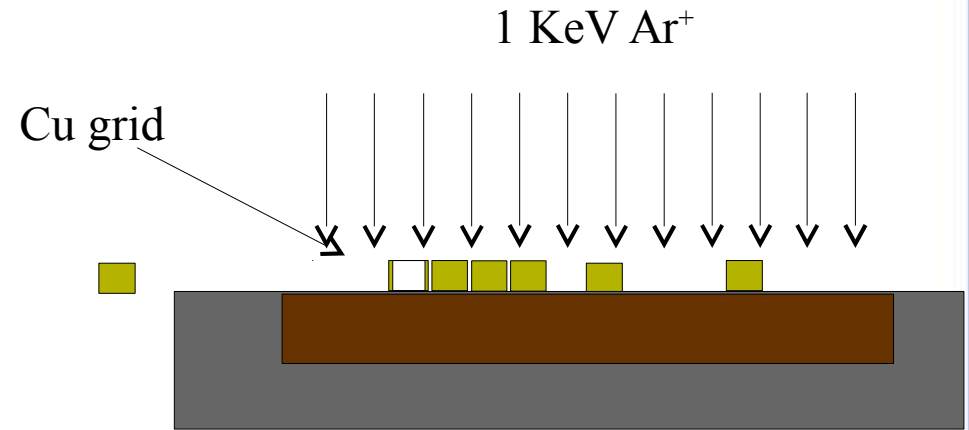
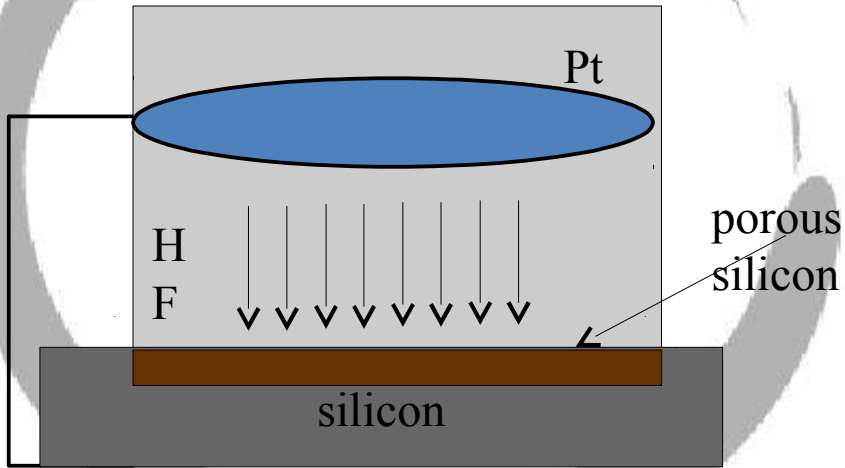
## Traditional lithography



R.J. Martín-Palma, V. Torres-Costa, M. Manso, and J.M. Martínez-Duart, *Journal of Nanophotonics* **3**, 031504 (2009).

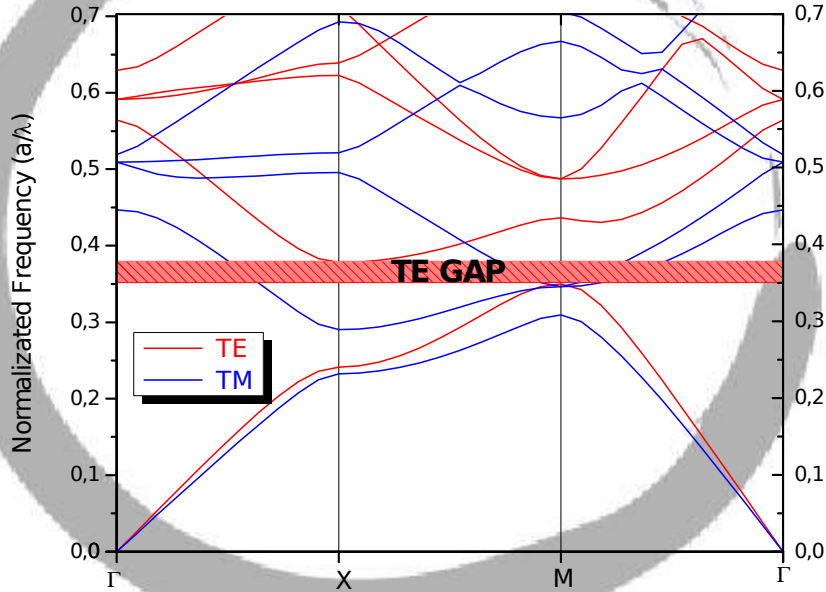
M. Manso Silvan, M. Arroyo Hernandez, V. Torres Costa, R.J. Martín Palma, J.M. Martínez Duart, *Europhysics Letters* **76**, 690 (2006).

# Photonic crystals (cont'd)

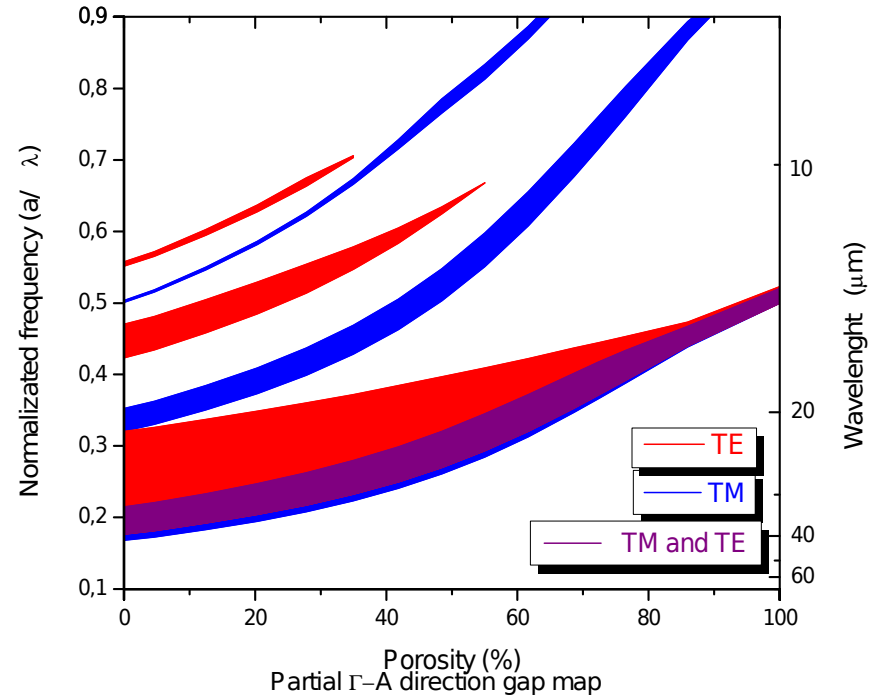




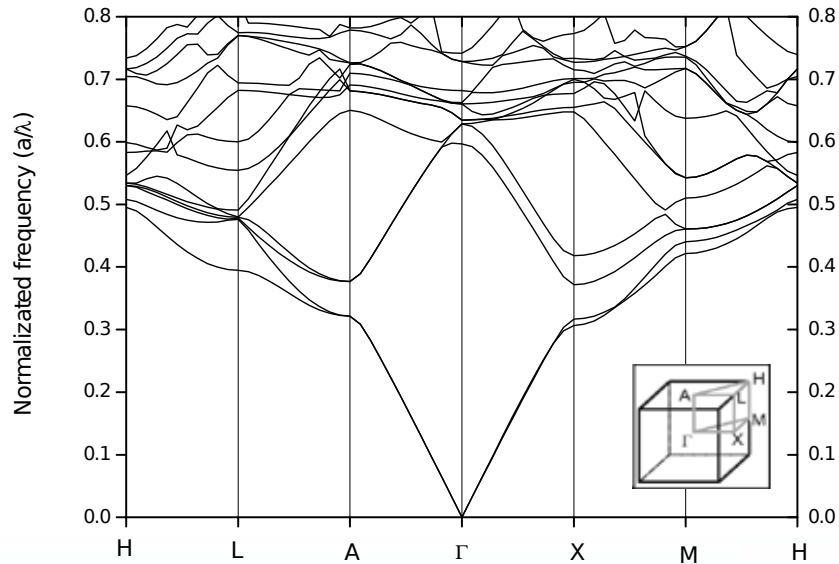
### 2D PHOTONIC BAND STRUCTURE



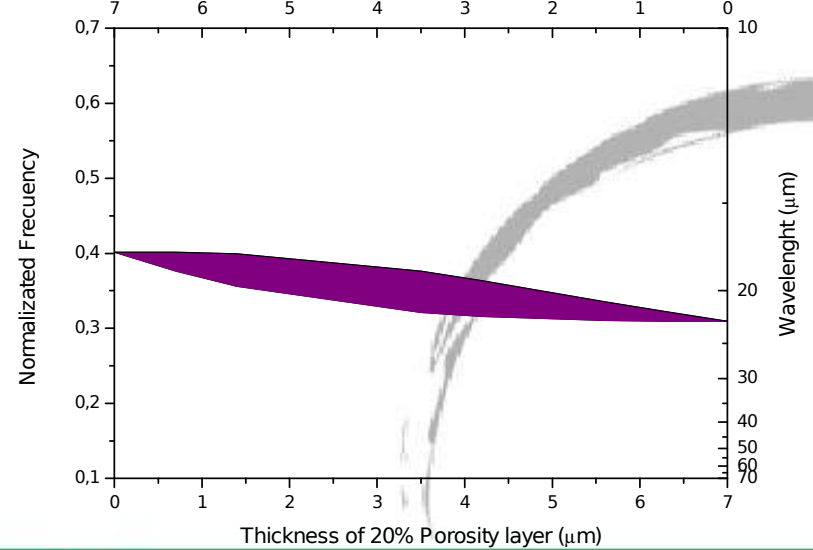
### Partial $\Gamma$ -X gap map



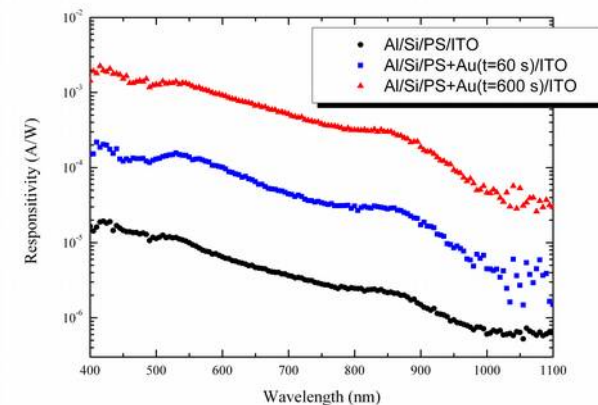
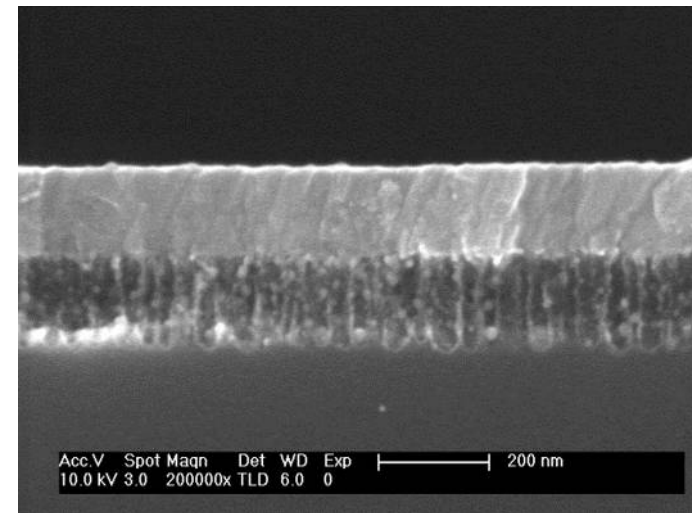
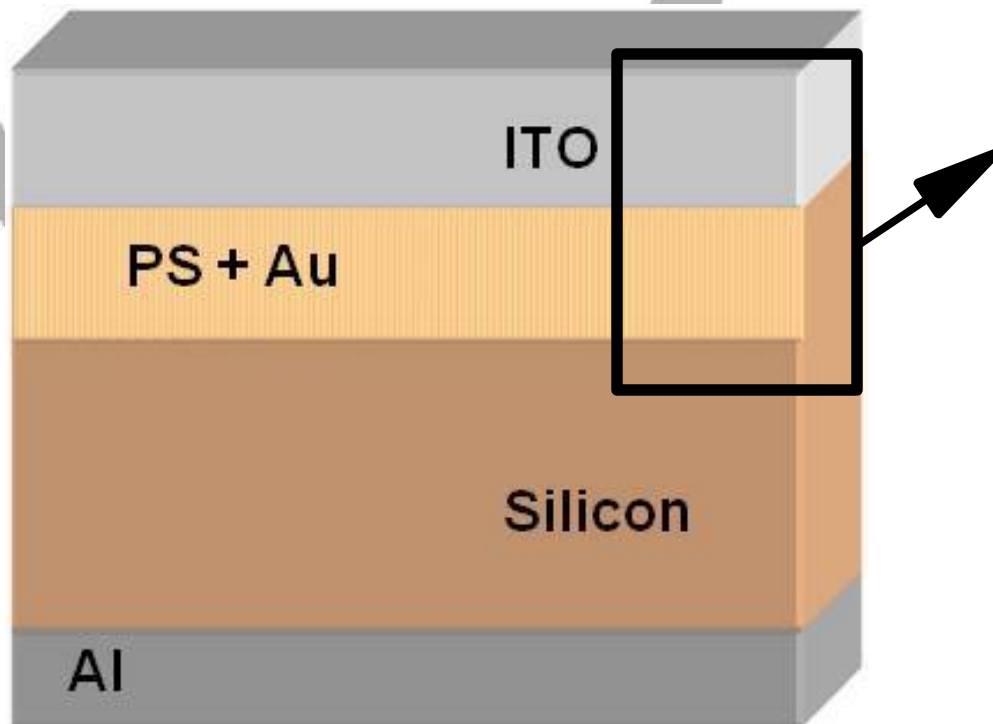
### 3D PHOTONIC BANDS STRUCTURE



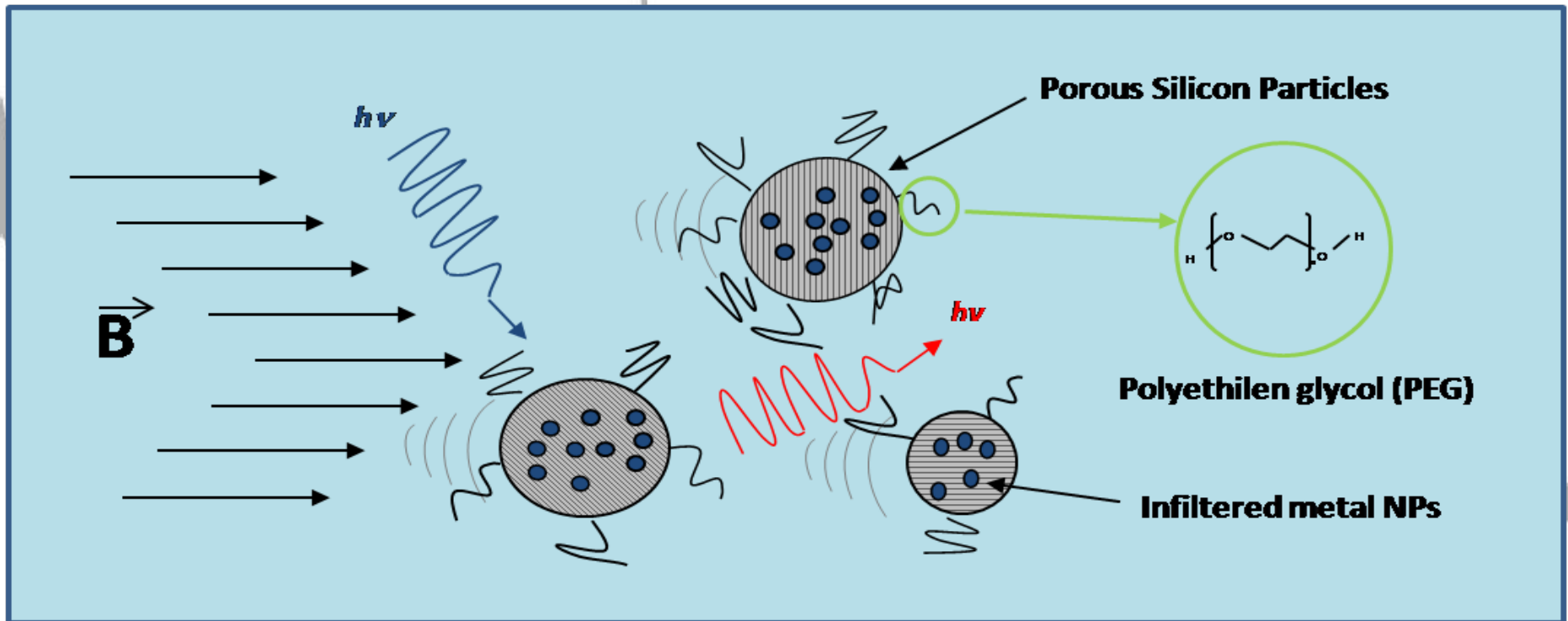
### Thickness of 80% Porosity layer ( $\mu\text{m}$ )



# Hybrid gold/porous Si thin films for plasmonic solar cells

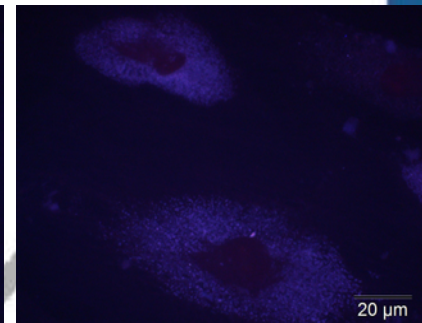
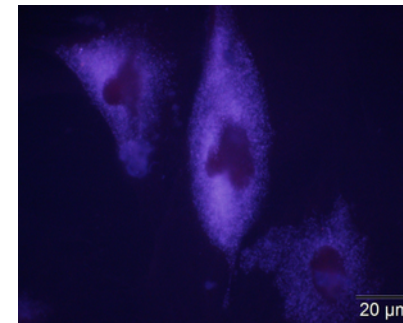
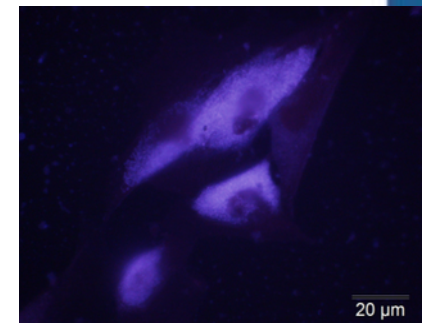
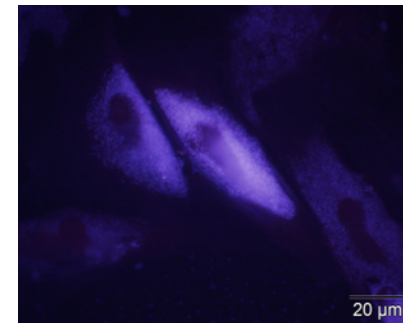
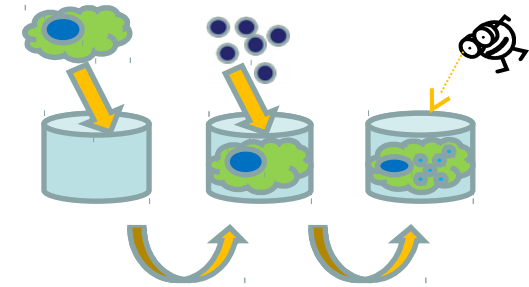
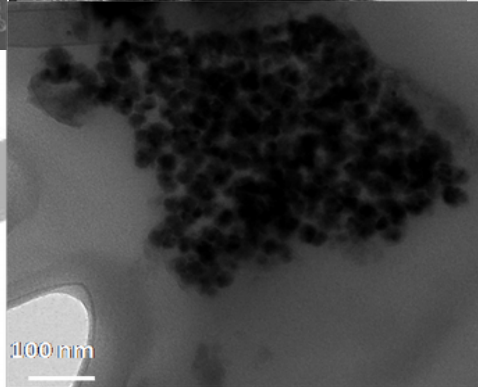
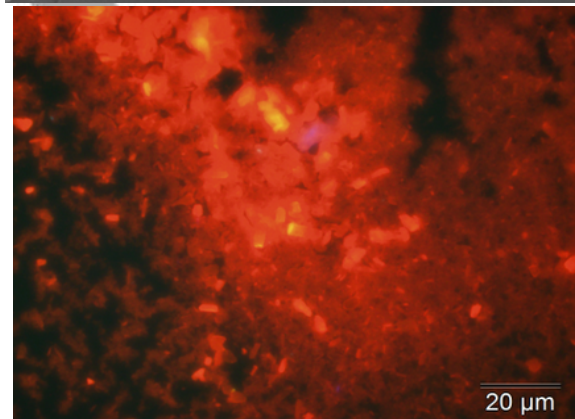
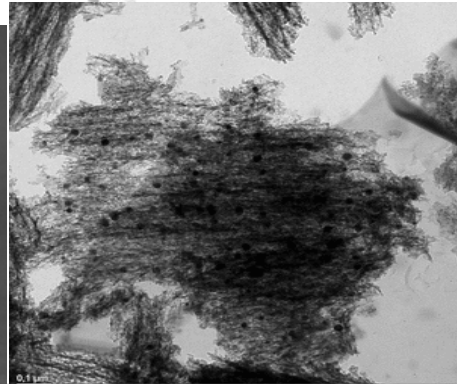
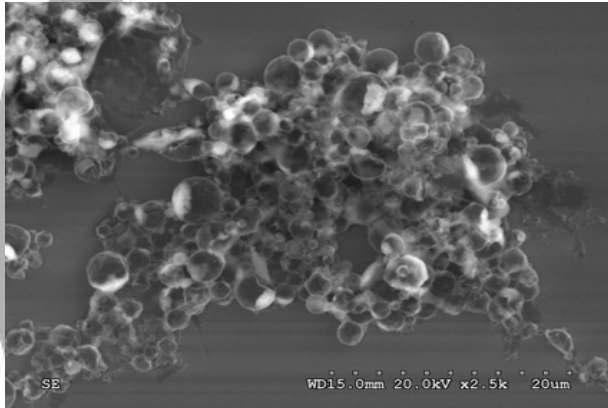


# Biomedical applications: nanoPS-based multifunctional particles



- A porous  $\text{SiO}_2$  matrix hosts Si nanocrystals and metal NPs.
- Luminescent + magnetic + biocompatible.

# NanoPS-based multifunctional particles in action

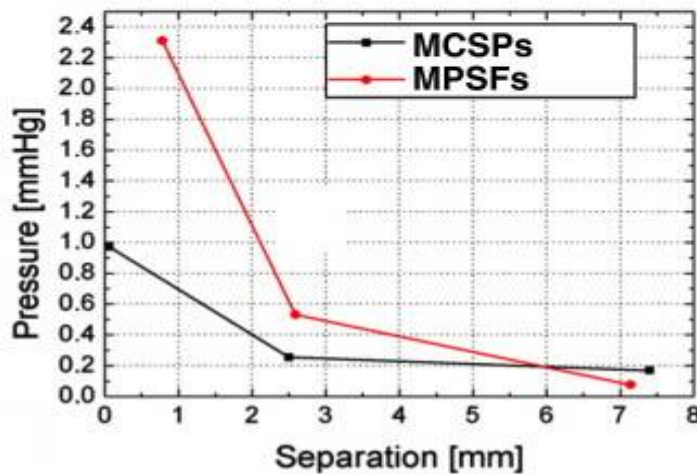
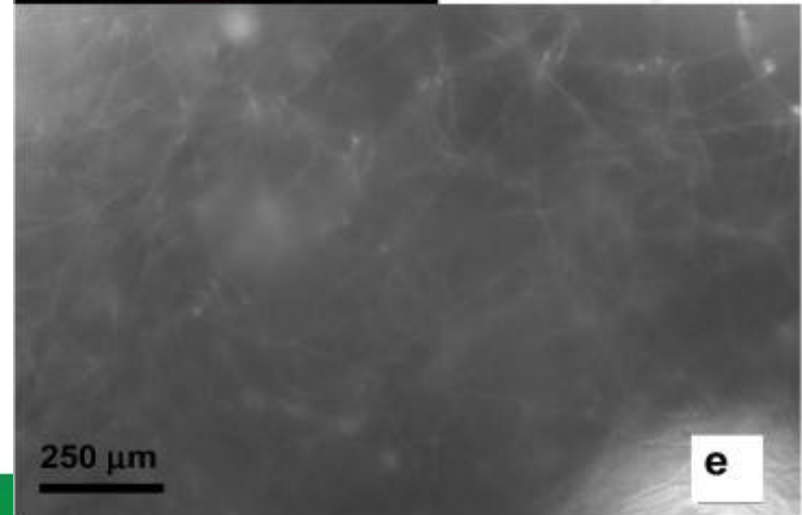
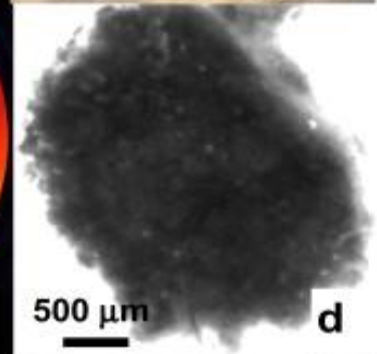
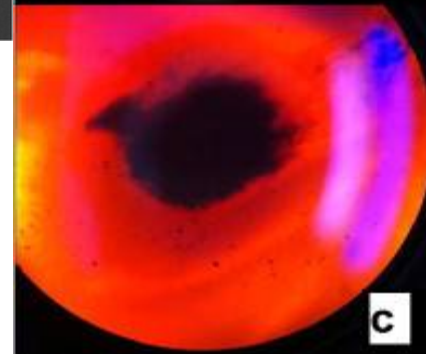
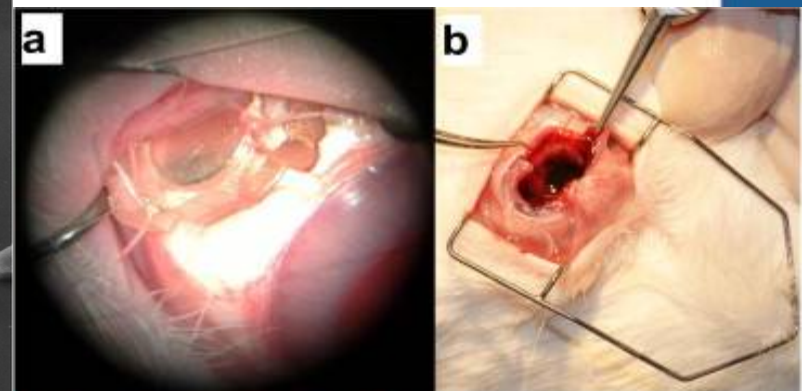
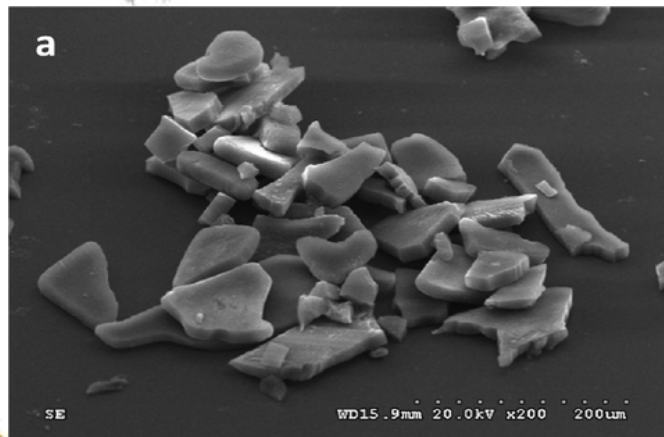
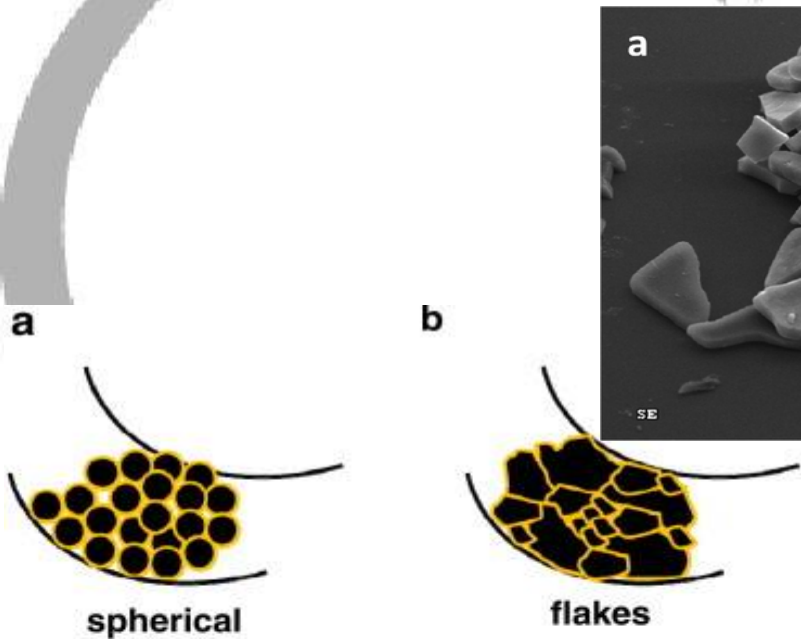


- The blue emission of the nanoPS particles allowed tracking the cellular cytosol of hMSCs.
- Studies of proliferation up to 72h showed no apoptosis response in the cells.



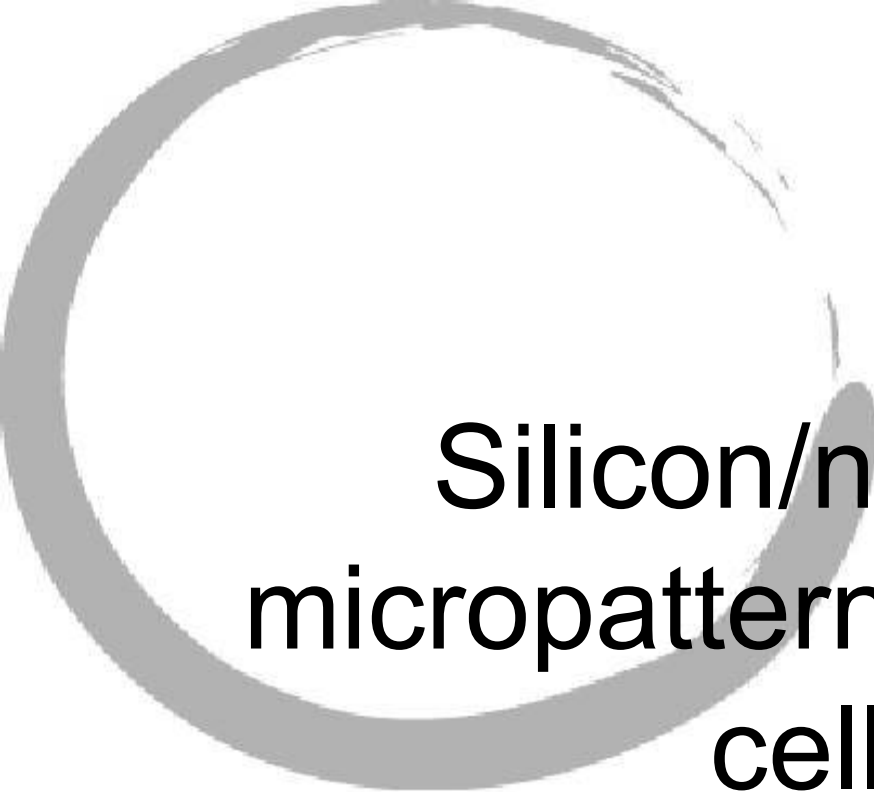
**Potential applications:**  
Cellular & molecular imaging, cell labeling & tracking, diagnosis, targeted delivery of therapeutic compounds, magnetic resonance imaging contrast agents, probes & sensors, ...

# Magnetic PS flakes as retina pressure actuators



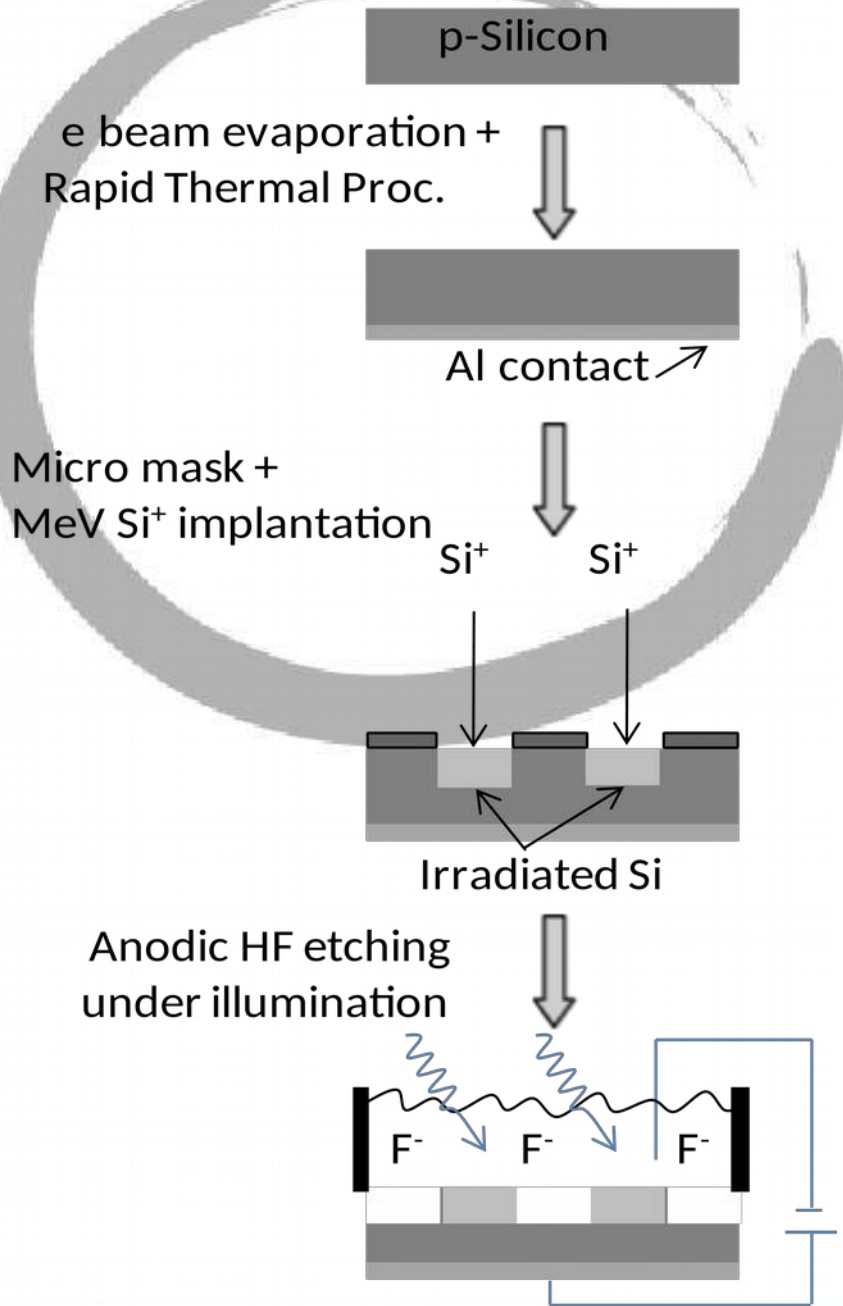
Low inflammatory response and no necrosis effects

Images after 1 month post mortem inspection of rabbits: (a) area of the sclera after explanation of the permanent magnet; (b) Eye dissection for extraction of the MPSF agglomerate from the eye wall; (c) in situ retinal tissue with attached MPSF; (d) explanted MPSF; (e) magnification from (d).

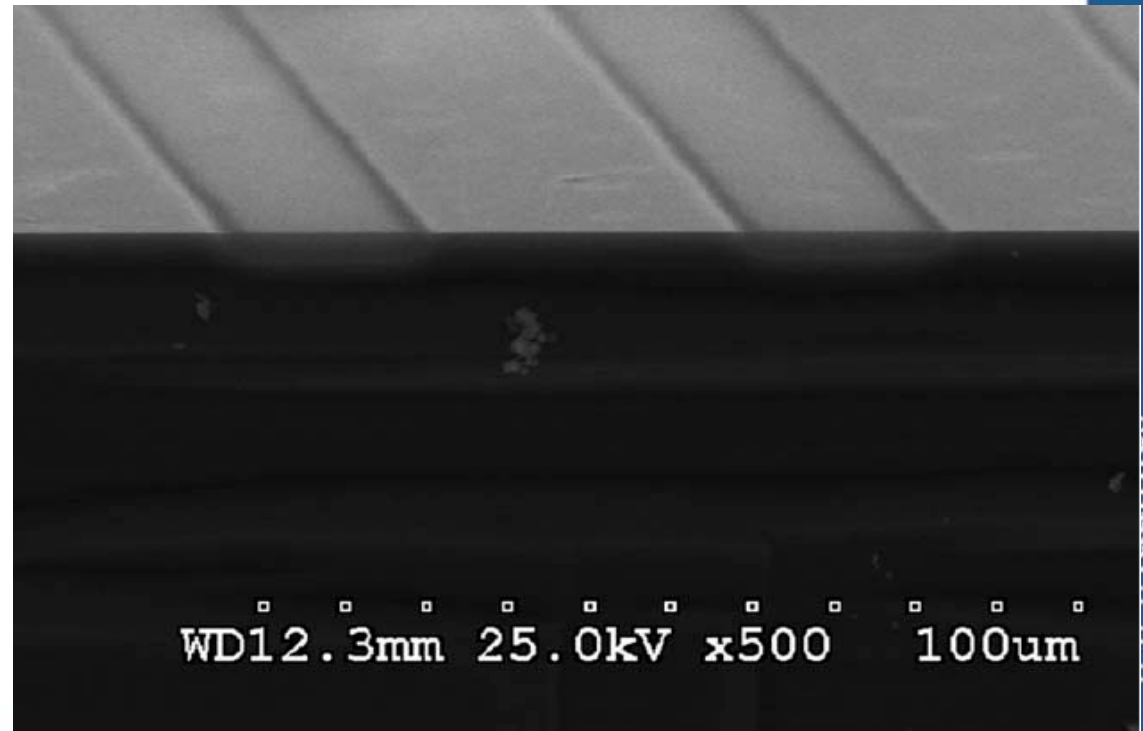


# Silicon/nanoPS surface micropatterns for the control of cell behavior

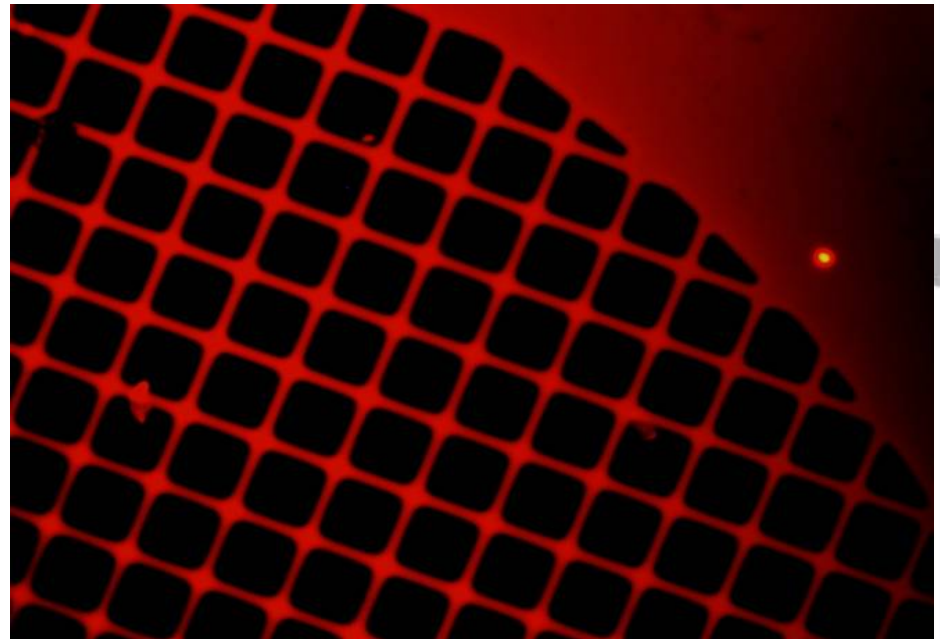
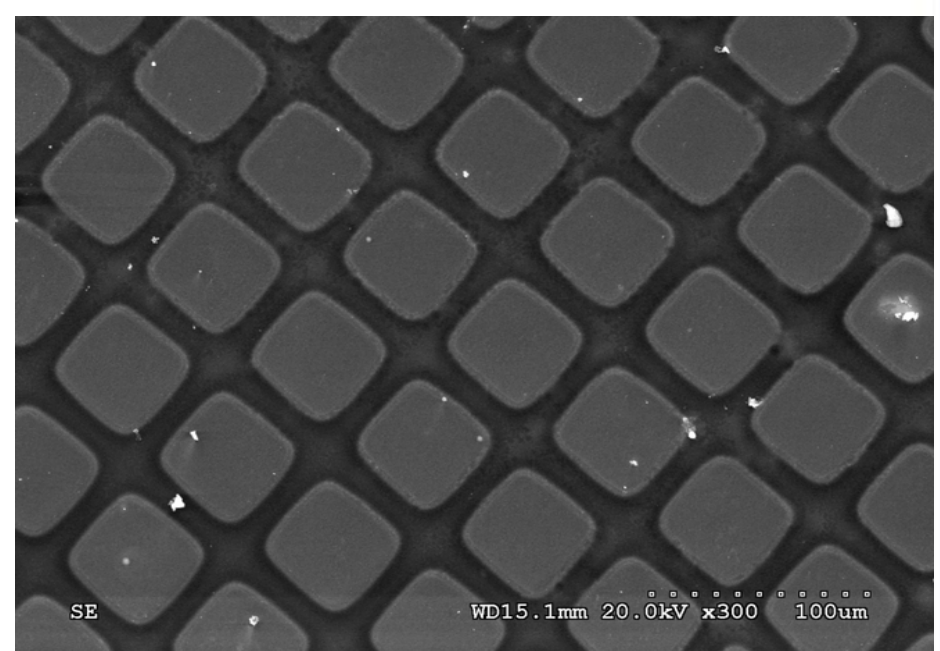
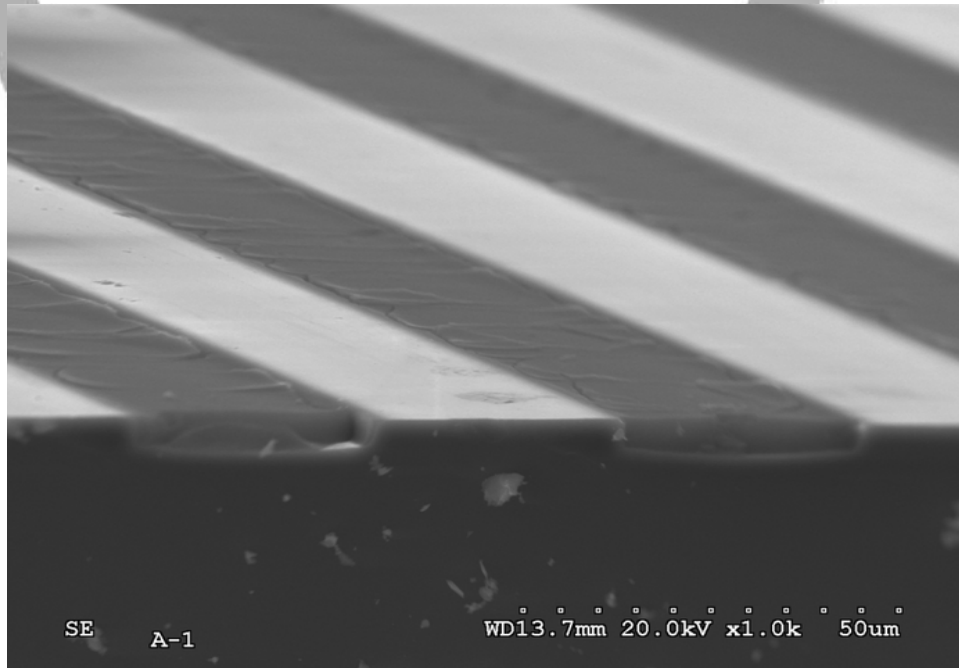
# Fabrication



- Ohmic Al contact (e-beam evaporation + rapid thermal annealing).
- MeV implantation with Si<sup>+</sup> ions.
- Anodic etching.



# 1D and 2D Si/nanoPS surface micropatterns





# Cell culture on 1D Si/nanoPS micropatterns

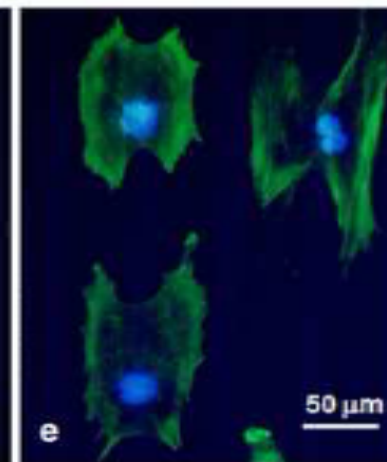
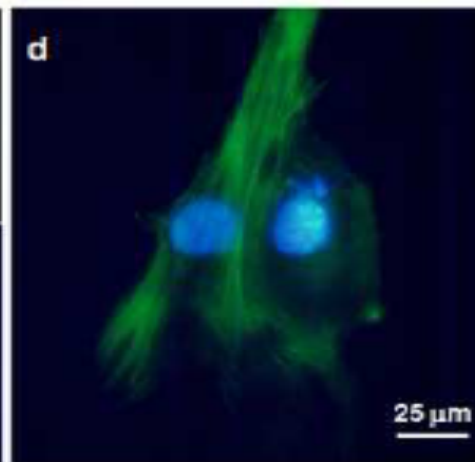
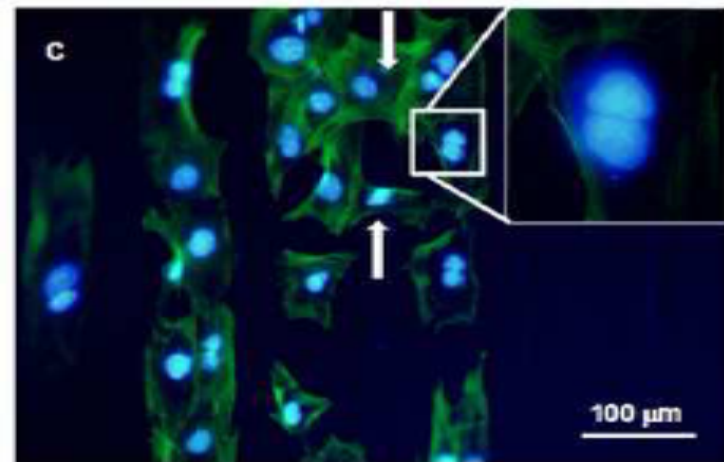
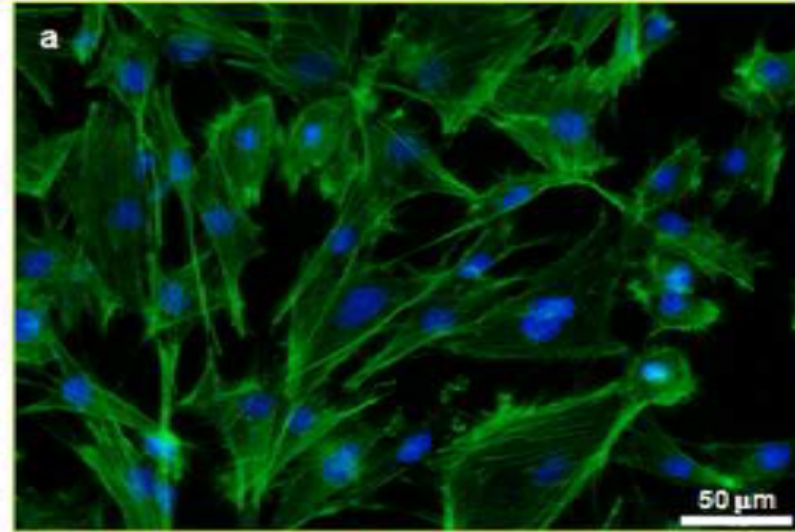
Fluorescence microscopy (actin is stained green, nuclei are stained blue):

(a) Glass control.

(c) 75  $\mu\text{m}$  Si/25  $\mu\text{m}$  nanoSi stripes: Cells preferentially located on Si (Several cells appear in a final stage of cellular division)  $\rightarrow$  Proliferative state

(d) 50  $\mu\text{m}$  Si/25  $\mu\text{m}$  nanoPS stripes: Cells predominantly located in Si areas, occasionally in nanoPS areas

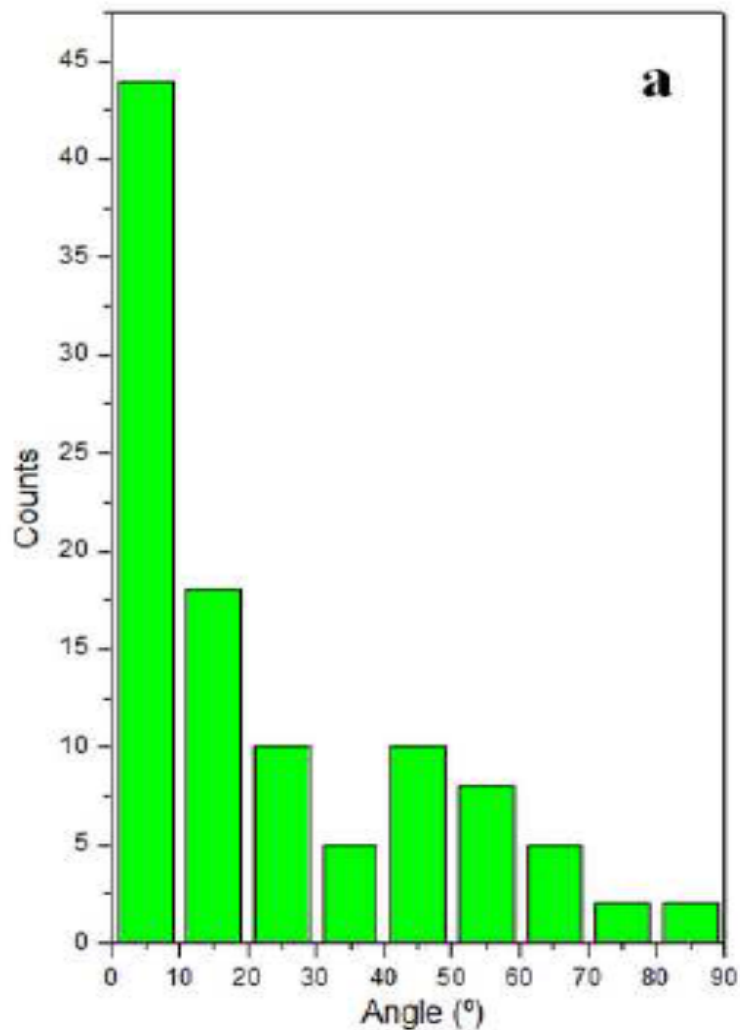
(e) 40  $\mu\text{m}$  Si/20  $\mu\text{m}$  nanoPS stripes: Actin skeleton on Si areas, nuclei on nanoPS areas.



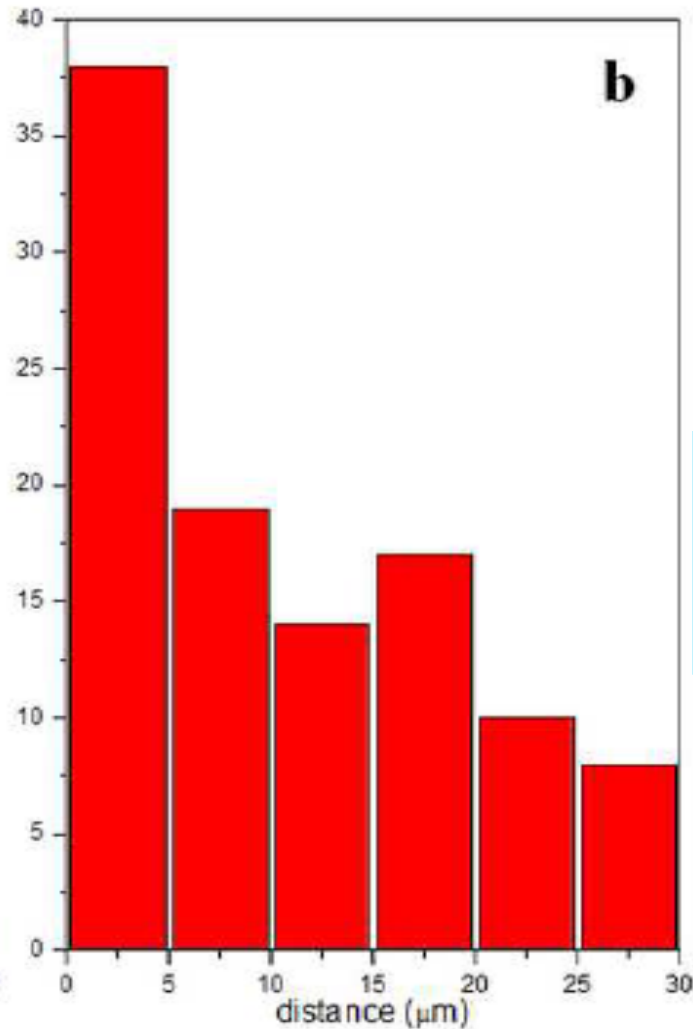
Response of hMSCs depends on the Si/nanoPS ratio

A. Muñoz-Noval *et al.*, Journal of Biomedical Materials Research: Part A 100A(6), 1615 (2012).

# Cell surface distribution



Actin fiber orientation with respect to the stripes (average  $12^{\circ} \pm 5^{\circ}$ )

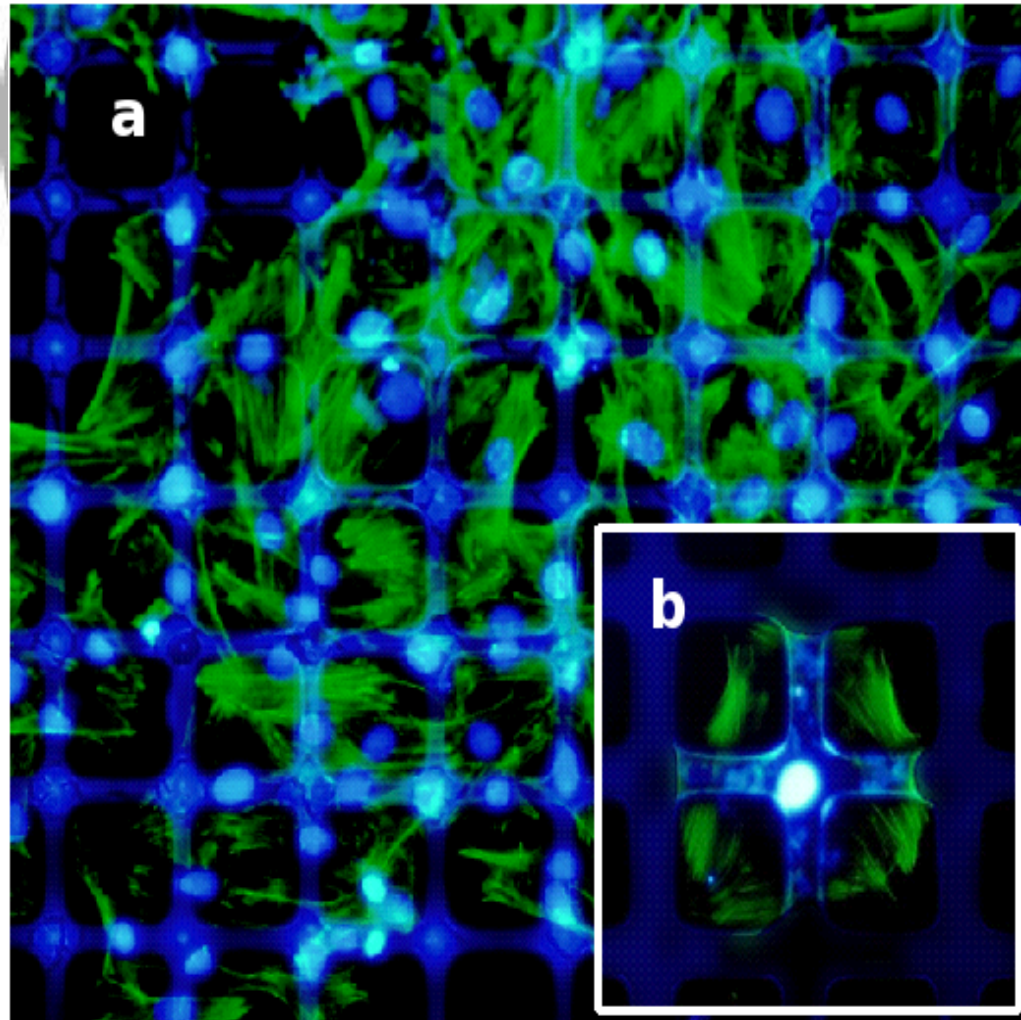


Nucleus distance with respect to the center of the closest nanoPS microstripe center

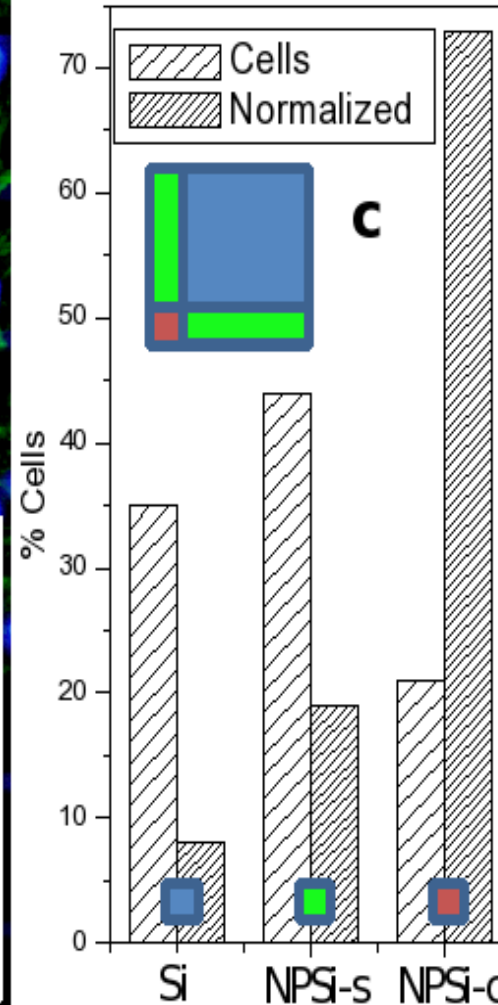
40  $\mu\text{m}$  Si/20  $\mu\text{m}$  nanoPS 1D structures

54% of hMSCs population on the surface of nanoPS (nanoPS represents 33% of the total area!).

# Cell culture on 2D Si/nanoPS micropatterns



Actin is stained green  
Nuclei are stained blue



V. Torres-Costa, *et al.*, International Journal of Nanomedicine 7, 623 (2012).

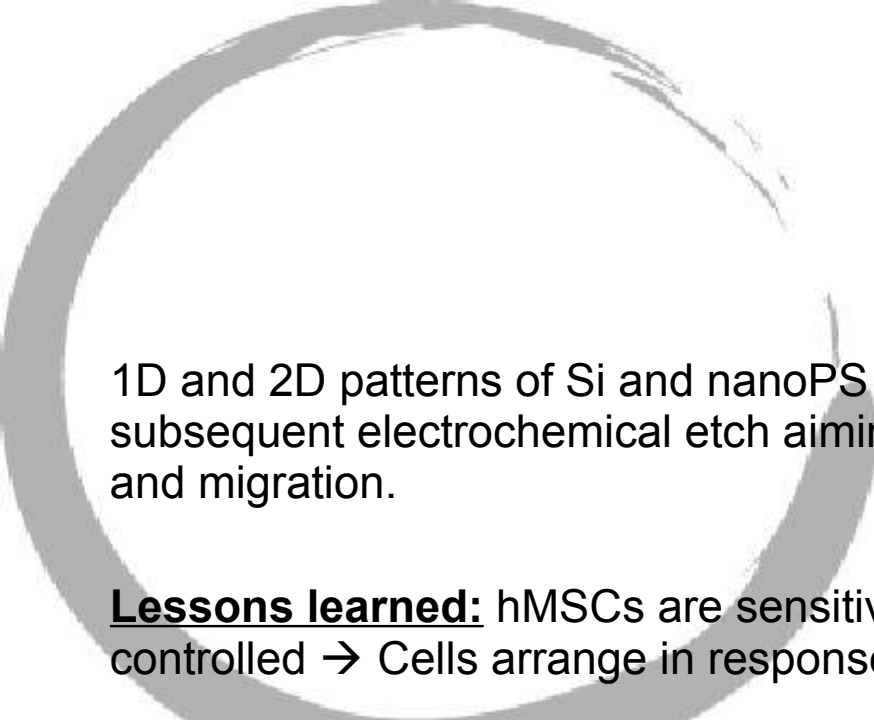
100  $\mu\text{m}$  Si/ 25  $\mu\text{m}$  nanoPS squares:

(a) General view

(b) Detail of an intersection: cells adhere and extend their cytoskeleton quasi-symmetrically

(c) histogram of hMSC population: absolute % and area-normalized

**Potential applications:** Basic studies (cell adhesion and migration), tool in regeneration, healing, or cancer propagation studies.



1D and 2D patterns of Si and nanoPS were engineered by ion-beam irradiation and subsequent electrochemical etch aiming at studying the mechanisms of cell adhesion and migration.

**Lessons learned:** hMSCs are sensitive to surface patterns and migration can be controlled → Cells arrange in response to the particular surface topography.

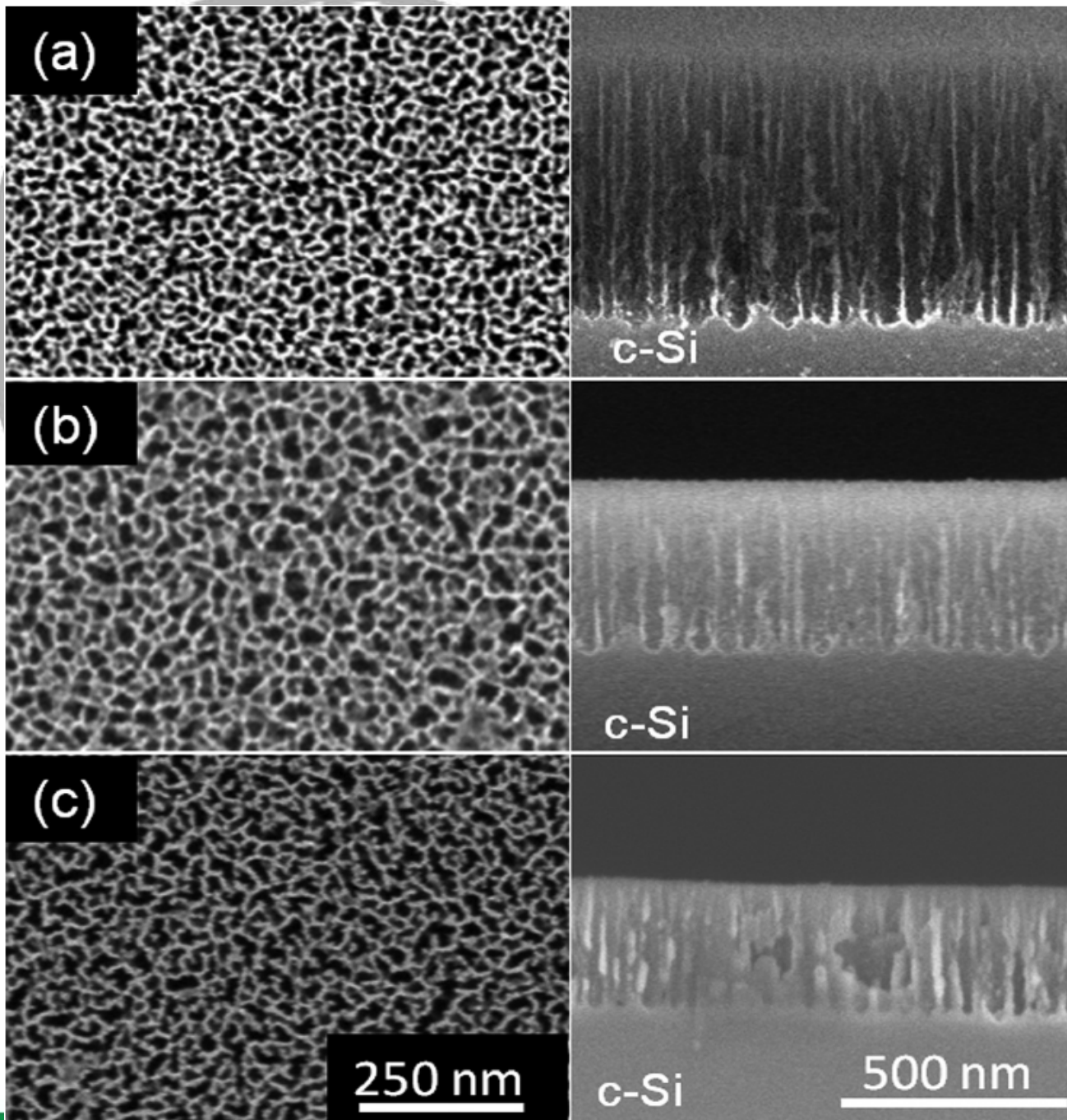
**Drawbacks:** Relatively complex technique for the fabrication of the surface micropatterns textured at the nanoscale.



# Laser fabrication of Si/nanostructured porous silicon surface micropatterns



# NanoPS layers



Thicknesses:

(a) 563 nm

(b) 372 nm

(c) 290 nm

# Patterning method

Interferential process:

Single pulses of an excimer laser ( $\lambda = 193 \text{ nm}$ ,  $\tau = 20 \text{ ns}$ )

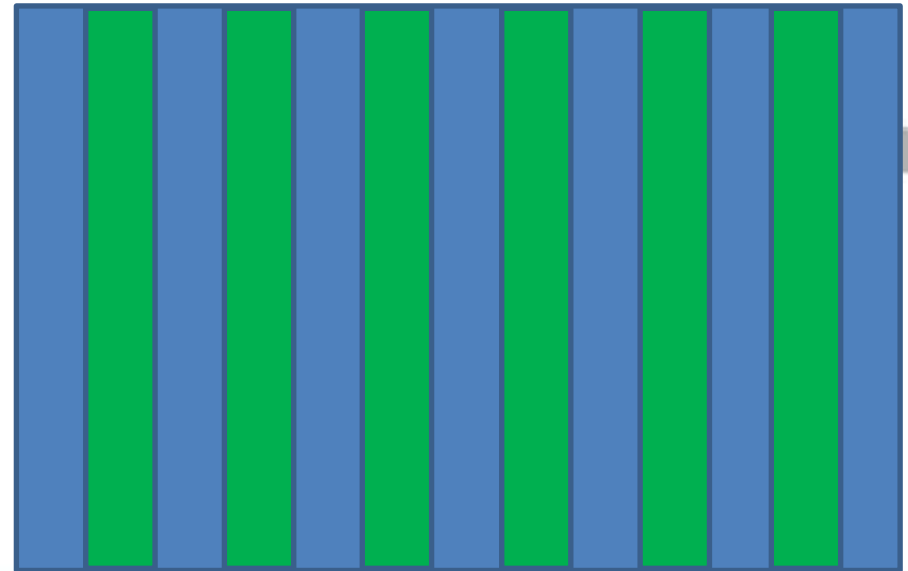
The nanoPS surface thus becomes exposed to a modulated intensity formed by the maxima and minima of interference.

The period of the modulation is modified by using different combinations of projection lenses.

Fluence:

- constant along the  $y$  axis

-  $x$  axis:  $F(x) = F \cdot (1 + \cos(2\pi x/\Delta))$

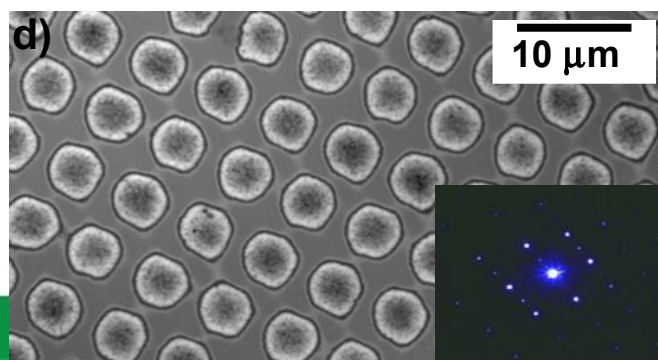
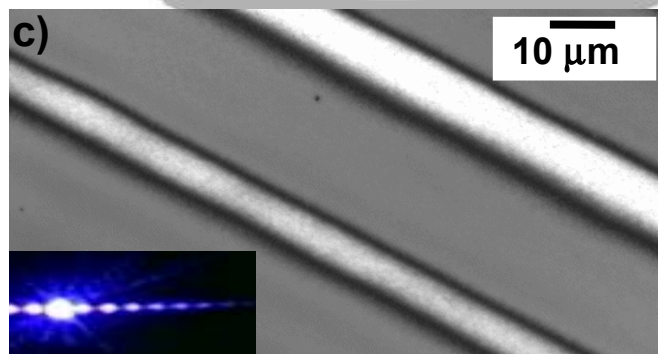
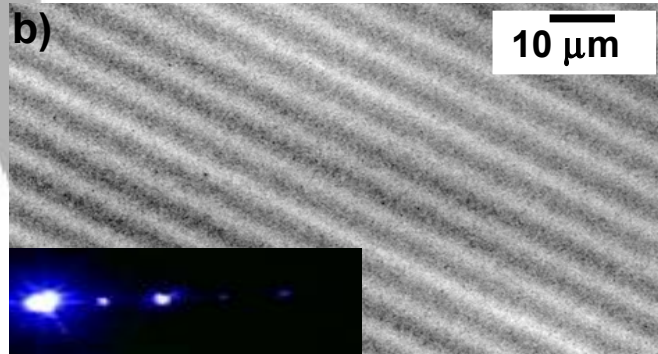
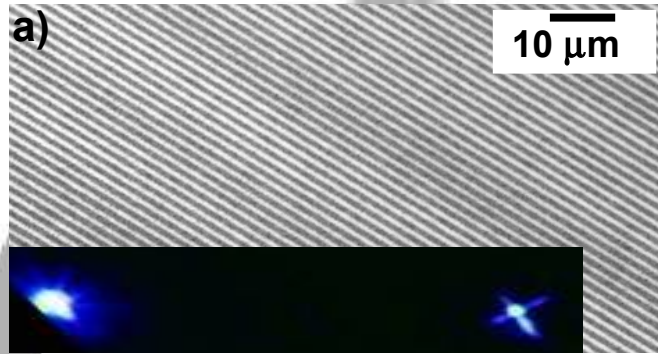


# Structure of the patterns

By using different projection optics the effective laser fluences and periods achieved are different:

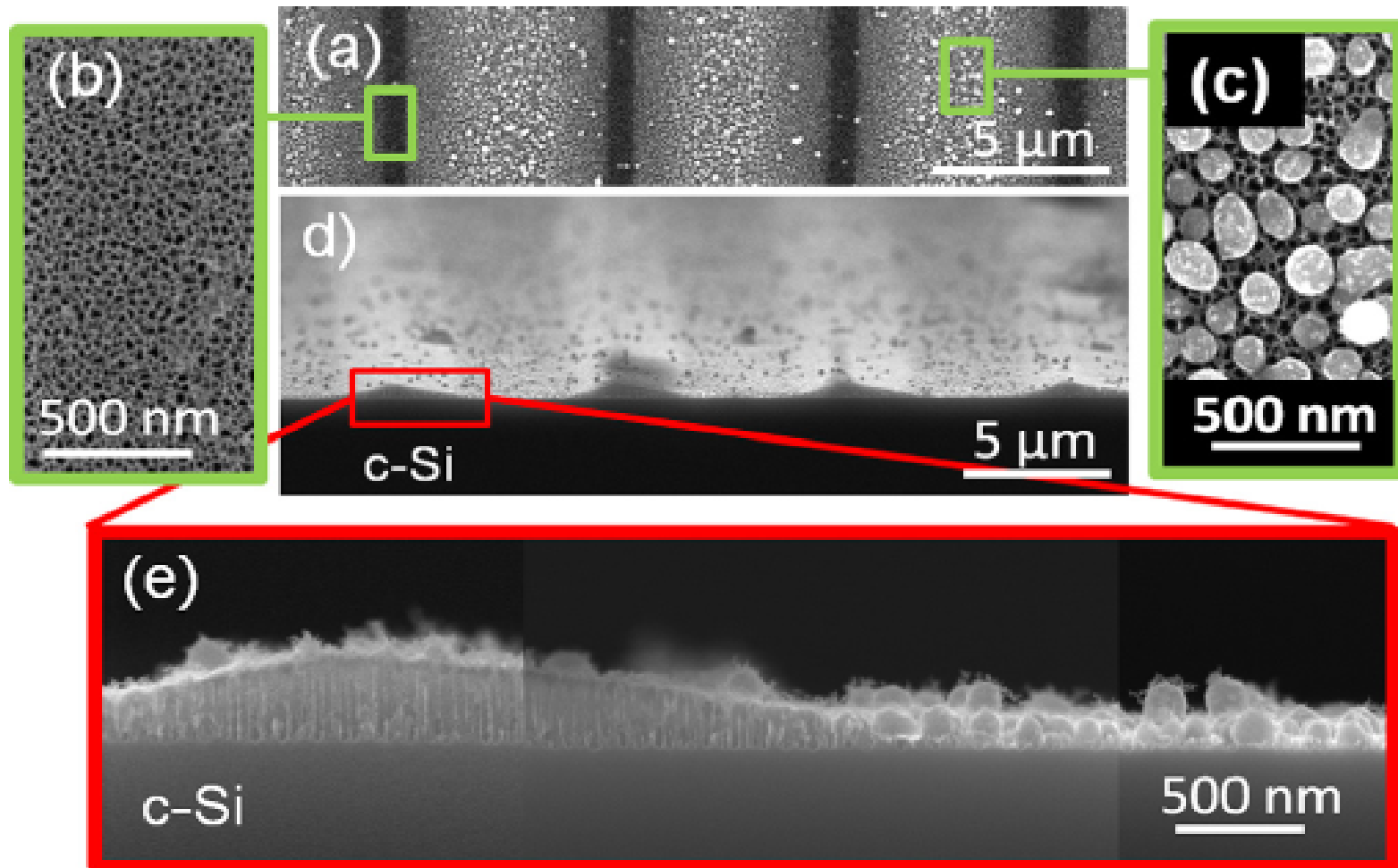
- (a)  $198 \text{ mJ/cm}^2$  and  $1.7 \mu\text{m}$
- (b)  $50 \text{ mJ/cm}^2$  and  $6.3 \mu\text{m}$
- (c)  $11 \text{ mJ/cm}^2$  and  $31 \mu\text{m}$
- (d)  $19 \text{ mJ/cm}^2$  and  $6.3 \mu\text{m}$ .

The insets show the experimental diffraction patterns





# Structure of the patterns (cont' d)



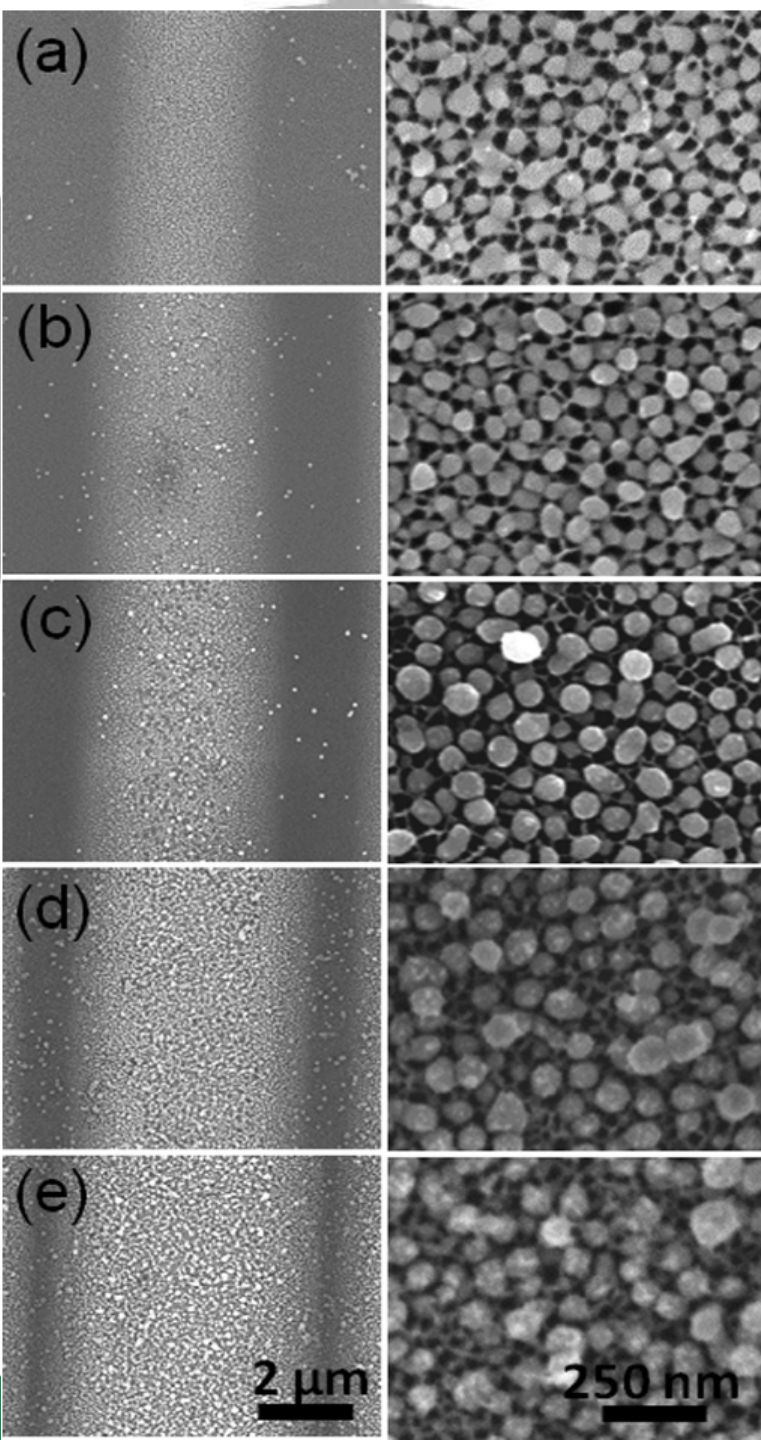
Pattern with a period of 6.3  $\mu\text{m}$  (372 nm-thick nanoPS layer) using 44  $\text{mJ cm}^{-2}$

# Effect of fluence

Patterns with a period of  $6.3 \mu\text{m}$  /  
290 nm-thick nanoPS layer

Fluence:

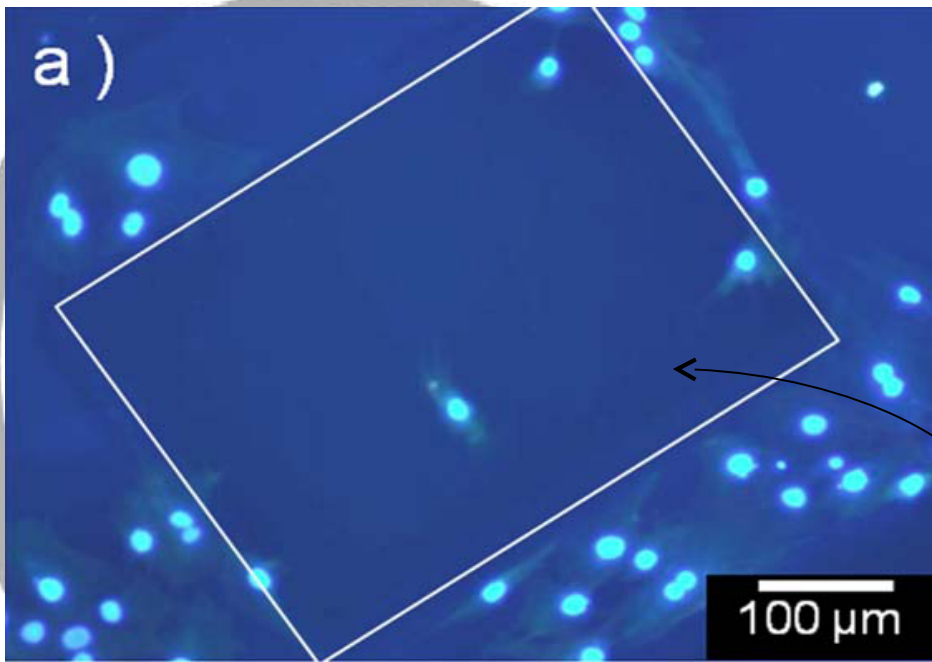
- (a)  $11 \text{ mJ}\cdot\text{cm}^{-2}$
- (b)  $18 \text{ mJ}\cdot\text{cm}^{-2}$
- (c)  $28 \text{ mJ}\cdot\text{cm}^{-2}$
- (d)  $42 \text{ mJ}\cdot\text{cm}^{-2}$
- (e)  $80 \text{ mJ}\cdot\text{cm}^{-2}$



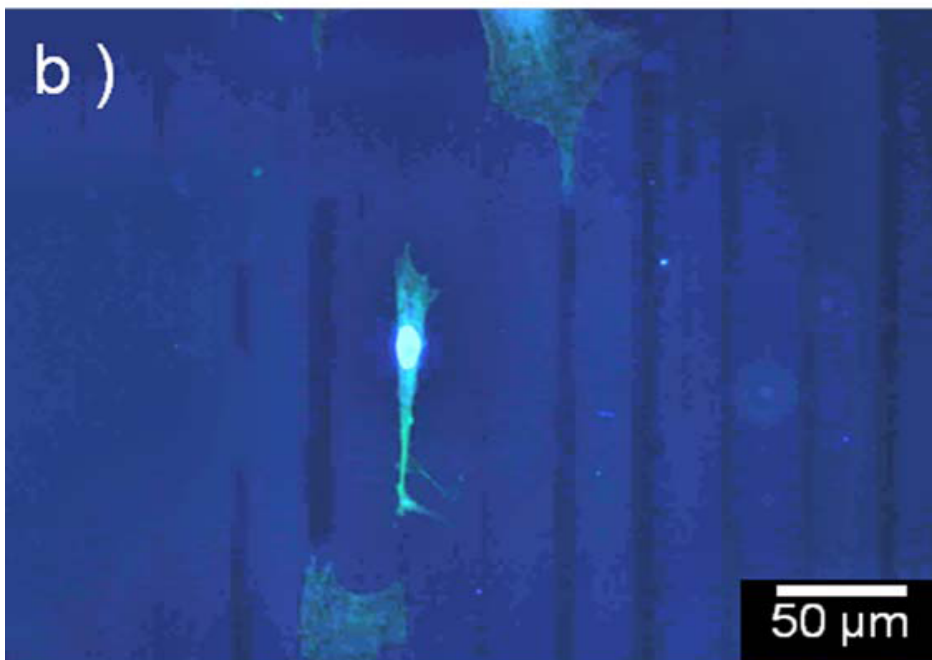
# Cell culture

Blue fluorescence images of hMSCs on two patterns:

- (a)  $1.7 \mu\text{m}$
- (b)  $31 \mu\text{m}$




Patterned region



The hMSCs bind directly and align along the transformed regions of the pattern whenever the width of the trenches on these regions compares with the dimensions of the hMSCs.

Position of the trenches in the pattern



**Lessons learned:** Phase-mask UV laser interference has been proved as a powerful and versatile technique for the fabrication of 1D and 2D patterns on nanoPS in short time (ns) and over relatively large areas (mm<sup>2</sup>).

# Conclusions and outlook

**Porous silicon allows the development of a wide variety of low-cost devices, entirely based on silicon, and fully compatible with nowadays CMOS technology.**

# Acknowledgments



*ciber-66n*



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